

# *X-ray absorption spectroscopy and detectors*

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*EDIT2015 International School  
Excellence in Detectors and Instrumentation Technologies  
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# Outline

- *Light*
- *X-rays and Synchrotron radiation sources*
  - *X-rays and atoms*
  - *X-ray sources*
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  - *Interactions of x-rays with matter*
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  - *Ionization chambers*
- *Solid State Detectors*
  - *Silicon Drift detectors*
  - *Some applications of XRF to Cultural Heritage*
- *Conclusions*

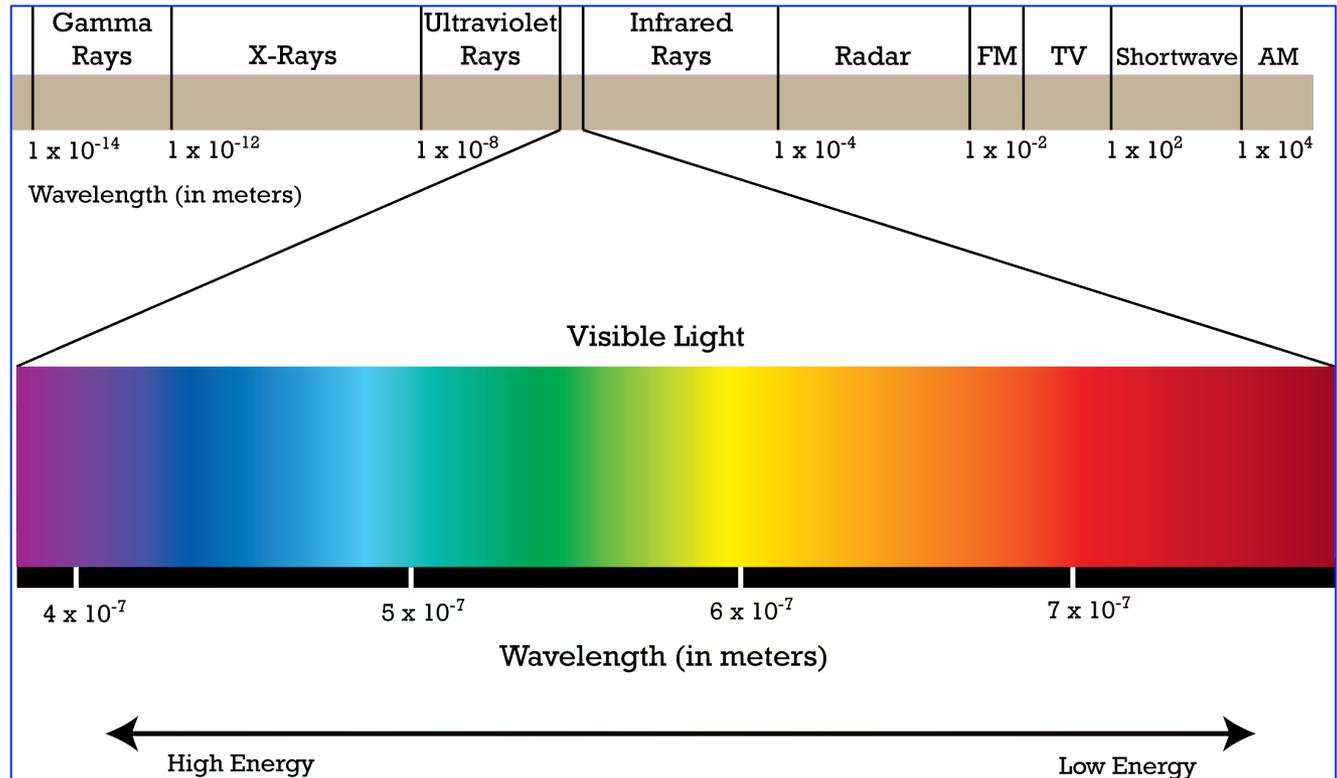


# *Light*

*Progress in science goes in parallel with the technical progress in producing and using light at different wavelengths to explore the physical world.*

# Light

*Visible light* is only a *tiny slice of the electromagnetic spectrum*. The entire electromagnetic spectrum of light is huge, spanning from *gamma rays on one end to radio waves*.



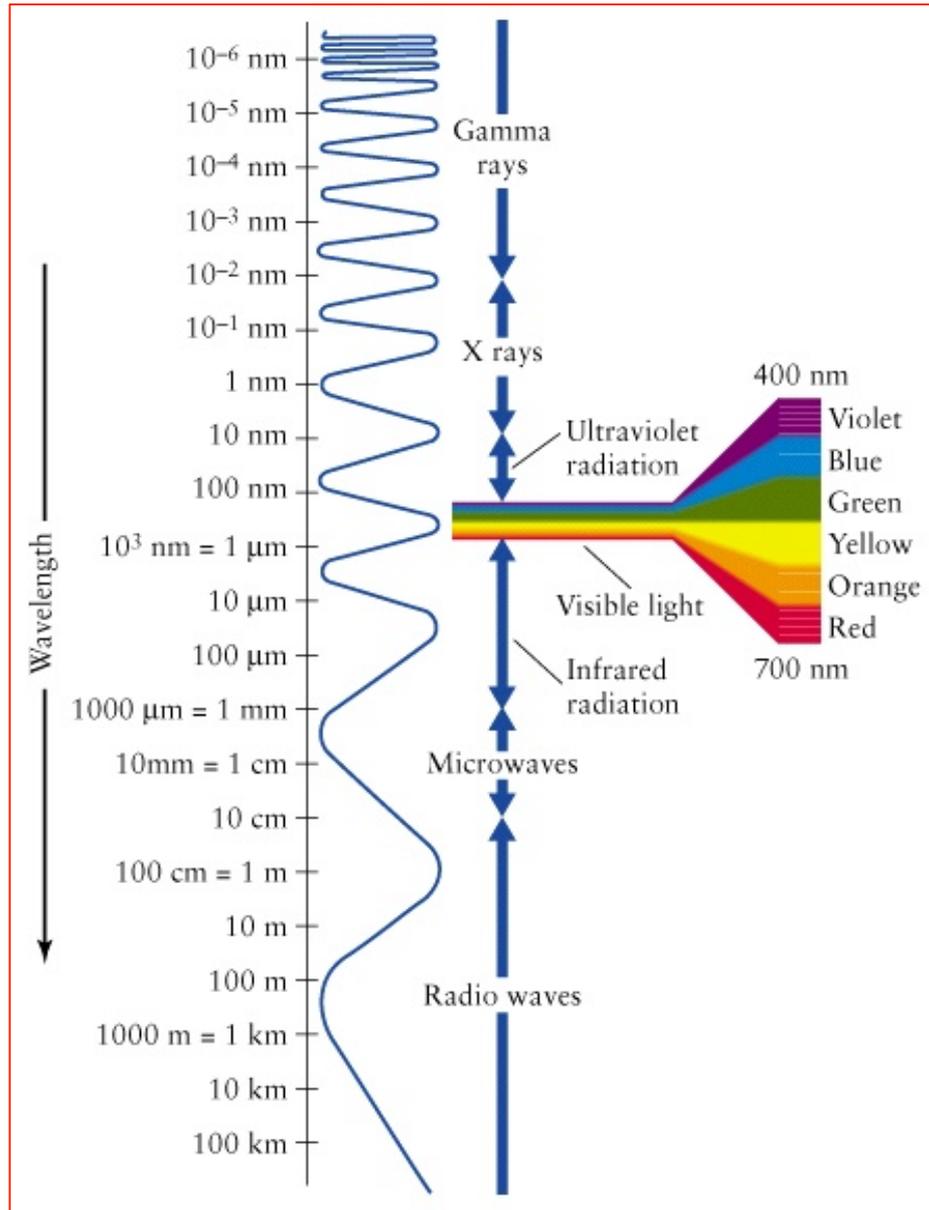
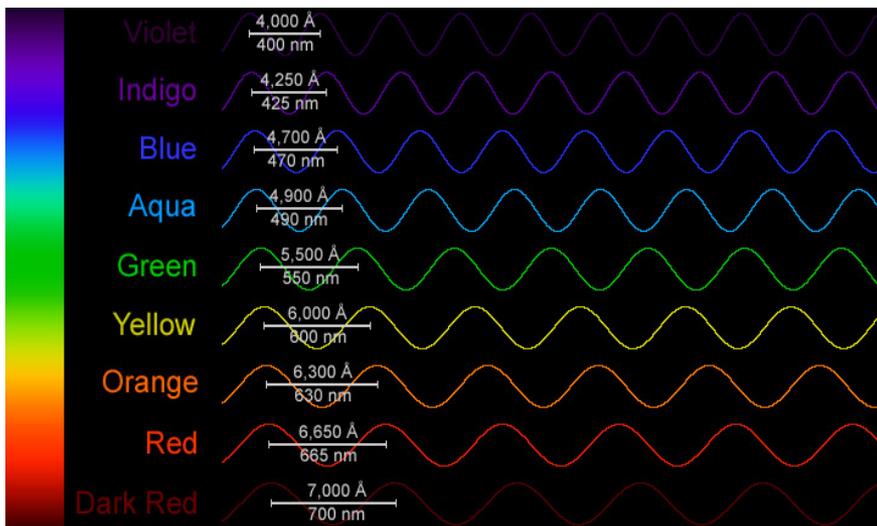
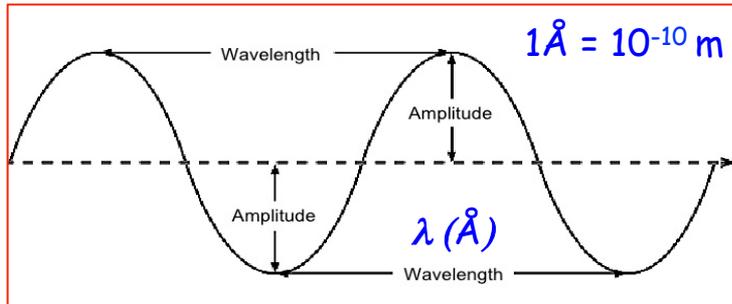
*Visible Light is the light we can see using our eyes.* This tiny human spectrum encompasses a very specific range of wavelengths from about **380 nm to 780 nm**.

*Physiologically we see these frequencies because the photoreceptors in our retinas are sensitive to them.* When photons of light hit the photoreceptors this creates an electrochemical signal which is the first step in a fascinating process which ultimately results in us seeing colors.

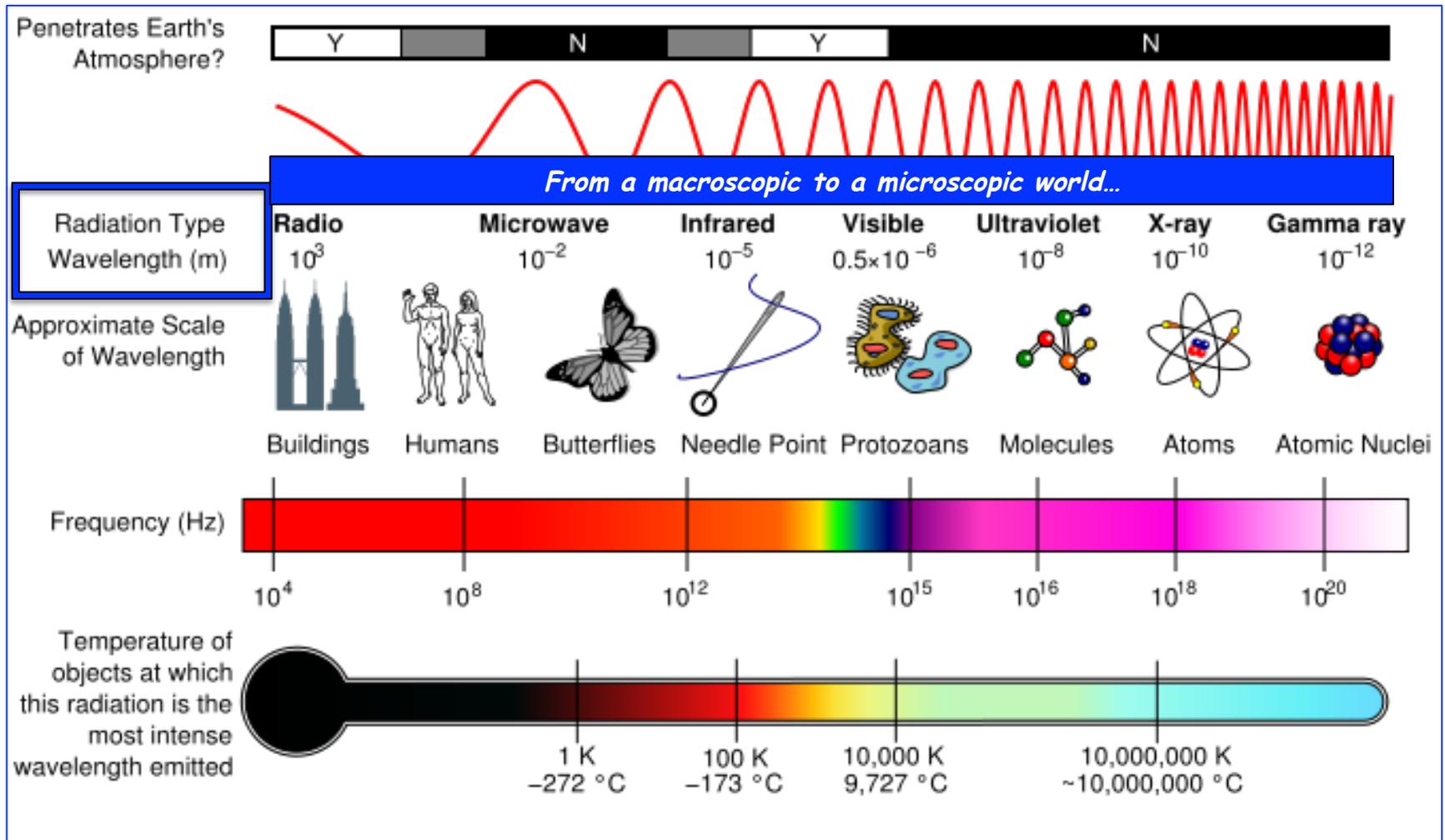
# Light and waves

Light travels as waves of energy.

Waves of light have different **wavelengths** (the distance between the top of one wave and the top of the next). **Different colors of visible light have different wavelengths.**



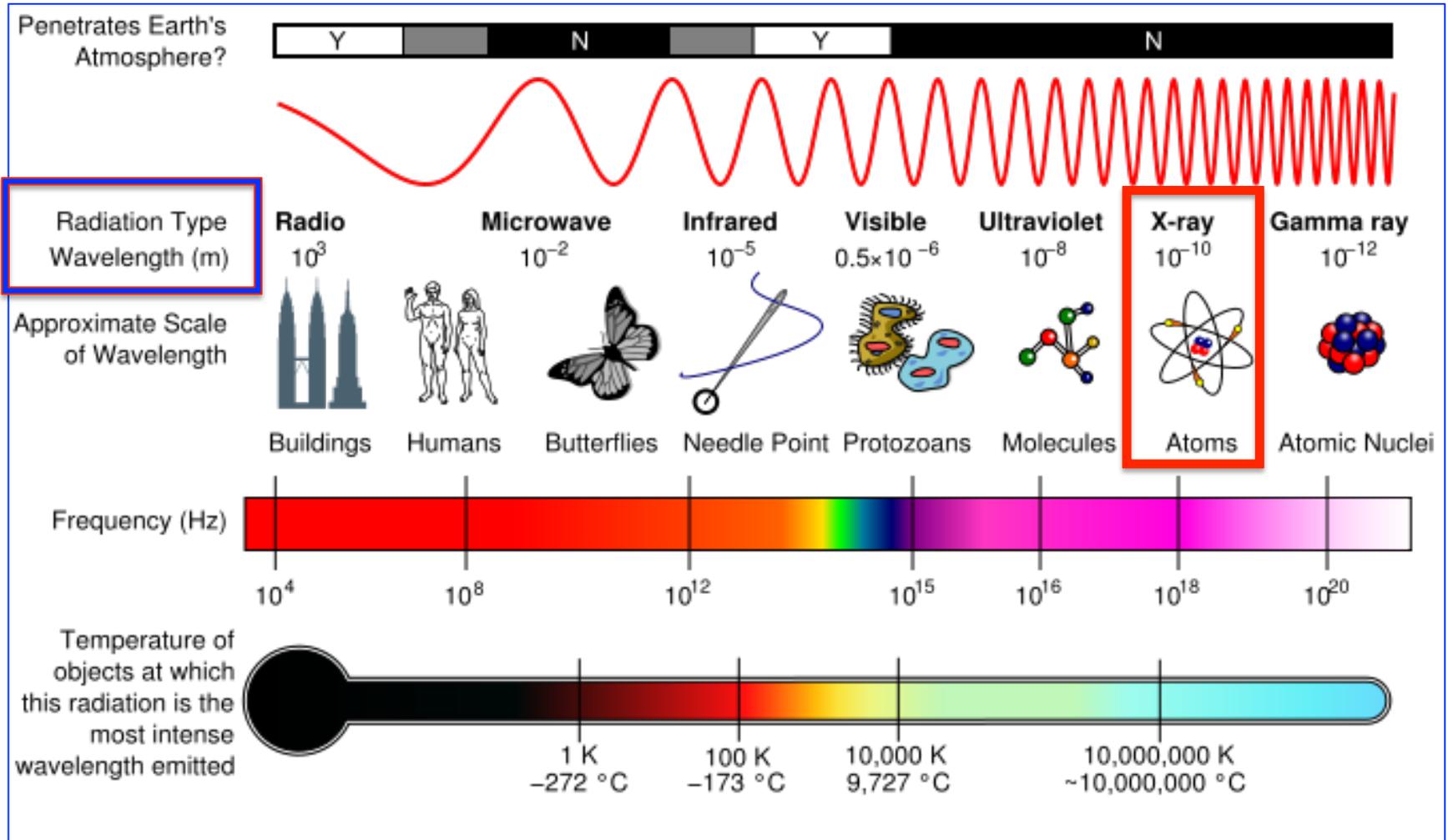
# Electromagnetic Spectrum



The **wavelength** ( $\lambda$ ) and **frequency** ( $\nu$ ) of light are strictly related: the higher the frequency the shorter the wavelength! This is because **all light waves move through vacuum at the same speed** ( $c$  = speed of light) and the equation that relates wavelength and frequency for electromagnetic waves is:  $\lambda \nu = c$

*X-rays*

# Electromagnetic Spectrum and X-rays



# X-rays discovery

## EINE NEUE ART VON STRAHLEN.

VON  
DR. W. RÖNTGEN,  
O. O. PROFESSOR AN DER K. UNIVERSITÄT WÜRZBURG.

WÜRZBURG.  
VERLAG UND DRUCK DER STAHEL'SCHEN K. HOCH- UND UNIVERSITÄTS-  
BUCH- UND KUNSTHANDLUNG.  
Kade 1895.

60 S.

*On a New Kind of Rays*

While **Wilhelm Roentgen** was working on the effects of **cathode rays** during **1895**, he discovered X-rays. His experiments involved the passing of electric current through gases at extremely low pressure. On **November 8, 1895** he observed that certain rays were emitted during the passing of the current through discharge tube. His experiment that involved working in a totally dark room with a well covered discharge tube resulted in the **emission of rays which illuminated a barium platinocyanide screen. The screen became fluorescent even though it was placed two meters away from discharge tube.**

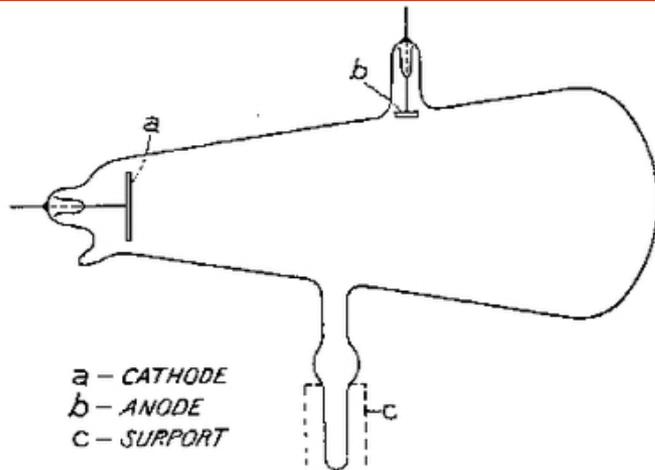


Fig. 1. Earliest type of roentgen tube.

**Gas tube:** electrons are freed from a cold cathode by positive ion bombardment, thus necessitating a certain gas pressure.

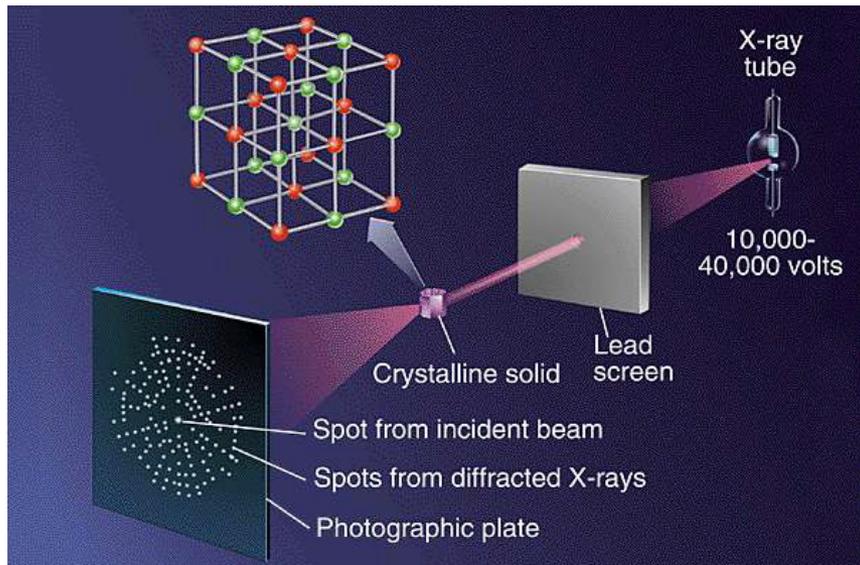
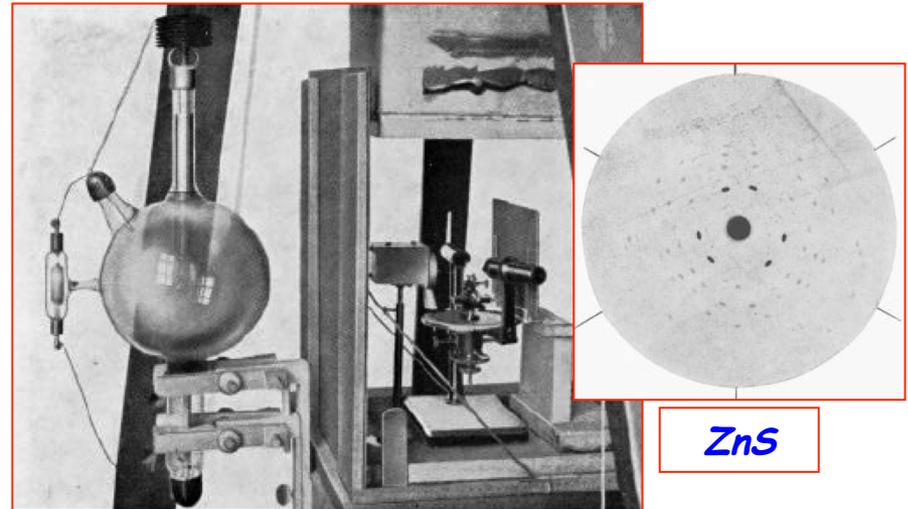
He continued his experiments using **photographic plates** and generated the very **first "roentgenogram"** by developing the image of **his wife's hand** and analyzed the variable transparency as showed by her bones, flesh and her wedding ring.



# Contribution of Physics : X-ray diffraction



*Max von Laue theorized and proved in 1912 that x-rays could be diffracted by crystalline materials.*



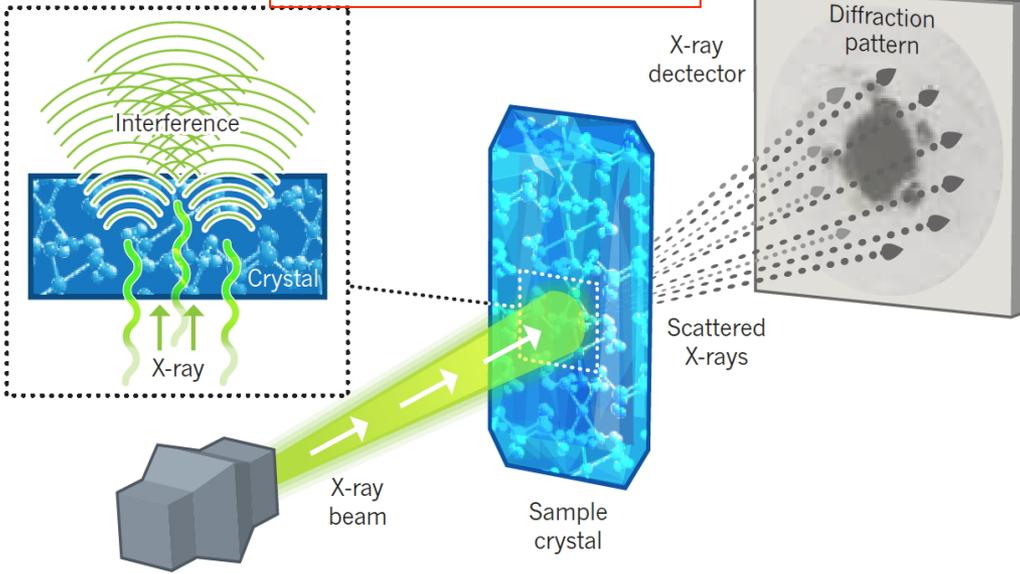
This discovery was extended by **William Lawrence Bragg** and his father **William Henry Bragg**: they showed that *diffraction could be treated as reflection from evenly spaced planes if monochromatic x-radiation was used.*

$$\text{Bragg's Law: } n\lambda = 2d \sin\theta$$

$\lambda$  is the *wavelength* of the X-radiation  
 $d$  is the *inter-planar spacing* in the crystalline material and  $\theta$  is the *diffraction angle*.

# X-rays and atoms

*N. Jones, Nature 505, 602 (2014)*



*With X-rays we can study atoms because wavelengths are of the order of  $10^{-10}$  m or 0.1 nm or  $1\text{\AA}$*

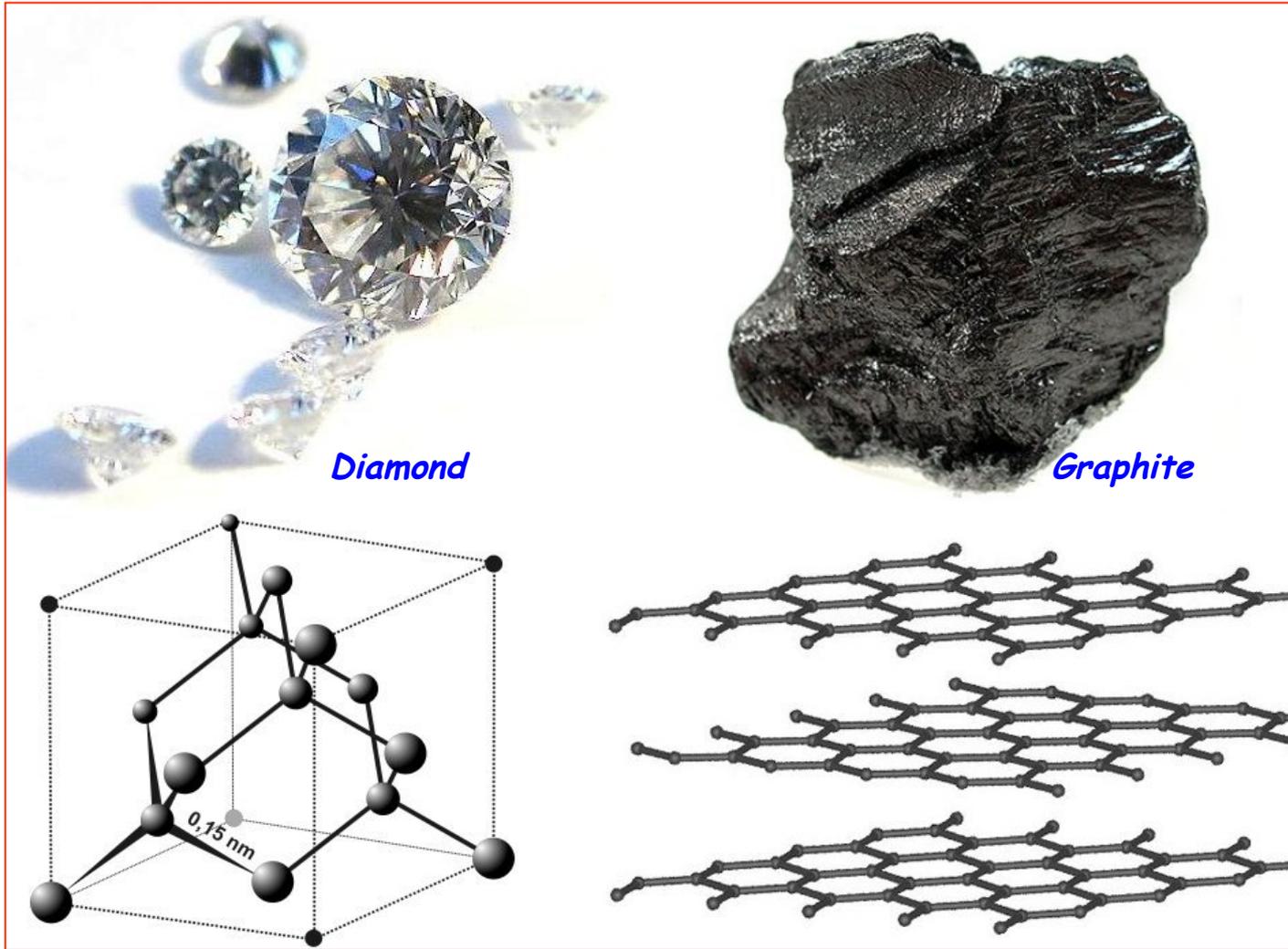
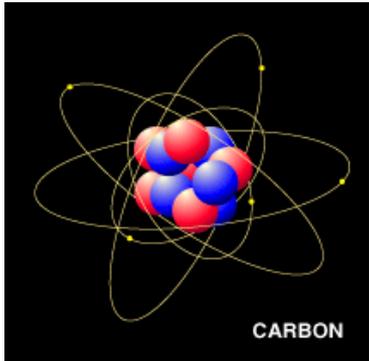
*Matter is composed of atoms!*

*Using X-rays we can study the atomic structure of materials! The atomic structure primarily affects the chemical, physical, thermal, electrical, magnetic, and optical properties.*



*Why is this important?*

# X-rays and Atoms



*Diamond*

*Graphite*

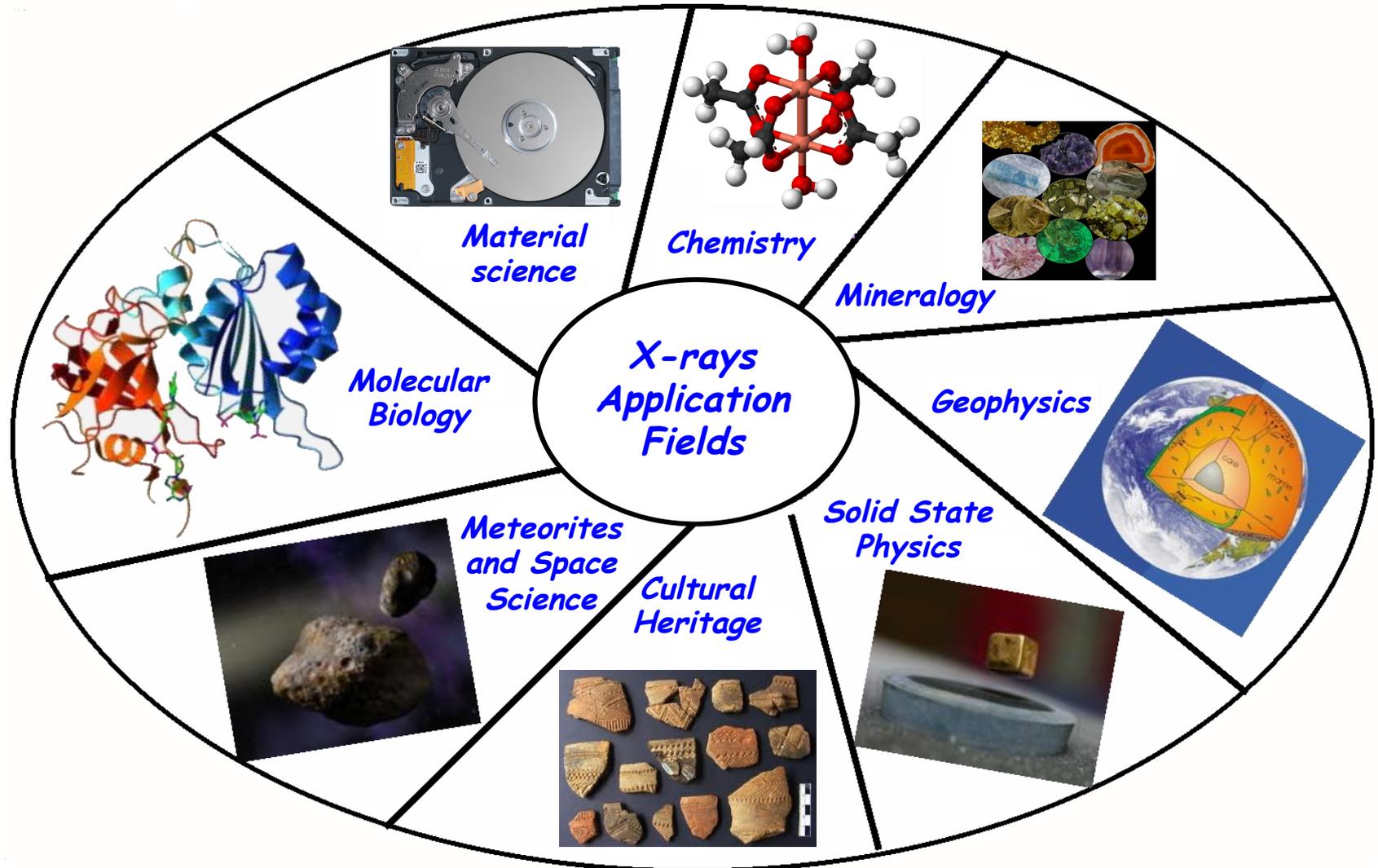
*Both diamond and graphite are made entirely out of carbon!*

*Using x-rays to reveal the atomic structure of materials*

*Graphite is opaque and metallic- to earthy-looking, while diamonds are transparent and brilliant.*

*The different properties of graphite and diamond arise from their distinct crystal structures.*

# *X-rays application fields*



# *X-ray sources*

*X-ray conventional sources  
and synchrotron radiation*

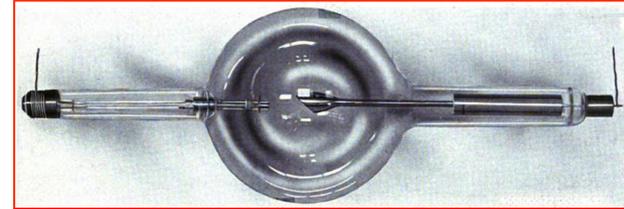
*X-ray conventional sources*

# X-rays: conventional sources

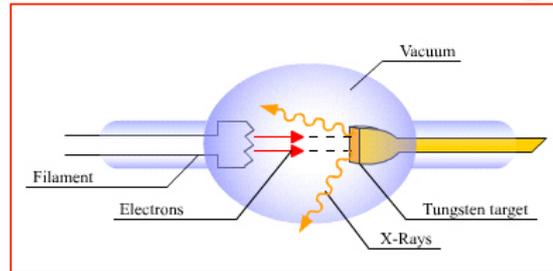
From gas tubes (cold cathode) to high vacuum tubes (hot cathode)



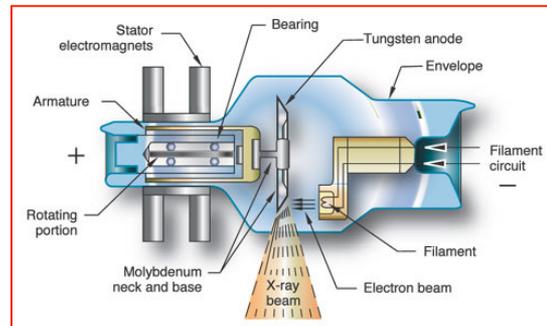
*Crookes tube*



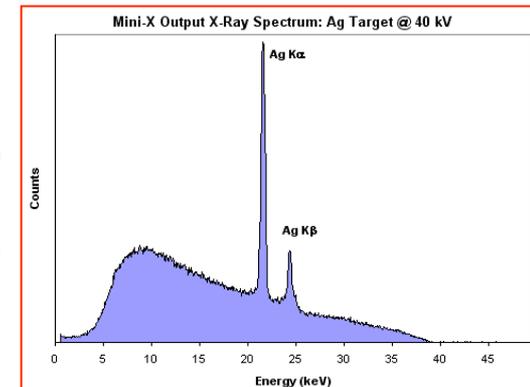
*Coolidge tube*



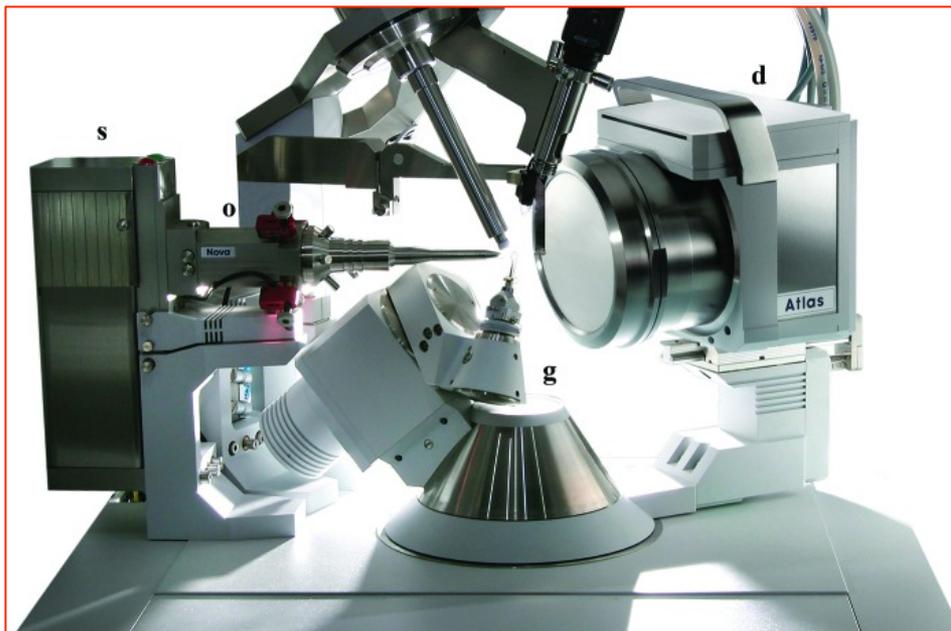
The *Coolidge tube (1913)*, also called *hot cathode tube*, is the most widely used. Electrons are produced by thermionic effect from a tungsten filament heated by an electric current. The filament is the cathode of the tube. The high voltage potential is between the cathode and the anode, the electrons are accelerated, and hit the anode.



The *rotating anode tube* is an improvement of the *Coolidge tube* anode surface (water cooled) is always moving, so heat is spread over a much larger surface area giving a 10-fold increase in the operating power.



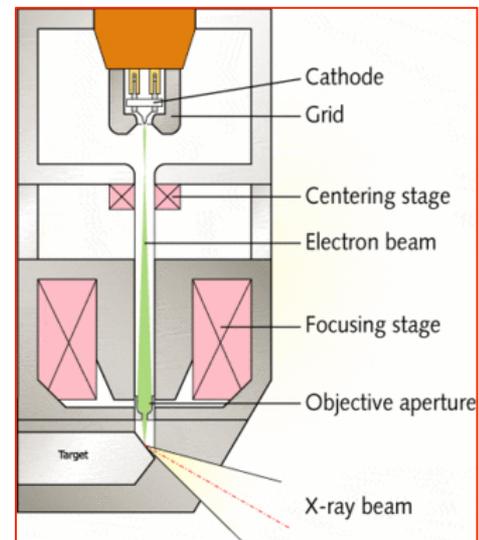
# X-rays: conventional sources



## EVOLUTION

A compact X-ray in-house laboratory system consisting of a *microfocus sealed-tube source* (s), focusing multi-layer optics (o), a four-circle goniometer (g) and a CCD detector (d).

Pictures of *Agilent Technologies*.



Approximate X-ray beam brilliance for the main types of in-house sources with optics

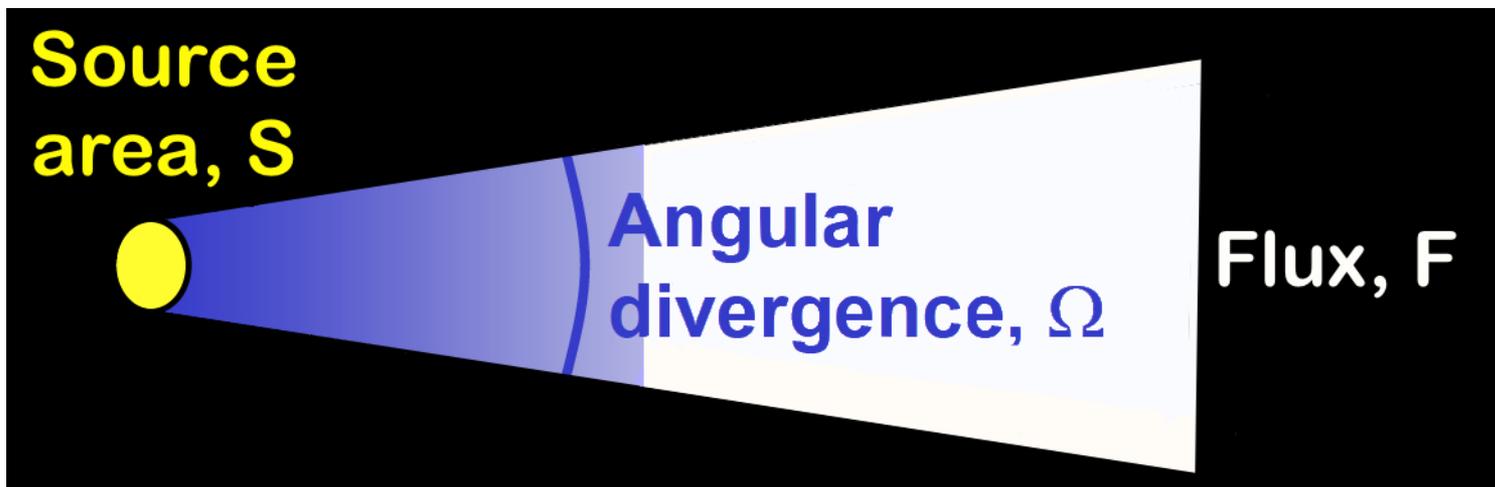
System	Power (W)	Actual spot on anode ( $\mu\text{m}$ )	Apparent spot on anode ( $\mu\text{m}$ )	Brilliance ( $\text{photons s}^{-1} \text{mm}^{-2} \text{mrad}^{-1}$ )
Standard sealed tube	2000	$10000 \times 1000$	$1000 \times 1000$	$0.1 \times 10^9$
Standard rotating-anode generator	3000	$3000 \times 300$	$300 \times 300$	$0.6 \times 10^9$
Microfocus sealed tube	50	$150 \times 30$	$30 \times 30$	$2.0 \times 10^9$
Microfocus rotating-anode generator	1200	$700 \times 70$	$70 \times 70$	$6.0 \times 10^9$
State-of-the-art microfocus rotating-anode generator	2500	$800 \times 80$	$80 \times 80$	$12 \times 10^9$
Excillum JXS-D1-200	200	$20 \times 20$	$20 \times 20$	$26 \times 10^9$

# *Synchrotron radiation sources*

# Light sources and brightness

When interested in nm scale details: brightness becomes fundamental.

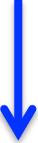
A *bright source* is the one *very effective in illuminating a specific target*.  
If the specific target is small a *bright source* is a *small size source with emission concentrated within a narrow angular spread*.



$$\text{Brightness} = \text{constant} \frac{F}{S \times \Omega}$$

# *Bright light sources?*

*HE particle accelerators*

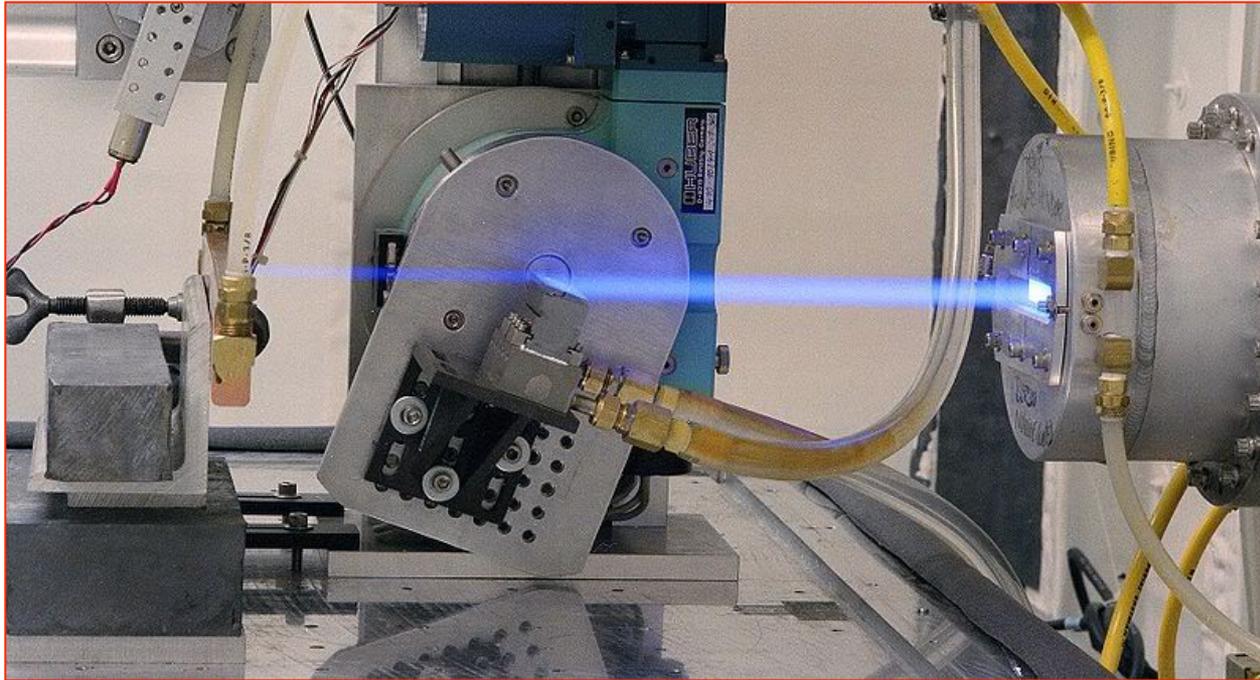
A blue arrow pointing downwards from the first box to the second box.

*Relativistic effects*

A blue arrow pointing downwards from the second box to the third box.

*Synchrotron light*

# *Synchrotron radiation and light sources*



*Synchrotron radiation opened a new era of accelerator-based light sources that have evolved rapidly over four generations:*

- the first three-generations based on storage rings*
- the forth and fifth generation light sources based on FELs.*

*A dramatic improvement of brightness and coherence over about 70 years.*

# Synchrotron light is present in nature!

*Synchrotron radiation is a very important emission process in astrophysics!*

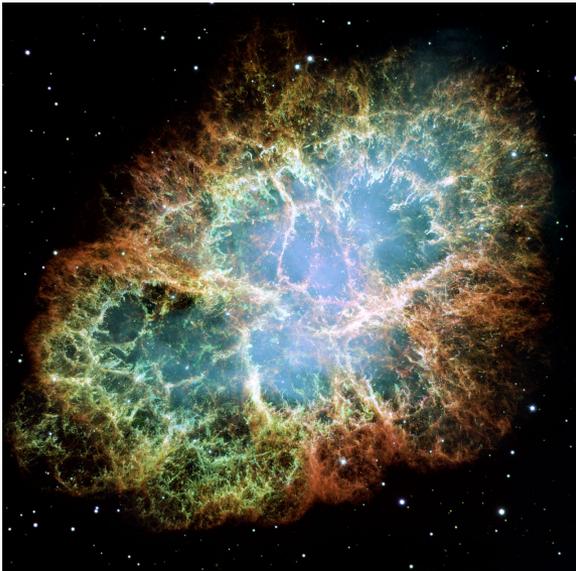
*Crab Nebula: remnant of a supernova explosion seen on earth by Chinese astronomers in 1054, at about 6500 light years from Earth in the constellation Taurus !*

*SR emission is produced by high energy electrons whirling around the magnetic fields lines originating from a Pulsar*

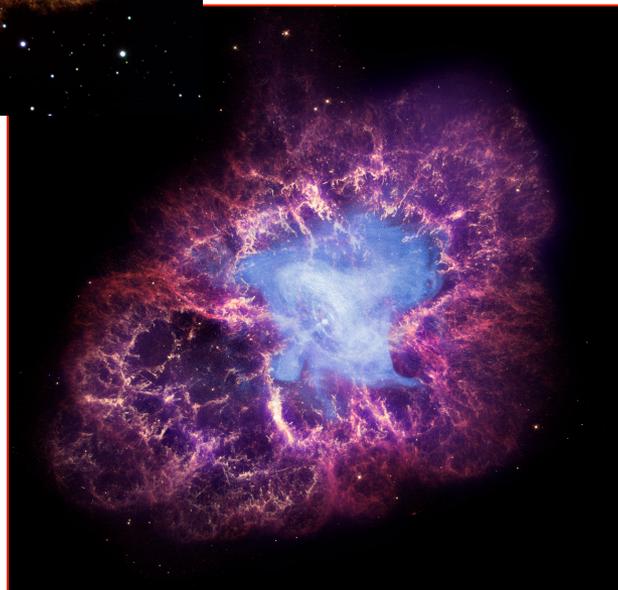
*The heart of the nebula is a rapidly-spinning neutron star, a pulsar, that powers the strongly polarised bluish 'synchrotron' nebula.*

*The Crab pulsar is slowing at the rate of about  $10^{-8}$  sec per day, and the corresponding energy loss agrees well with the energy needed to keep the nebula luminous. Some of this luminosity takes the form of synchrotron radiation, requiring a source of energy for accelerating charged particles.*

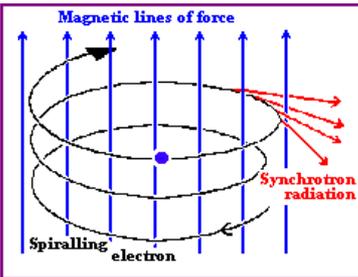
*Composite image data from three of NASA's Great Observatories. The Chandra X-ray Observatory image is shown in blue, the Hubble Space Telescope optical image is in red and yellow, and the Spitzer Space Telescope's infrared image is in purple. The X-ray image is smaller than the others because extremely energetic electrons emitting X-rays radiate away their energy more quickly than the lower-energy electrons emitting optical and infrared light. The Crab Nebula is one of the most studied objects in the sky, truly making it a cosmic icon.*



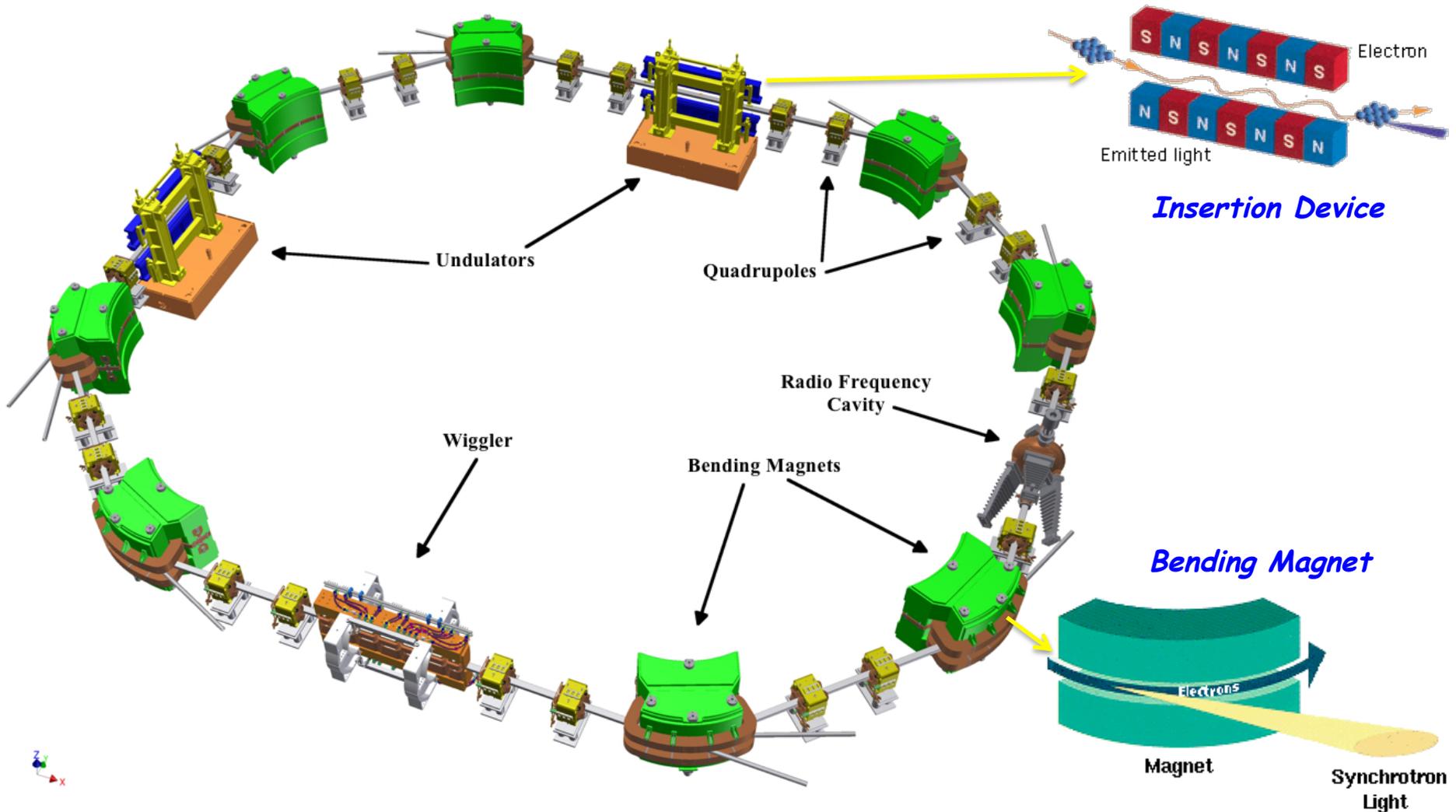
*NASA Hubble Space Telescope image of the Crab Nebula (NASA, ESA and Allison Loll/Jeff Hester (Arizona State University)).*



*NASA's Great Observatories' View of the Crab Nebula X-Ray-blue: NASA/CXC/J.Hester (ASU); Optical-red and yellow: NASA/ESA/J.Hester & A.Loll (ASU); Infrared-purple: NASA/JPL-Caltech/R.Gehrz (Univ. Minn.)*

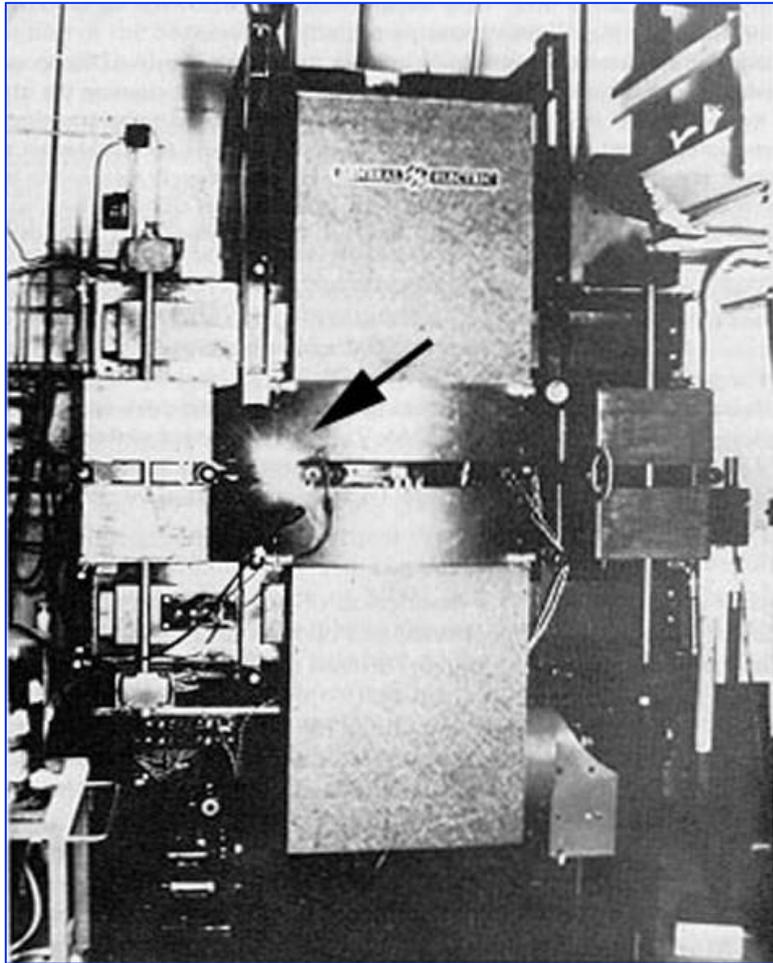


# *Synchrotron light is artificially produced by relativistic particles accelerated in circular orbits.*



*... and synchrotron radiation is also the coherent radiation emitted by the undulators of Free Electron Lasers.*

# Synchrotron radiation: history



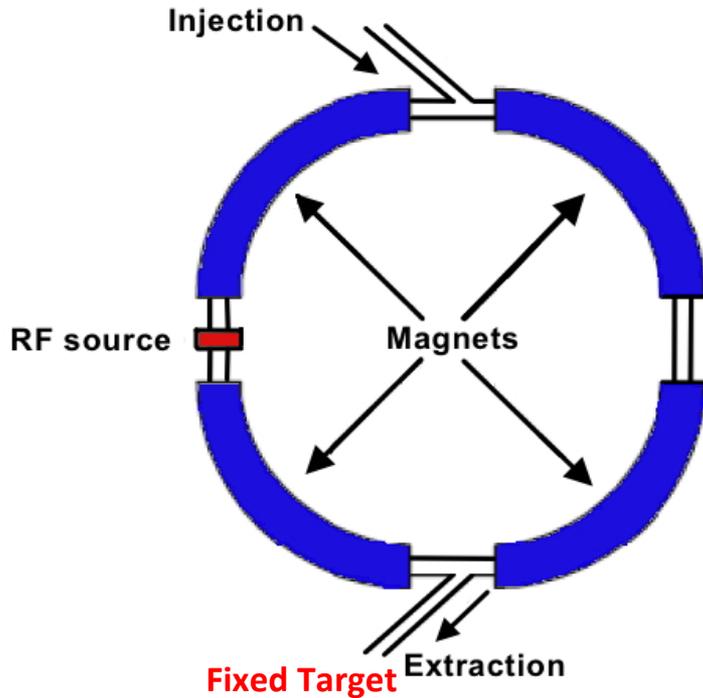
*Starting point: Proof of concepts, tests of theories!*

- In the 50s and 60s machines built for High Energy Physics: synchrotrons (*1947 First 'visual observation of synchrotron radiation*).
- Synchrotron radiation was considered a *nuisance by particle physicists: unwanted but unavoidable loss of energy!*
- 1961 US National Bureau of Standards (now NIST) modified their electron synchrotron : *access to the synchrotron radiation users*.
- Synchrotron radiation scientists became *parasites* of nuclear physics experiments. (*1961 Frascati - CNEN Electrosynchrotron - ( 0.4-1.1) GeV*)
- 1968 *First storage ring dedicated* to synchrotron radiation research: *Tantalus* (University of Wisconsin) only *bending magnets*.

*1947 General Electric Res. Lab. - 70 MeV Electron Synchrotron - N.Y. USA*

*F.R. Elder, A.M. Gurewitsch, R.V. Langmuir, and H.C. Pollock, Radiation from Electrons in a Synchrotron, Phys. Rev. 71,829 (1947)  
G. C. Baldwin and D.W. Kerst, Origin of Synchrotron Radiation, Physics Today, 28,9 (1975)*

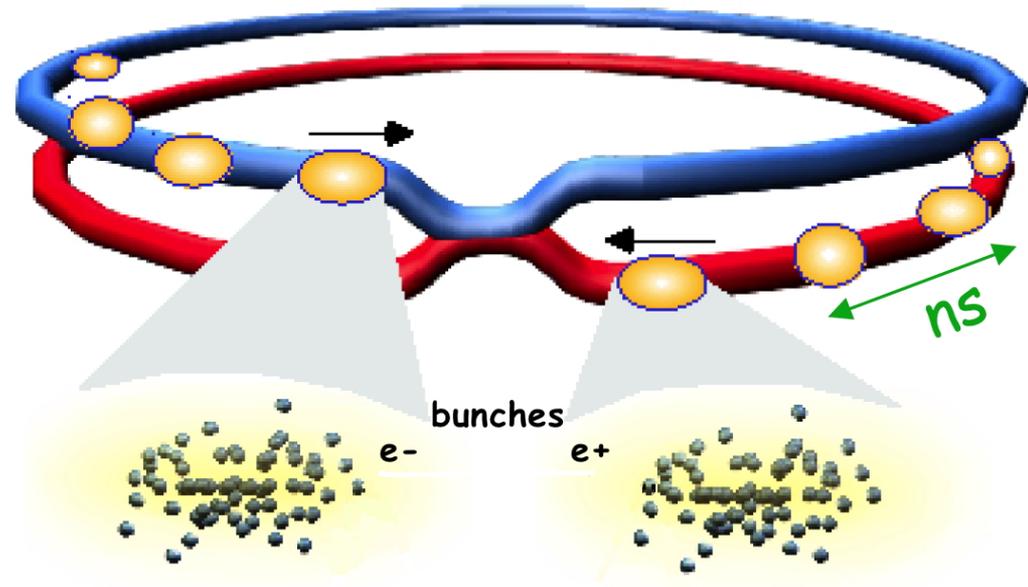
# Synchrotrons and Storage Rings



*Synchrotron*

Particle beam on fixed target

$$E_{CM} = (mE)^{1/2}$$



*Storage rings*

Colliding particle beams

$$E_{CM} = 2E$$

*Colliding beams more efficient*

$E = \text{particle energy} \gg m_0c^2$       $E_{CM} = \text{center-of-mass energy}$

# Comparing synchrotrons and storage rings

## Synchrotrons

- **Cyclic** - the guiding magnetic field used to bend the particles into a closed path, is time-dependent, being *synchronized* to a particle beam of increasing kinetic energy.
- **Emitted photon spectrum varies** as  $e^-$  energy changes during each cycle.
- **Photon intensity varies** as  $e^-$  energy changes during each cycle (also cycle to cycle variations).
- **Source position varies** during the acceleration cycle.
- **High Energy Radiation Background** (Bremsstrahlung +  $e^-$ ): **high**, due to loss of all particles on each cycle.

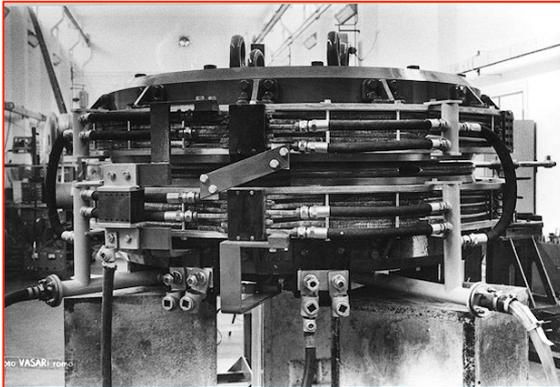
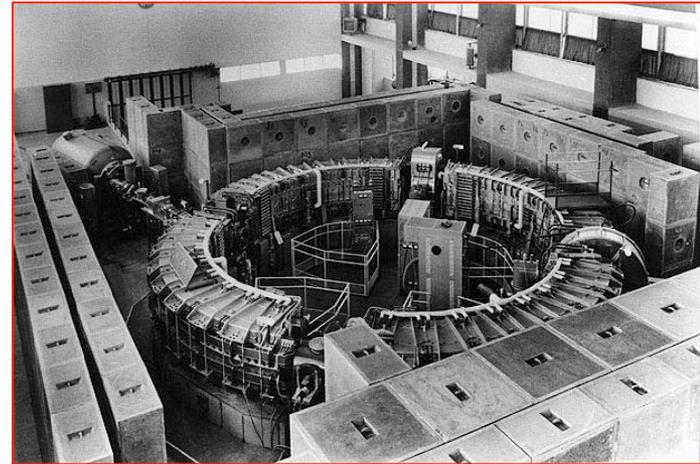
## Storage rings

- **Constant**: as special type of synchrotron in which the kinetic energy of the particles is kept constant.
- **Emitted photon spectrum constant**.
- **Photon intensity decays slowly** over many hours.
- **Source position constant**- submicron source stability.
- **High Energy Radiation Background: low** because same particles are stored for many hours.

# Synchrotron radiation: in the early history

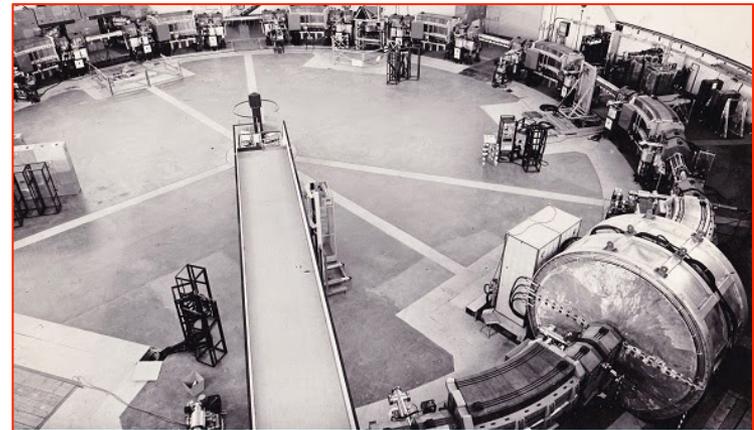
## Frascati: ElettroSynchrotron, ADA and ADONE

Frascati - CNEN (Comitato Nazionale Energia Nucleare)  
Laboratory **ElettroSincrotrone** - (0.4-1.1) GeV,  $C= 28$  m  
(1959-1975)



LNF **ADA** (Anello Di Accumulazione) - first electron-positron  
storage ring (proposed by B. Touschek) 0.25 GeV,  $C= 5$  m  
(1961-1964)

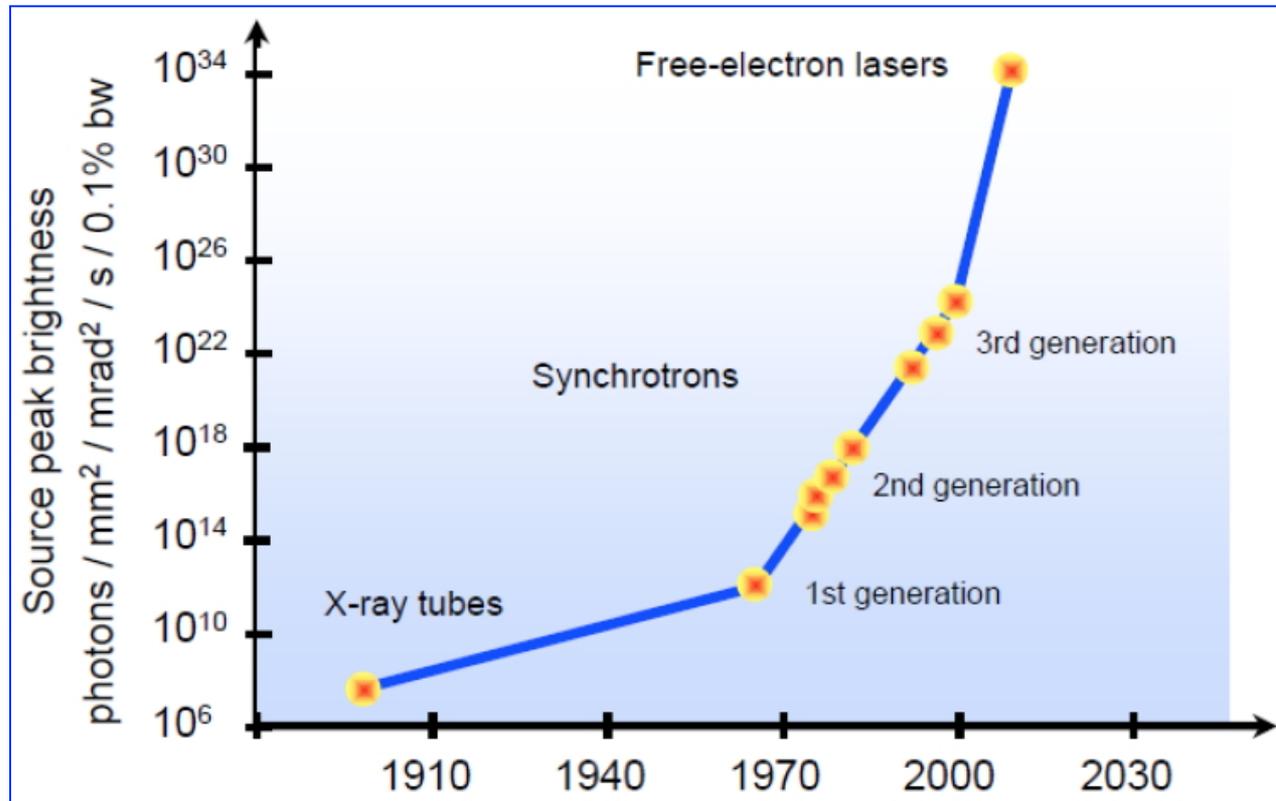
LNF **ADONE** (big ADA) electron-positron storage ring 1.5  
GeV per beam,  $C = 105$  m  
(1969-1993)



1976-1993 LNF **ADONE** 1.5 GeV parasitic/dedicated use  
for SR experiments after its use for HE experiments.

# *Increasing brightness*

*Brightness is the main figure of merit of synchrotron radiation sources and its huge increase, was obtained designing **low emittance machines**, minimizing the source size and the beam divergence.*



*Increase of a factor 1000 every 10 years!!!*

# *Synchrotron radiation: optimized sources*

## *Third generation sources*

*Synchrotron light is now a unique tool for science!*

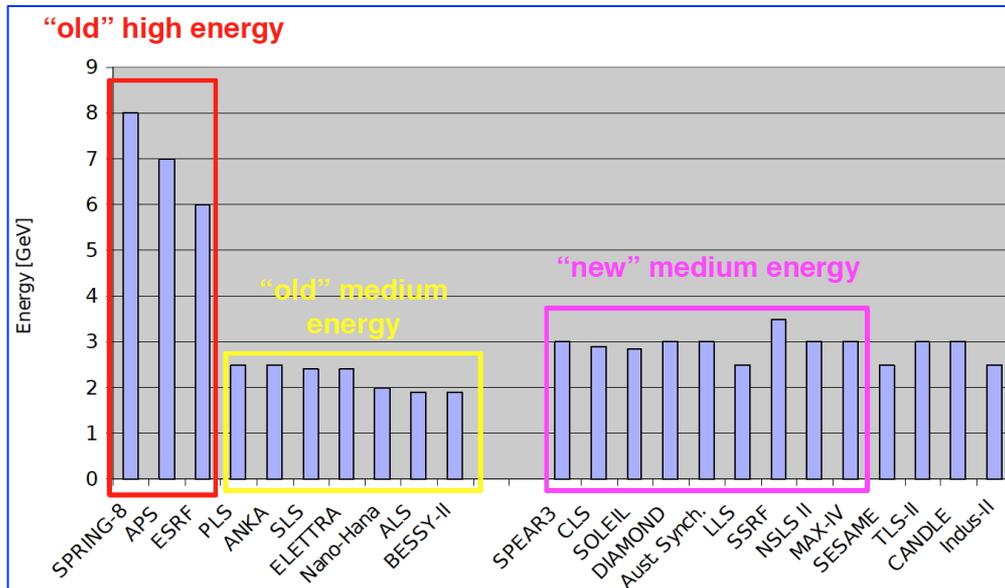


*ESRF, Grenoble - France 6 GeV,  $C = 844$  m  
opened to users in 1994*

- Sources designed specifically for high brightness or low emittance.*
- Emphasis on research with insertion devices like undulators!*
- High-energy machines able to generate hard x-rays*
- Larger facilities to support rapidly growing user community, many beamlines high number of users.*

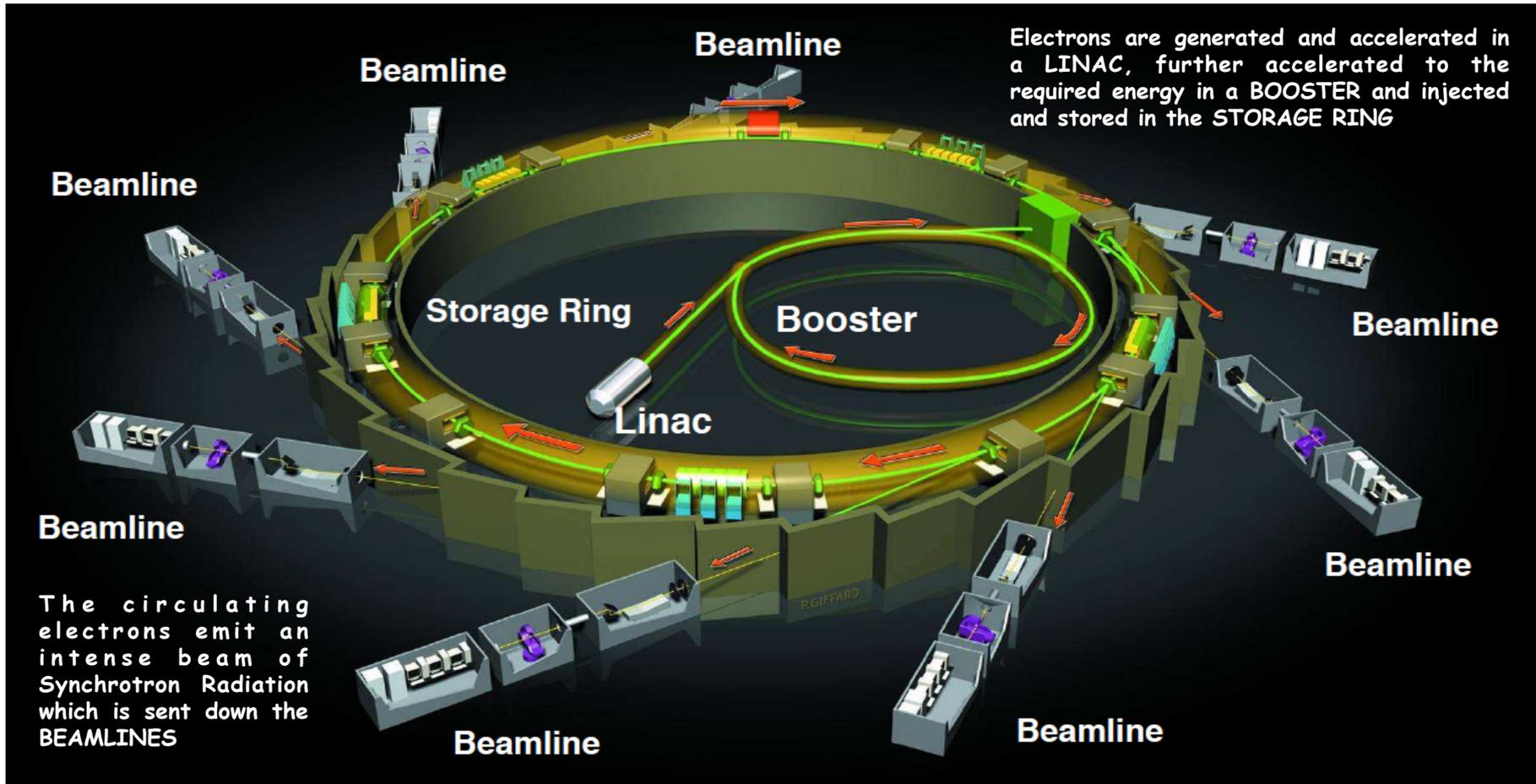
# Synchrotron radiation facilities

**18 in America**  
**25 in Asia**  
**25 in Europe**  
**1 in Oceania**  
*including facilities under design and FELS*



**Info on European Synchrotron Radiation Facilities: [www.wayforlight.eu](http://www.wayforlight.eu)**  
**About 67 operational Synchrotron Radiation Facilities Around the World information on: [www.lightsources.org](http://www.lightsources.org)**

# Schematic view of a Synchrotron Radiation facility



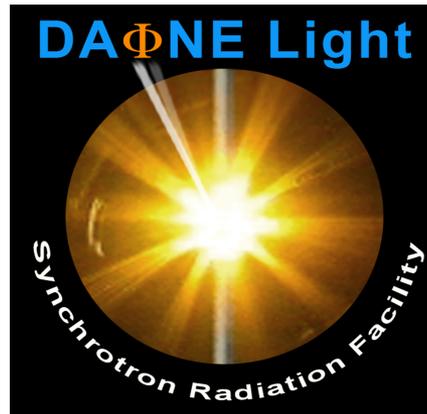
*As a function of the energy range to be used each beamline must be optimized for a particular field of research.*

*Beamline schematic composition:*

- *Front end*
- *Optical hutch*
- *Experimental hutch*
- *Control and computing*

The *front end* isolates the beamline vacuum from the storage ring vacuum; defines the angular acceptance of the synchrotron radiation via an aperture; blocks (beam shutter) when required, the x-ray and Bremsstrahlung radiation during access to the other hutches.

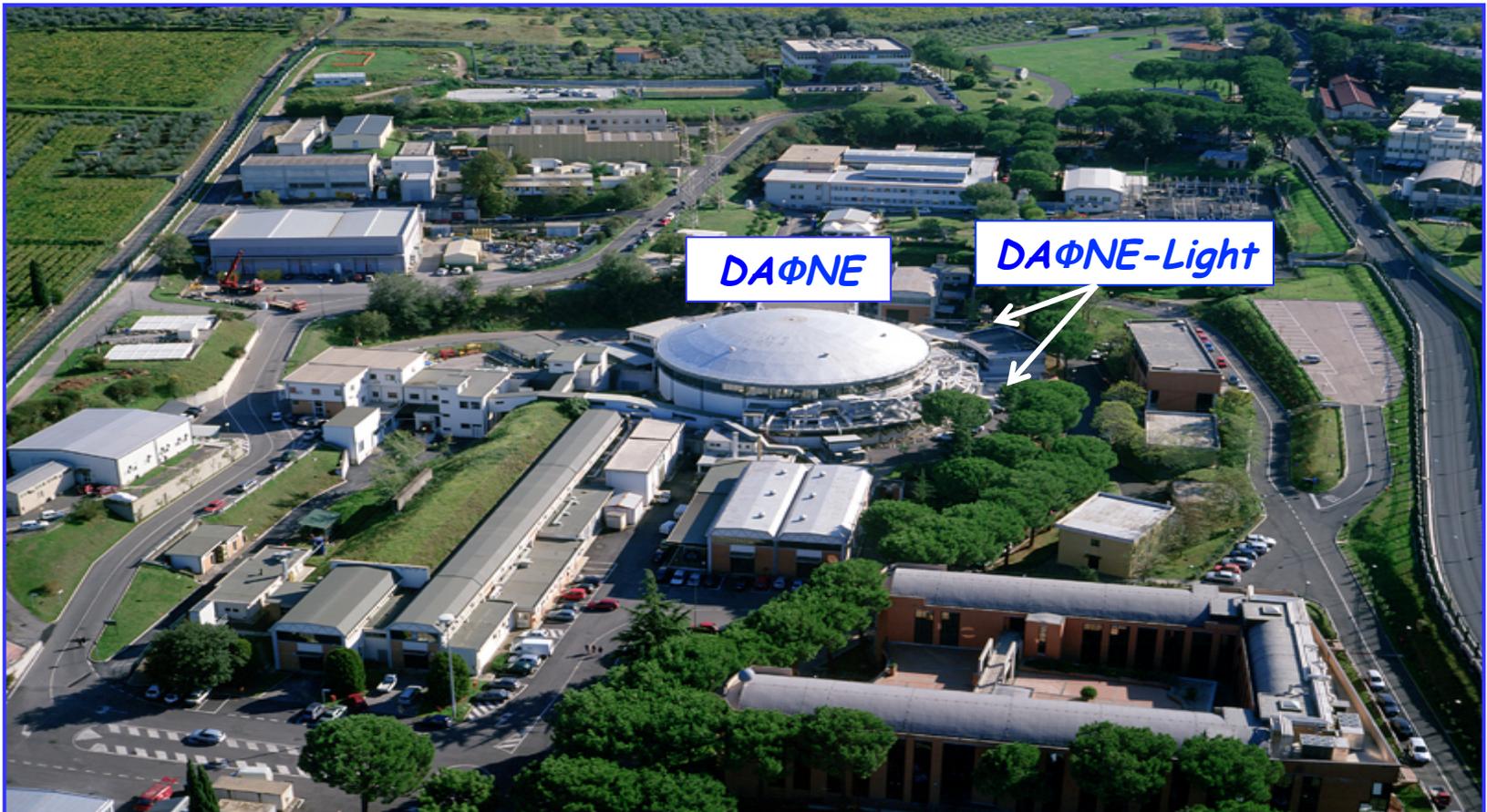
# *Synchrotron radiation @ INFN-Frascati National Laboratory*



# DAΦNE-Light



## INFN-LNF Synchrotron Radiation Facility



# Beamlines @ DAΦNE

1) **SINBAD - IR beamline** (1.24 meV - 1.24 eV)

2) **DXR1- Soft x-ray beamline** (900-3000 eV)

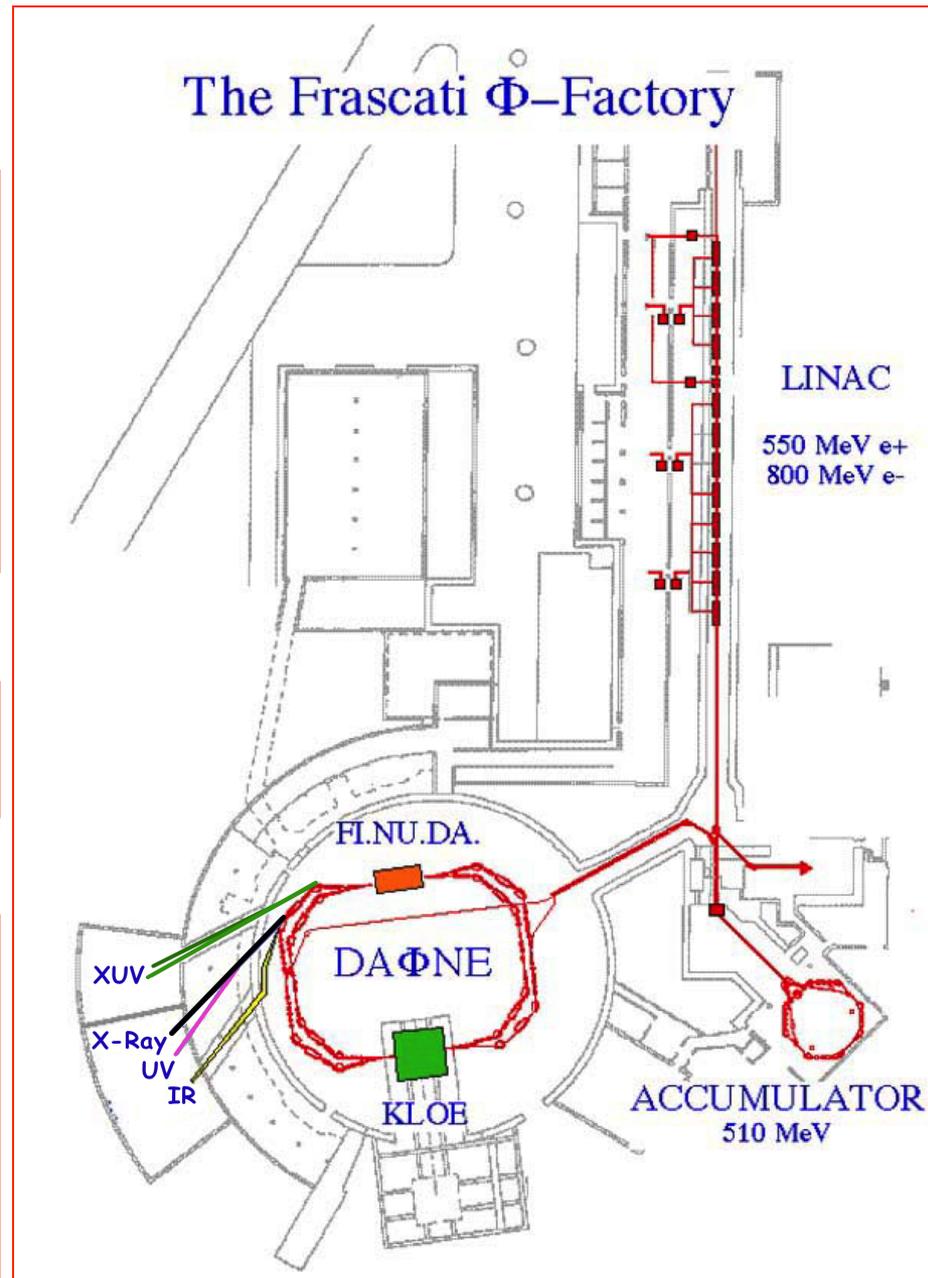
*Open to Italian and EU users*

3) **DXR2 - UV-VIS beamline** (2-10eV)  
*new setup.*

## XUV beamlines

4) **Low Energy Beamline** (35-200 eV)  
*ready for commissioning;*

5) **High Energy Beamline** (60-1000eV)  
*ready for commissioning.*

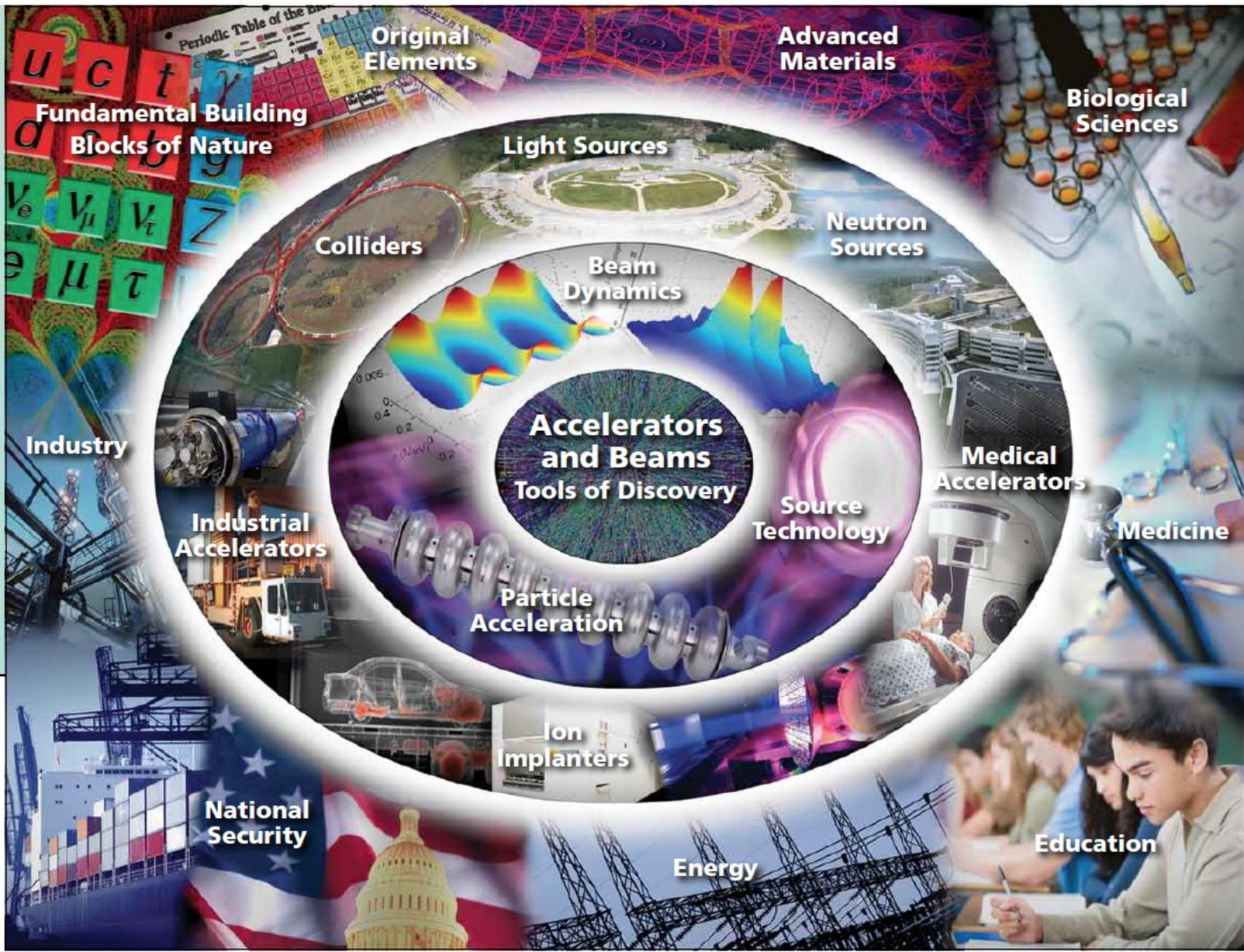


# *Available techniques*

- *FTIR spectroscopy, IR microscopy and IR imaging*
- *UV-Vis absorption spectroscopy*
- *Photochemistry: UV irradiation and FTIR micro-spectroscopy and imaging.*
- *Soft x-ray spectroscopy: XANES (X-ray Absorption Near Edge Structure) light elements from Na to S*
- *SEY (secondary electron yield) and XPS (X-ray photoelectron spectroscopy) - by electron and photon bombardment*

***From accelerators to applications***

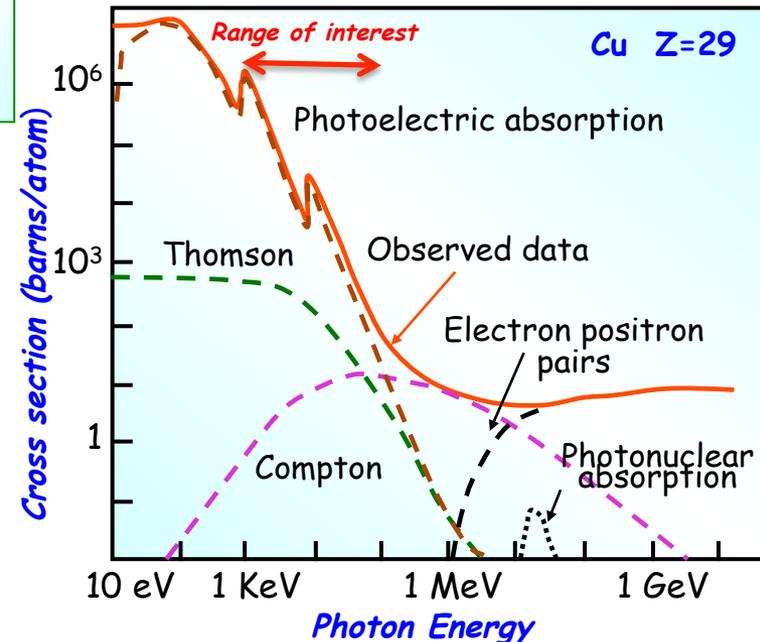
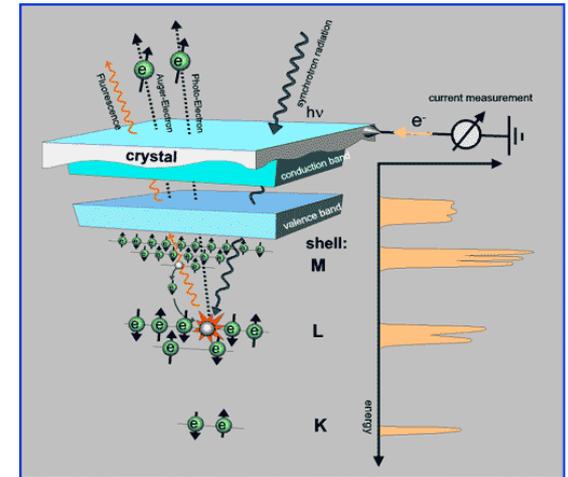
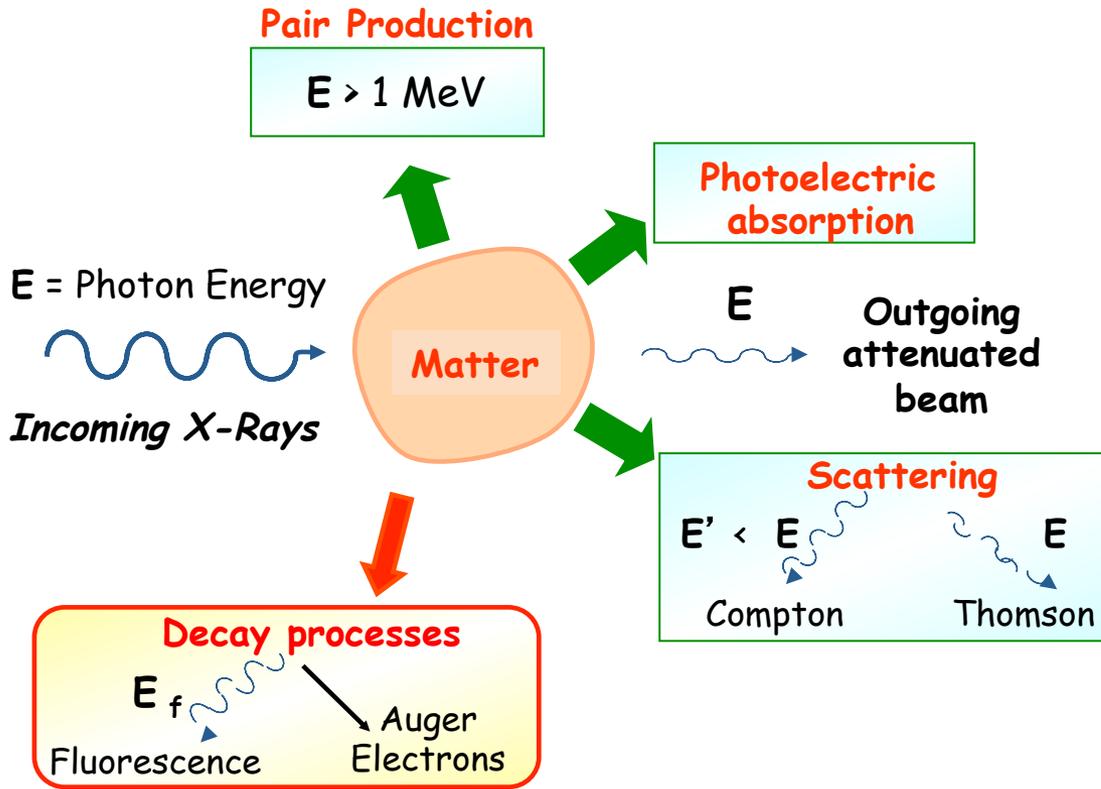
COURTESY OAK RIDGE NATIONAL LABORATORY.



# *Interactions of x-rays with matter*

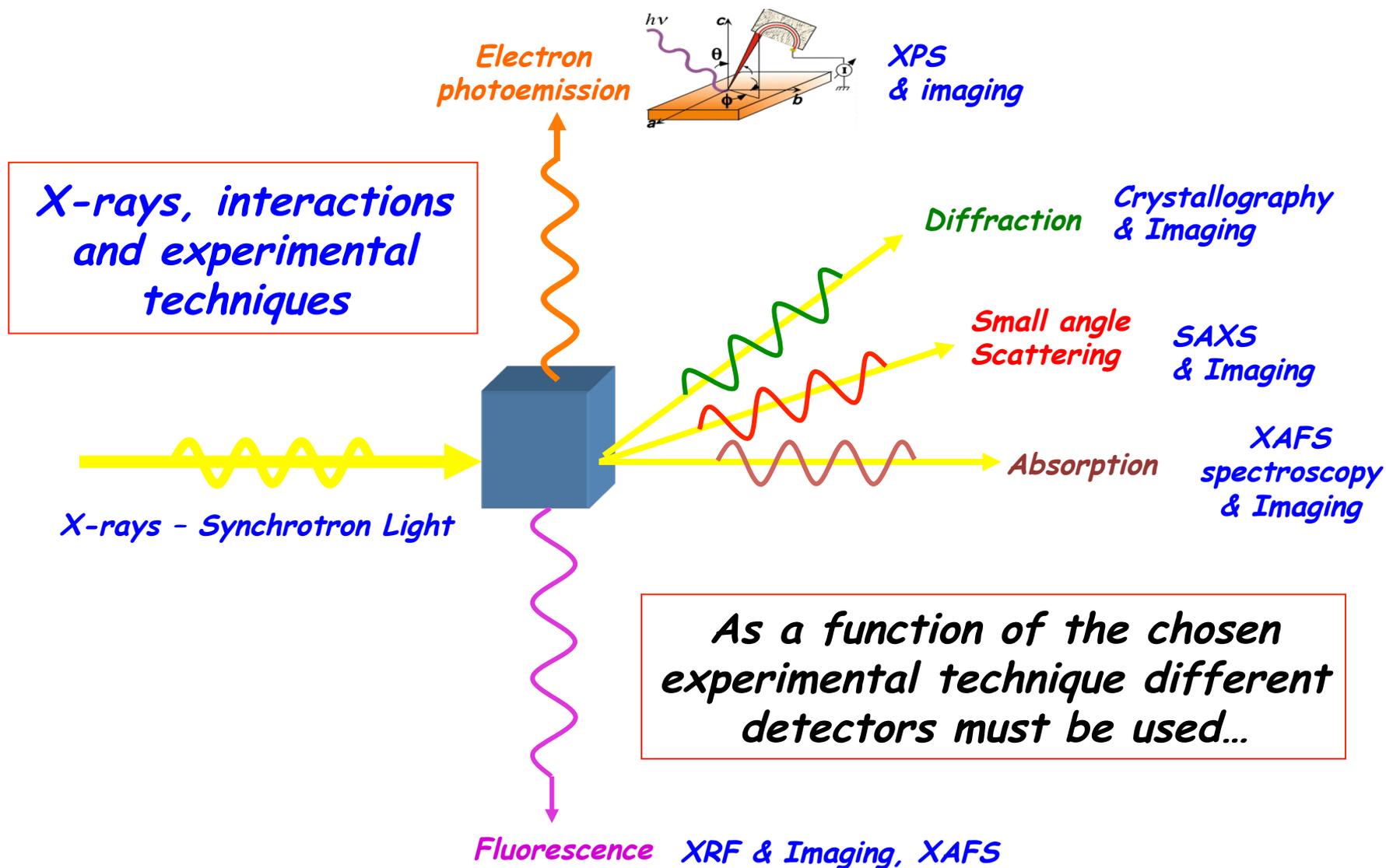
# Interaction of X-rays with matter

## Attenuation mechanisms for X-rays



There are different types of interaction of X-rays with matter but taking into account the energy range of interest the ones that will be taken into account are **absorption** and **elastic** or **Thomson scattering**.

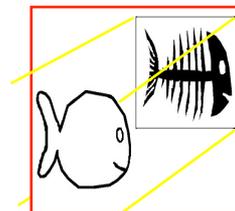
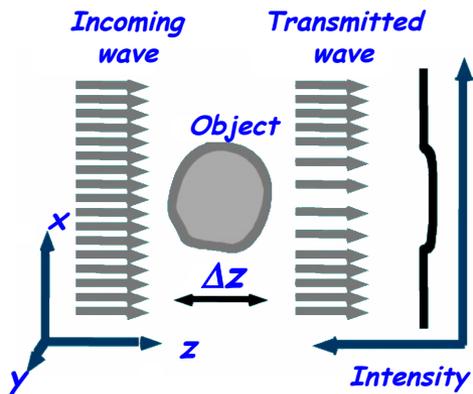
# *X-rays interactions with matter and experimental techniques*



# Some X-ray techniques

## Imaging

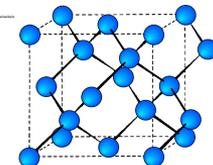
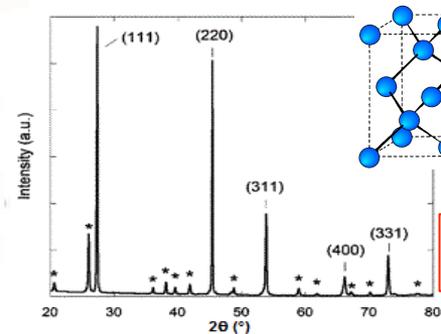
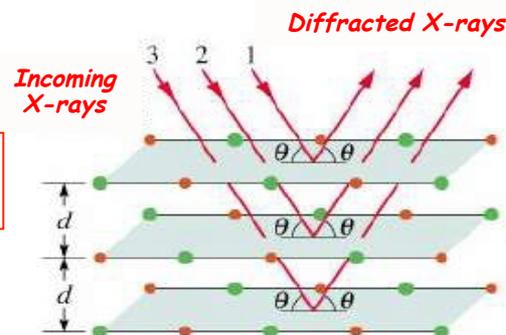
Conventional radiology relies on X ray absorption



## Scattering

Elastic scattering : Thomson (elastic) if  $E < E_{\text{binding}}$

$$n\lambda = 2d \sin\theta \quad \text{Bragg's Law}$$

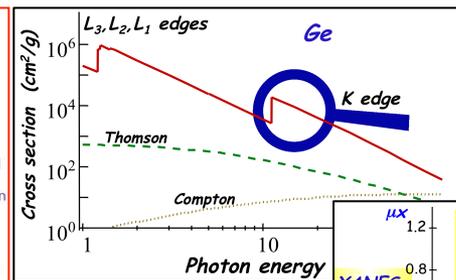
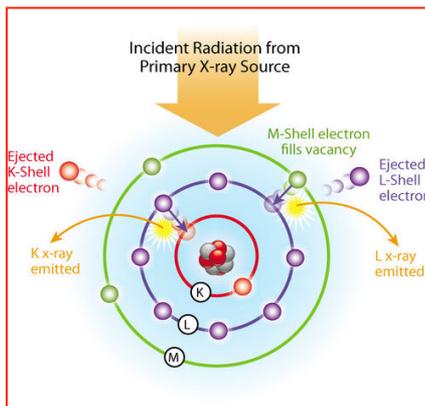


Ge crystal structure

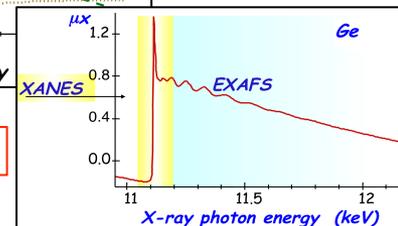
## Spectroscopy

X ray Absorption Fine Structure (XAFS)

Transmission and fluorescence mode



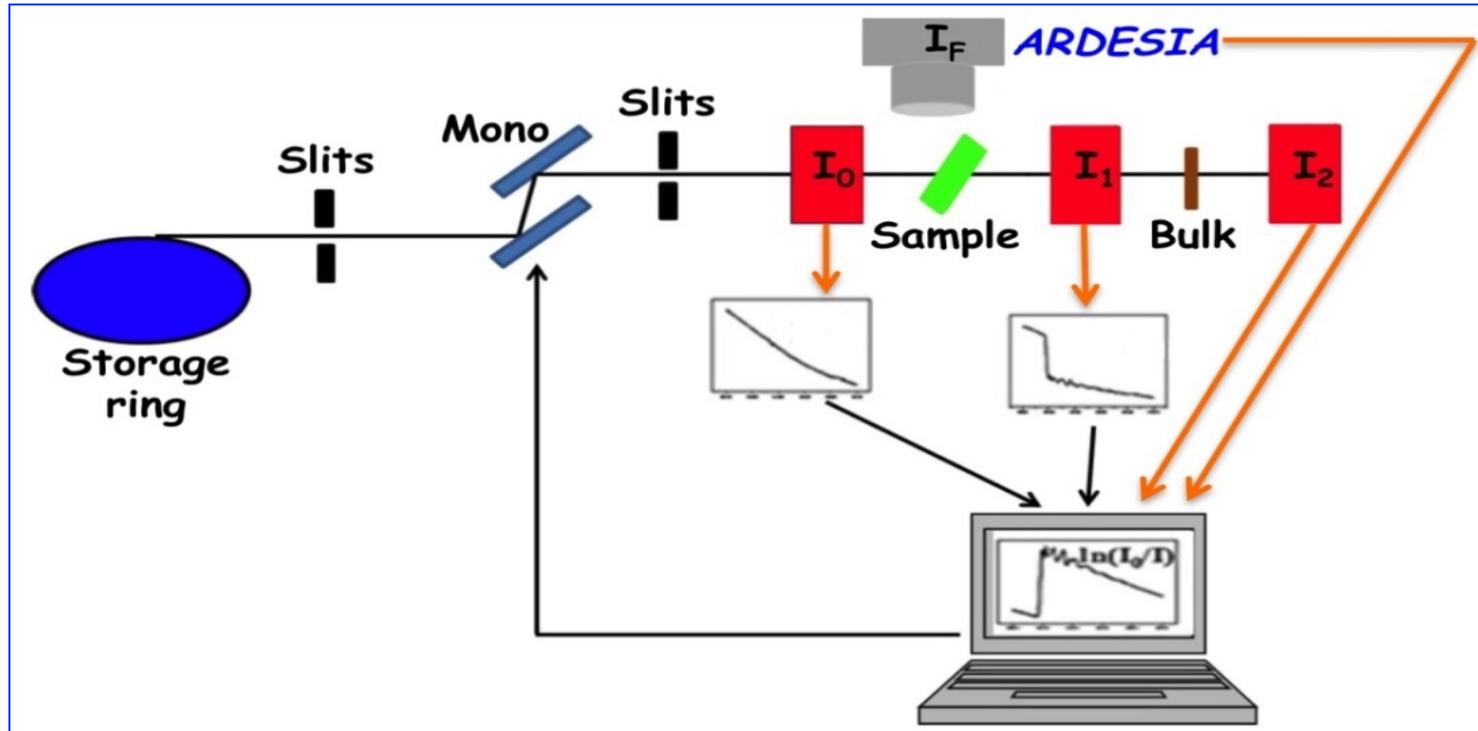
XAFS = XANES + EXAFS



# *X-ray Absorption Spectroscopy*

*XAS local sensitive and chemical selective probe  
that can provide structural, electronic and magnetic information.*

# DAFNE-L DXR1 beam line absorption spectroscopy

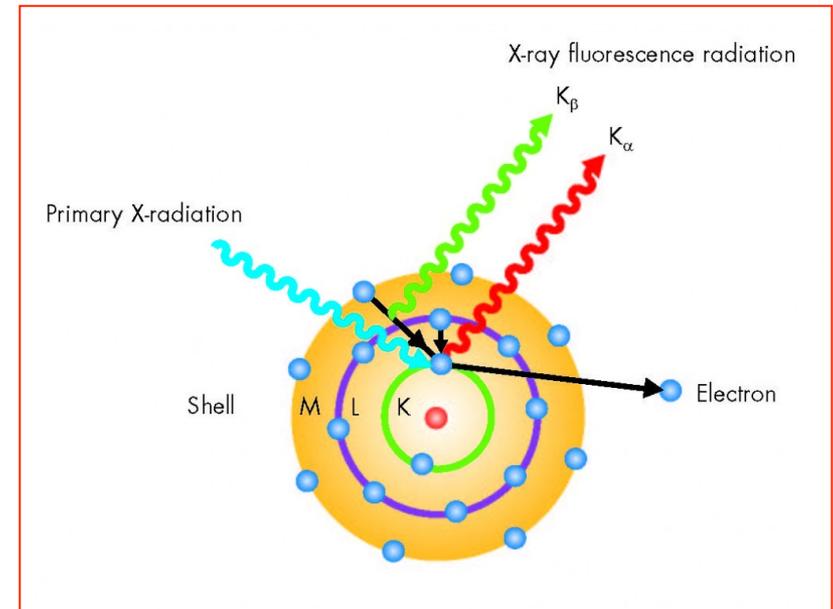


$I_0, I_1, I_2$  Gas ionization chambers -  $I_F$  SDD solid state detector

# Photons as Ionizing Radiation

- **Photoelectric effect**

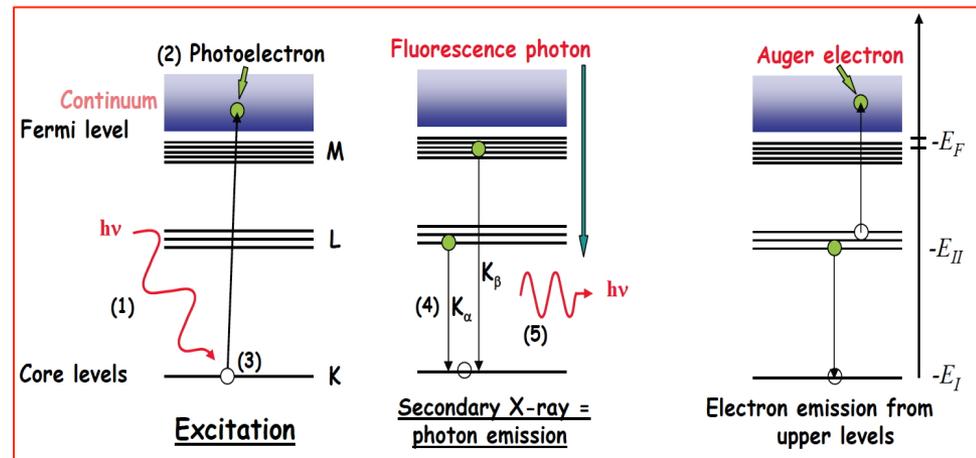
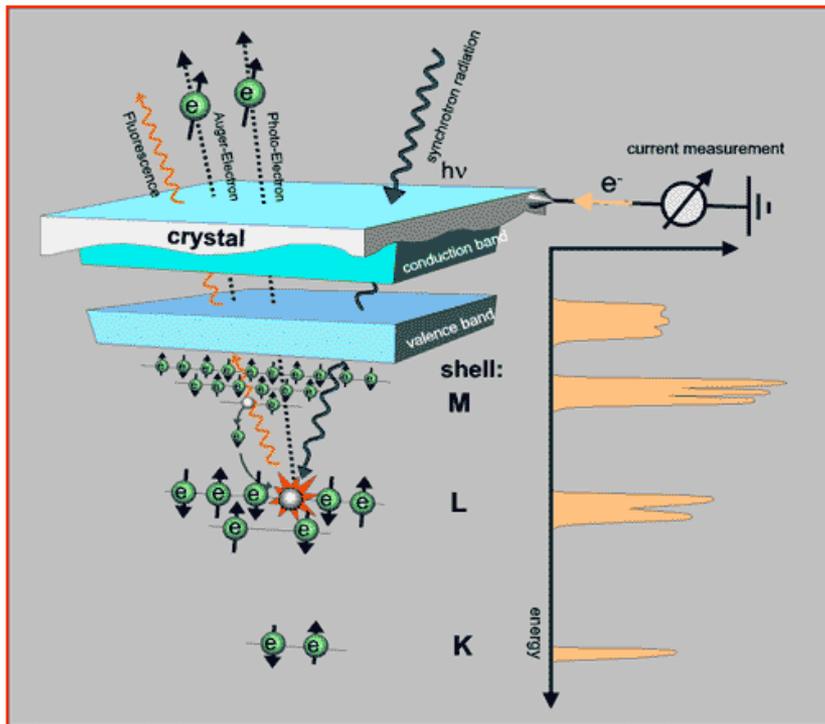
- Causes ejection of an inner orbital electron and thus also characteristic radiation (energy of fluorescence lines  $E_F \approx Z^2$ ) as orbital hole is filled
- Energy of ejected photoelectron:  $E_e = h\nu - E_B$



# Photoelectric absorption

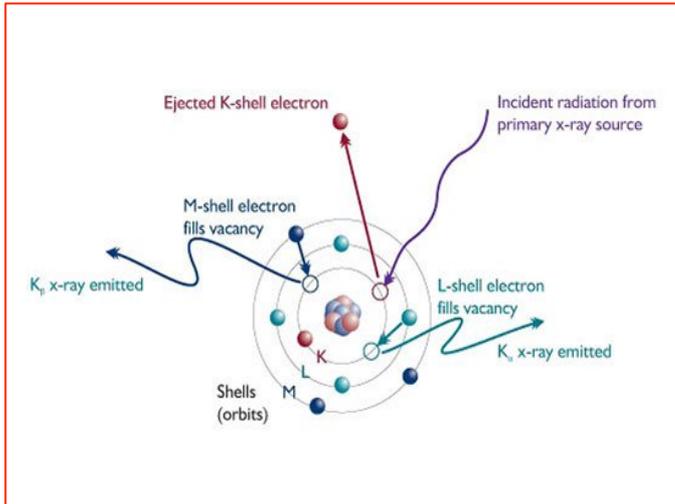
The probability of a photoelectric interaction is a function of the photon energy and the atomic number of the target atom.

A photoelectric interaction cannot occur unless the incident x-ray has energy equal to or greater than the electron binding energy.

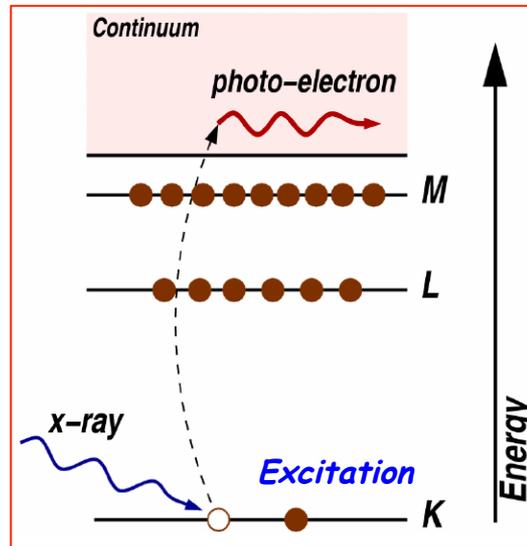


Absorption and decay effects XRF (X Ray Fluorescence) and AES (Auger Electron).

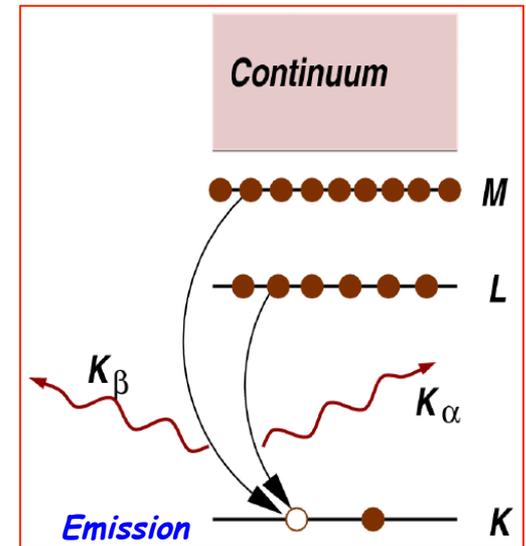
# XRF - X Ray Fluorescence Spectroscopy



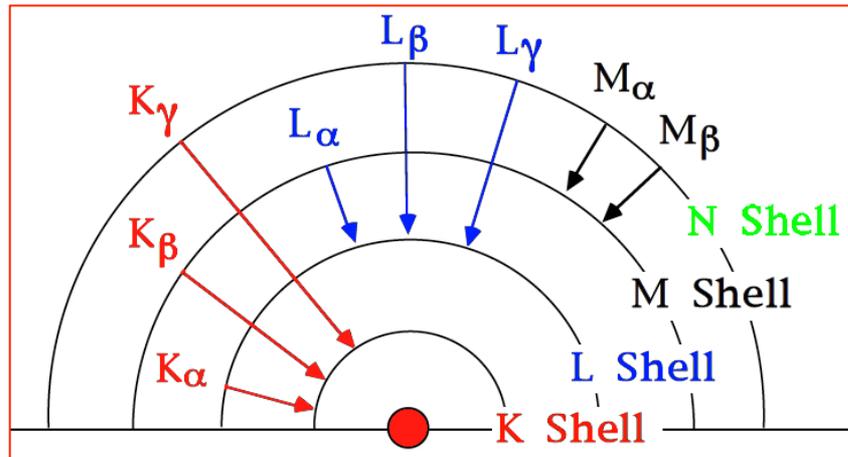
## X-ray absorption



## X-ray fluorescence

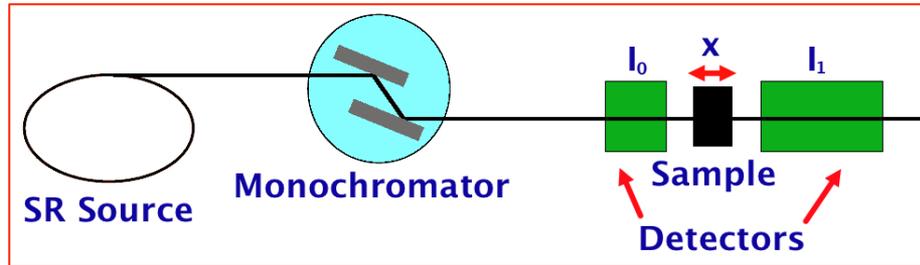


## Principle X-ray Fluorescence Emission Lines



For each atom every shell has a unique energy level determined by the atomic configuration for that element - Moseley's Law  $E = Z^2$

# X-ray absorption fine structure spectroscopy - XAFS

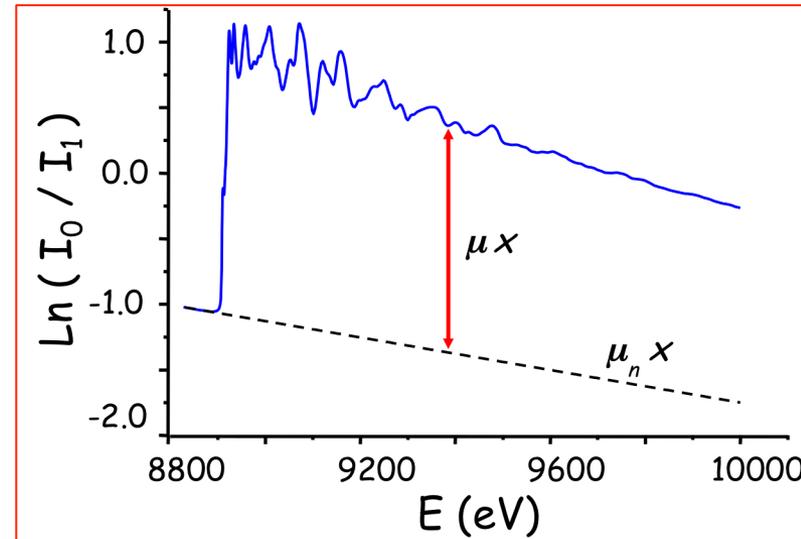
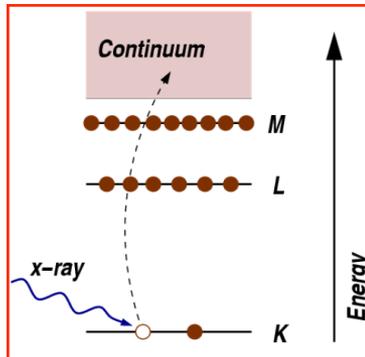
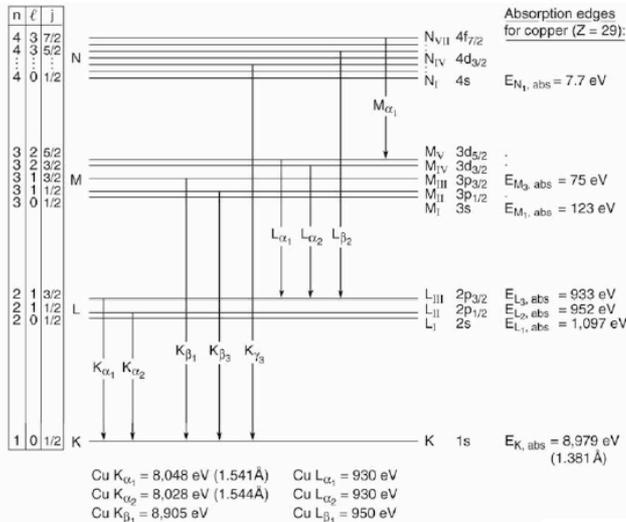


$$I_1 = I_0 \exp[-\mu(E) x]$$

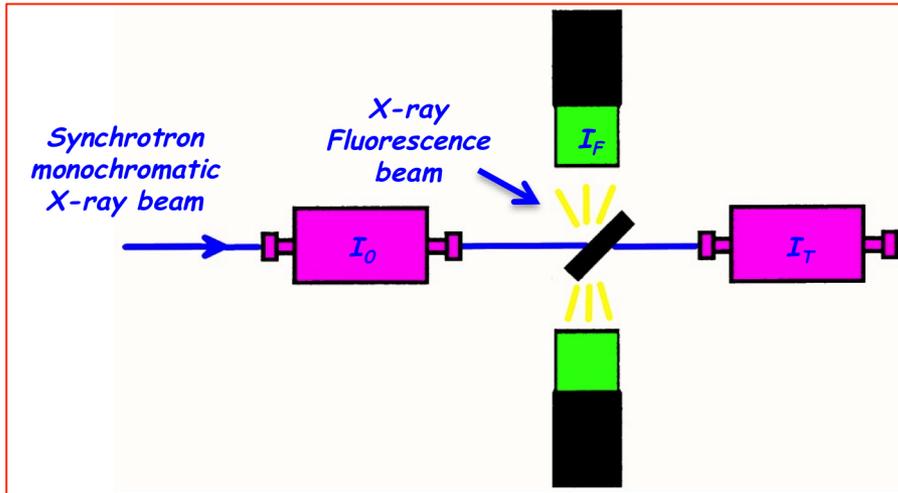
Exponential attenuation or equation of Beer-Lambert

Attenuation coefficient

$$\mu(E) = \frac{1}{x} \ln \left( \frac{I_0}{I_1} \right)$$



# XAFS in transmission or fluorescence geometries



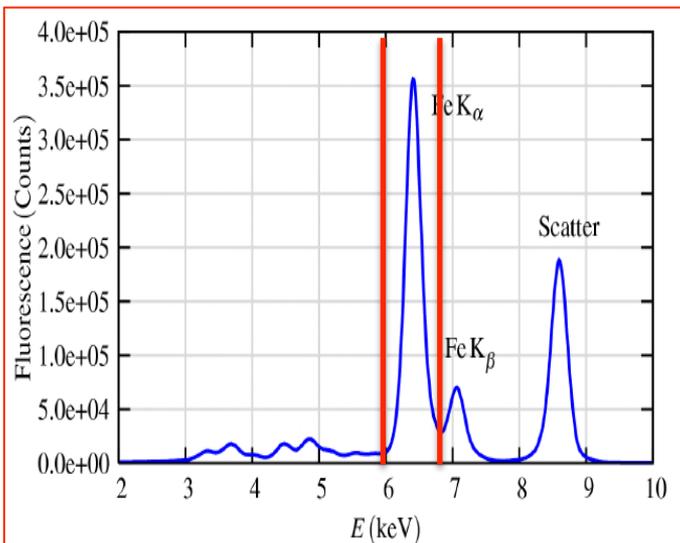
XAFS can be measured either in transmission or fluorescence geometries.  
The energy dependence of the absorption coefficient  $\mu(E)$ :

$$\mu(E)x = \ln\left(\frac{I_0}{I_1}\right)$$

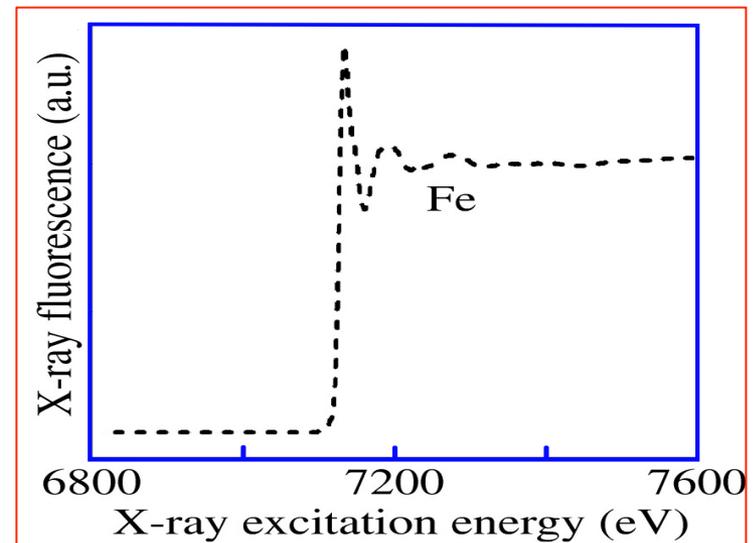
Transmission geometry

$$\mu(E)x = \left(\frac{I_F}{I_0}\right)$$

Fluorescence geometry



The probability of fluorescence emission is directly proportional to the absorption probability. So in fluorescence mode the variation of the intensity of the fluorescence line as a function of energy gives the XAFS spectra.



# Fermi's golden rule

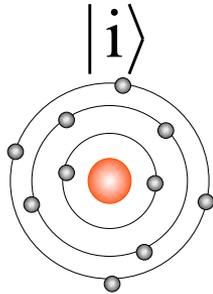
$$\mu(\omega) = \frac{4\pi n\alpha}{\omega} \sum_f \left| \langle i | d | f \rangle \right|^2 \delta(\hbar\omega + E_i - E_f)$$

$\alpha = 1/137$  fine structure constant

$$E = \hbar\omega + E_i$$

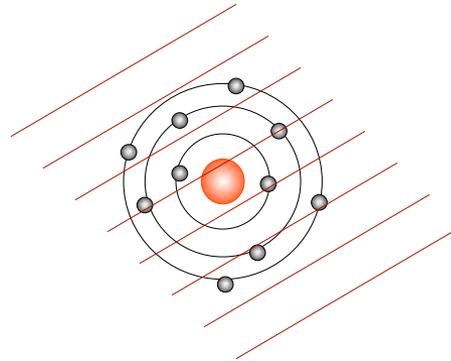
## Transition probability

INITIAL STATE

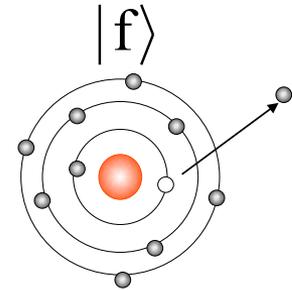


Ground state

INTERACTION



FINAL STATE



Core hole +  
excitation or ionization

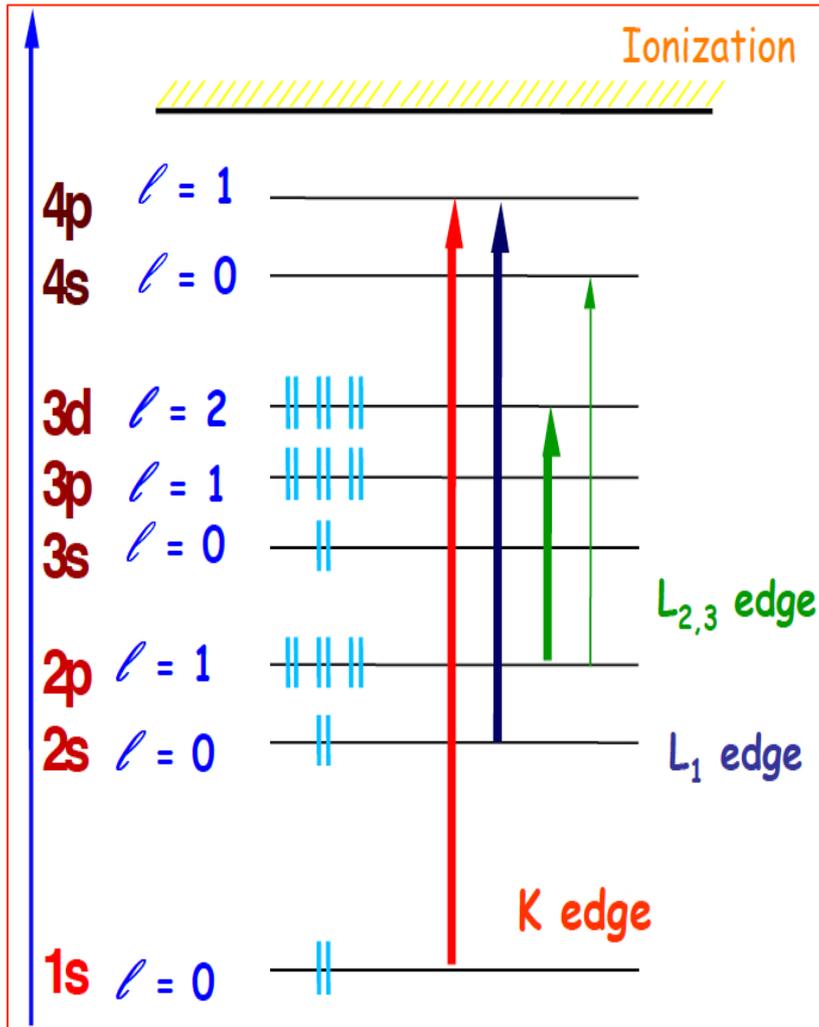
$$d = \hat{\epsilon} \cdot \vec{r} e^{i\vec{k} \cdot \vec{r}} = (\hat{\epsilon} \cdot \vec{r}) + i(\hat{\epsilon} \cdot \vec{r})(\vec{k} \cdot \vec{r}) + \dots$$

Photon polarisation vector  $\hat{\epsilon}$   
Wavevector of the Incident plane wave  $\vec{k}$

Electric Dipole Term  $(\hat{\epsilon} \cdot \vec{r})$   
Electric Quadrupole Term  $i(\hat{\epsilon} \cdot \vec{r})(\vec{k} \cdot \vec{r})$

$d =$  Interaction Hamiltonian describing the coupling to the X-ray field.

# XAFS spectroscopy



Element specific, angular momentum selective which probes density of unoccupied states.

## Selection rules:

**Dipole transition**

$$\Delta l = \pm 1$$

K edge:  $1s \rightarrow p$

L edge:  $2s \rightarrow p, 2p \rightarrow s, d$

**Quadrupole transition** (Much weaker)  $\Delta l = \pm 2$

K edge:  $s \rightarrow d, p \rightarrow f$

## Absorption edges:

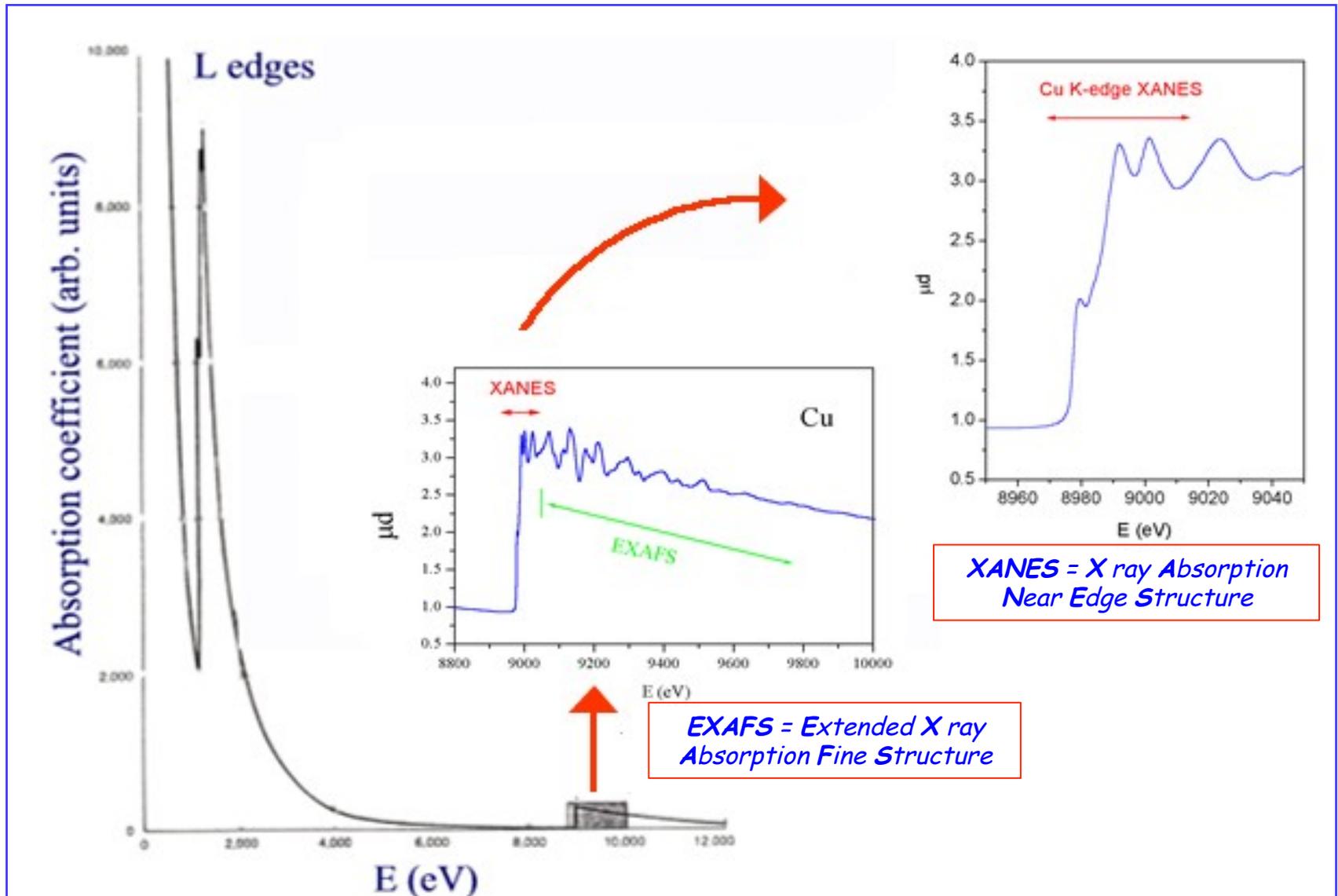
1s - K edge

2s, 2p - L edges

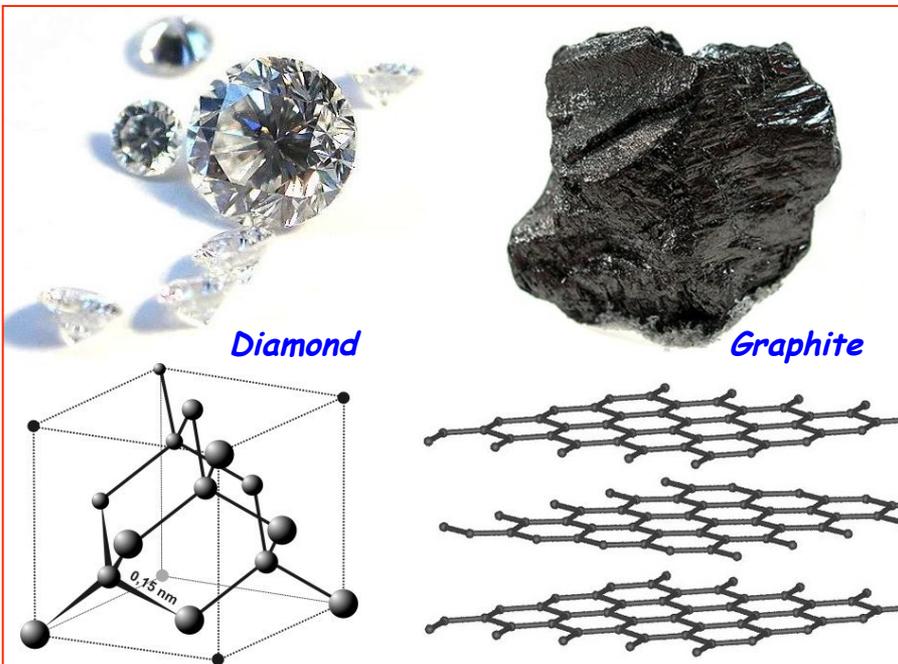
3s, 3p, 3d - M edges

4s, 4p, 4d, 4f - N edges

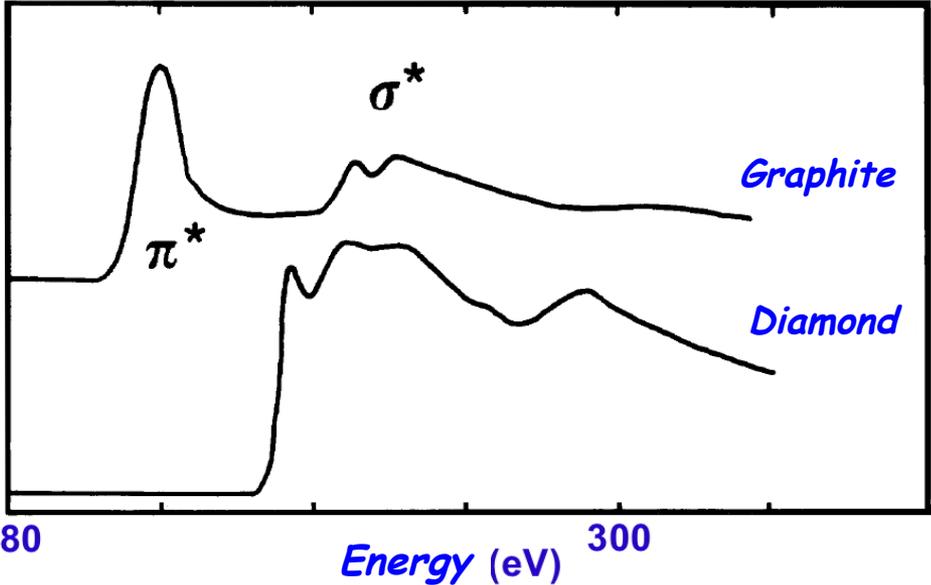
# XAFS = XANES + EXAFS



# XAFS and Carbon K edge



The quite different XAFS spectra of graphite and diamond.

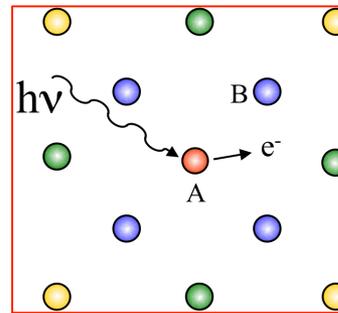
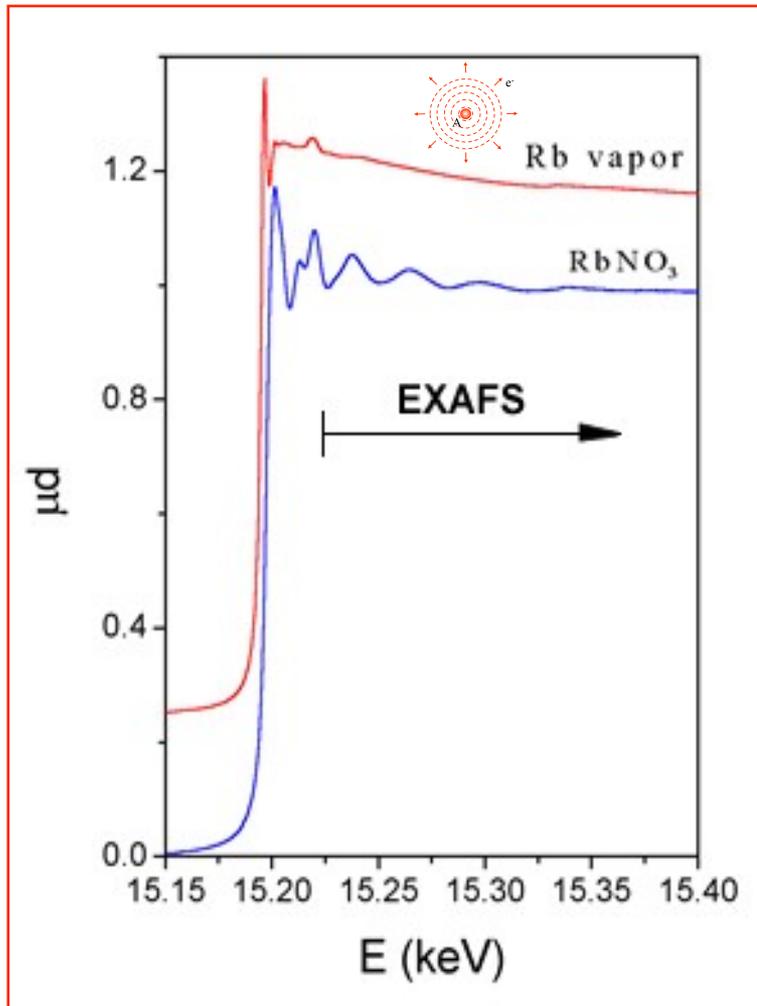


J. Robertson, *Prog Solid St. Chem* 21, 199 (1991)

# *EXAFS*

*Extended X ray Absorption Fine Structure*

# EXAFS phenomenological interpretation



X-ray absorption

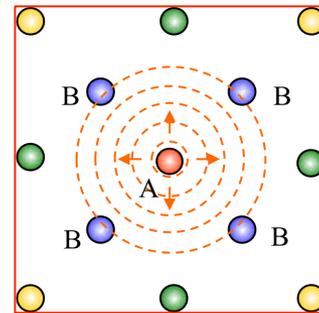
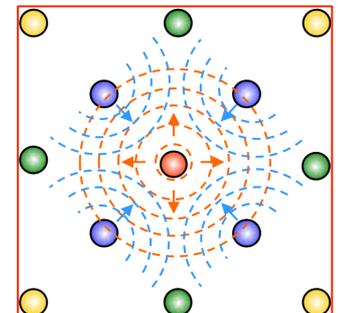
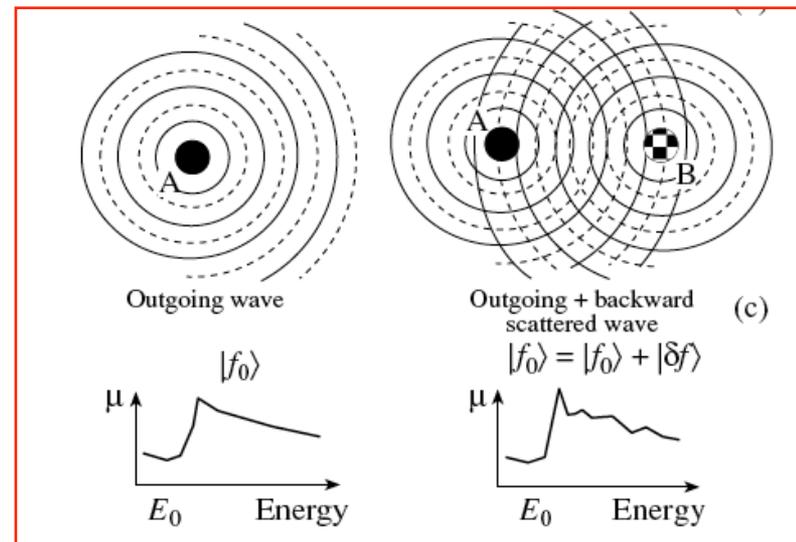


Photo-electron emission

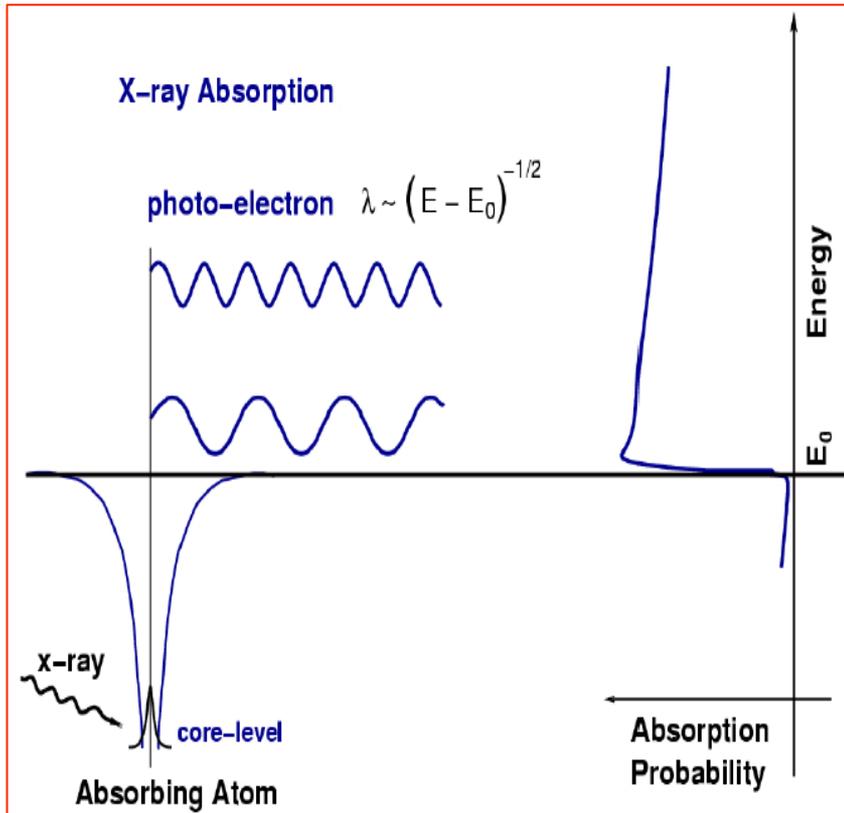


Interference

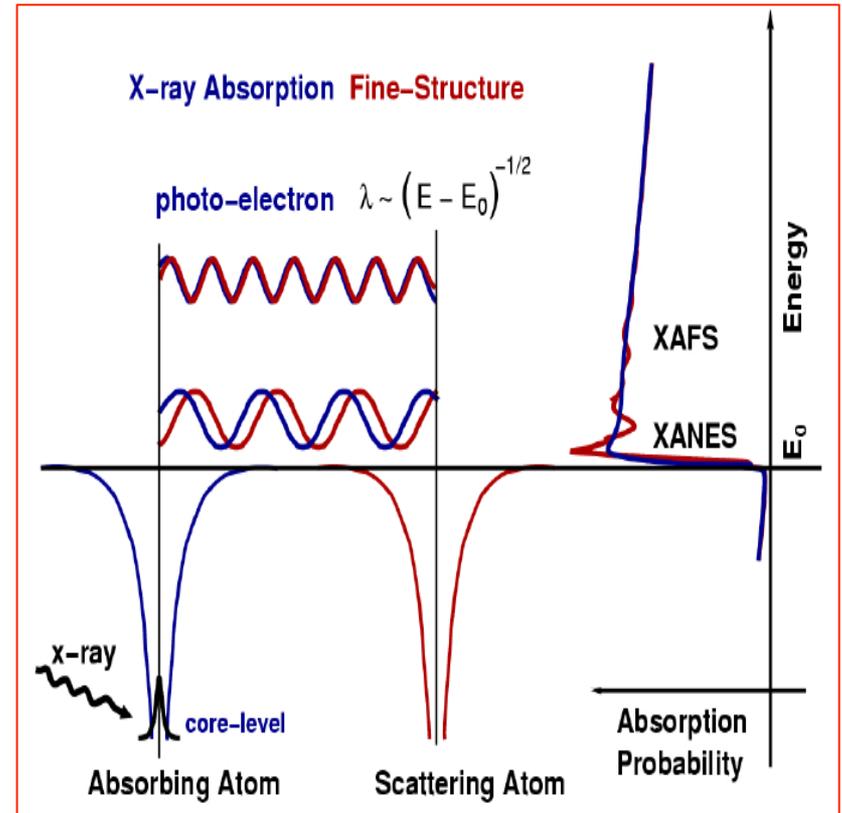


*Auto -interference phenomenon of the outgoing photoelectron with its parts that are backscattered by the neighbouring atoms*

# EXAFS phenomenological interpretation

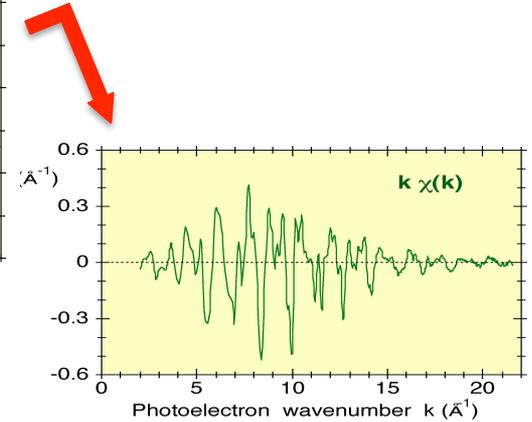
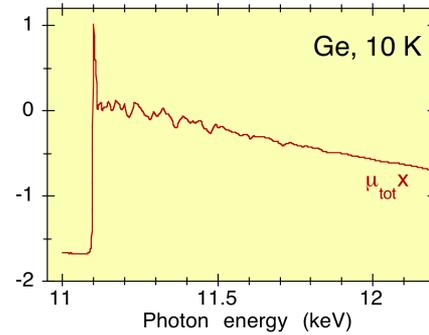
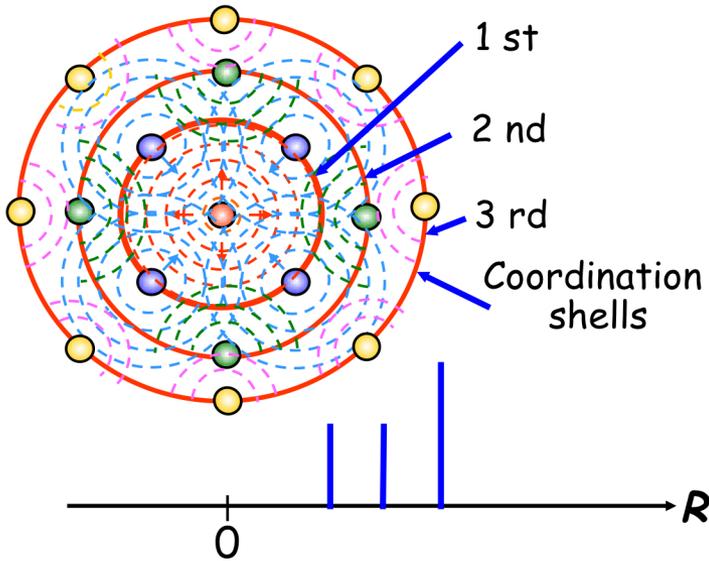


*Photoelectric effects in the presence of no scattering atom = a photo-electron is created that travels as a wave with wave number proportional  $(E - E_0)^{-1/2}$*



*The photo-electron scattered by a neighboring atom can return to the absorbing atom, modulating the amplitude of the photo-electron wave-function at the absorbing atom. This in turn modulates the absorption coefficient  $\mu(E)$ , causing EXAFS.*

# EXAFS formula



$$\chi(k) = -\frac{S_0^2}{k} \sum_s N_s \frac{|f_s(\pi, k)|}{R_s^2} e^{-k^2/\sigma_s^2} e^{-2R_s/\lambda_s} \sin(2kR_s + \phi_s(k))$$

Coordination number

Debye Waller factor

Interatomic distance

$$k = \sqrt{\frac{2m}{\hbar^2} (E - E_0)}$$

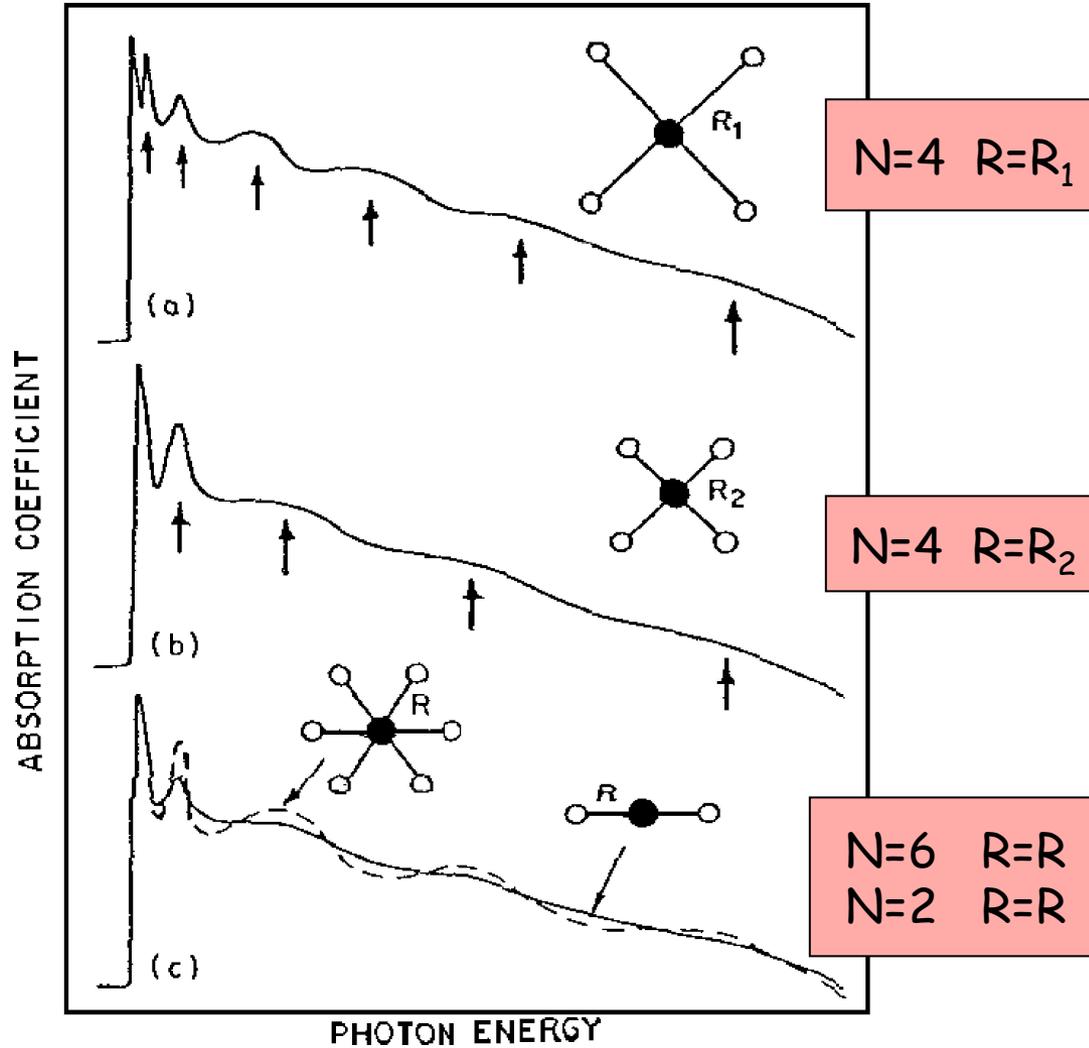
$k$  = wavenumber

Thermal disorder:  $e^{-k^2/\sigma^2}$

Electron mean free path:  $\lambda$

Inelastic scattering effect:  $S_0^2$

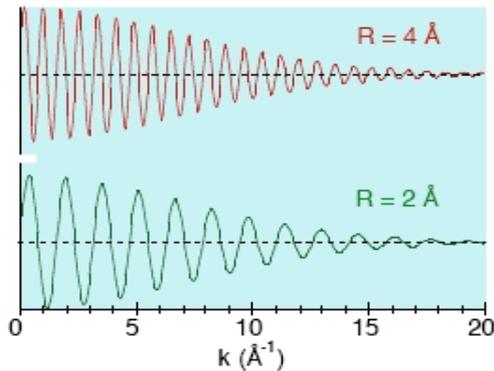
# EXAFS



# EXAFS and structural information

$$\chi(k) = -\frac{S_0^2}{k} \sum_s N_s \frac{|f_s(\pi, k)|}{R_s^2} e^{-k^2/\sigma_s^2} e^{-2R_s/\lambda_s} \sin(2kR_s + \phi_s(k))$$

$N_s$   
↑  
Coordination number
 $e^{-k^2/\sigma_s^2}$   
↑  
Debye Waller factor
 $2kR_s$   
↑  
Interatomic distance

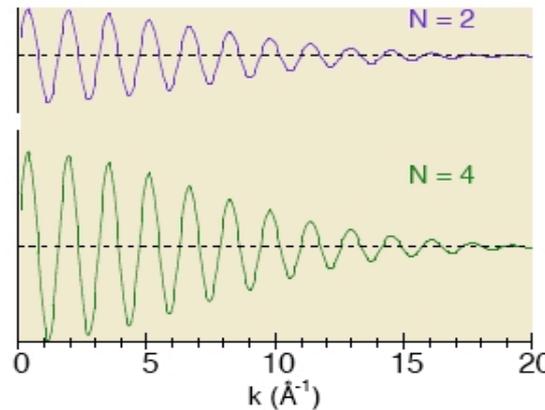


Frequency



Inter-atomic distance

$R$

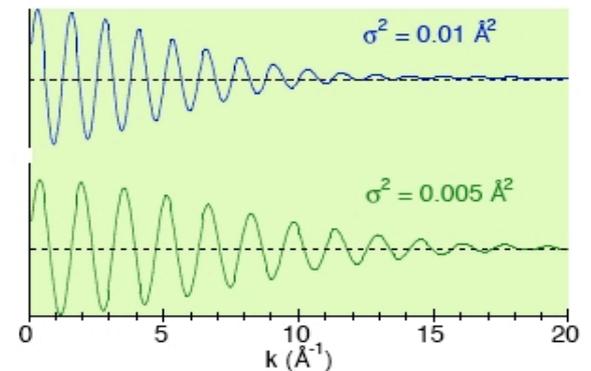


Amplitude



Coordination number

$N$



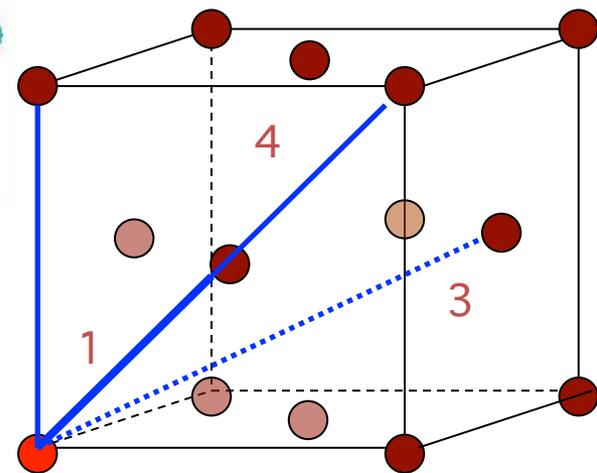
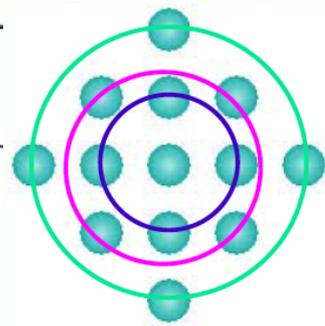
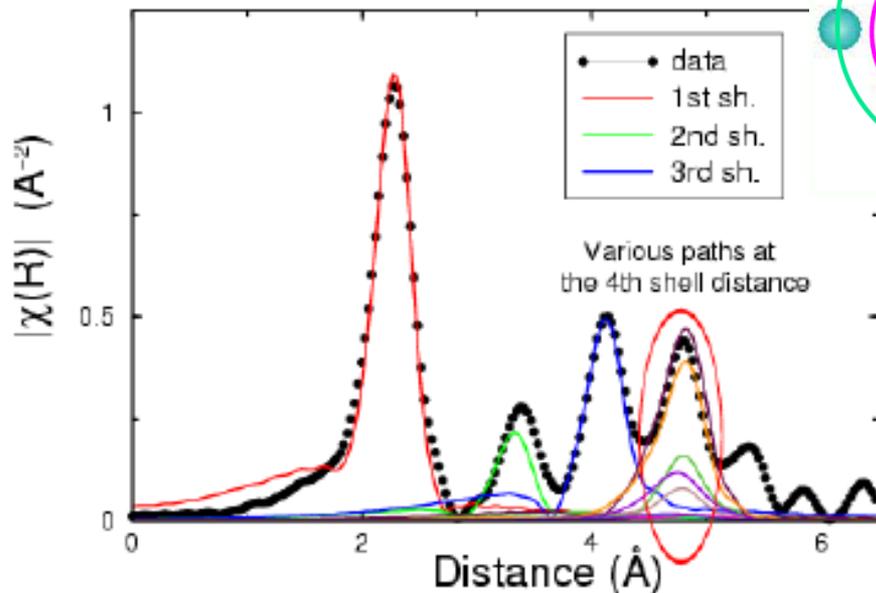
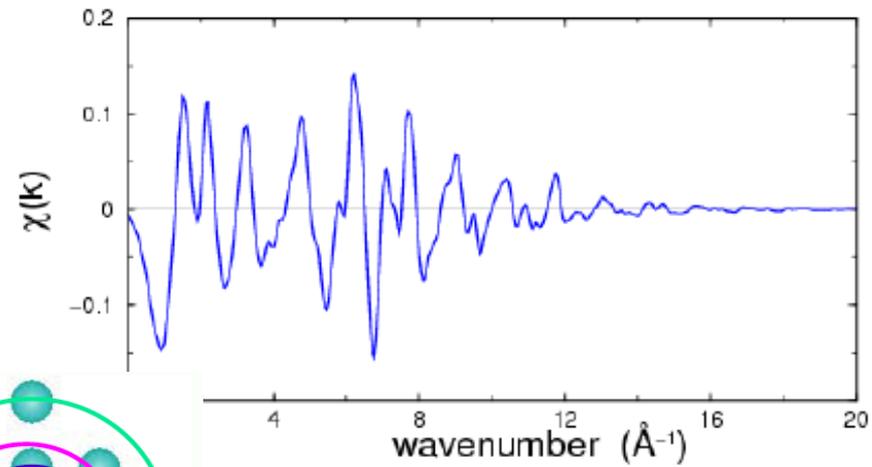
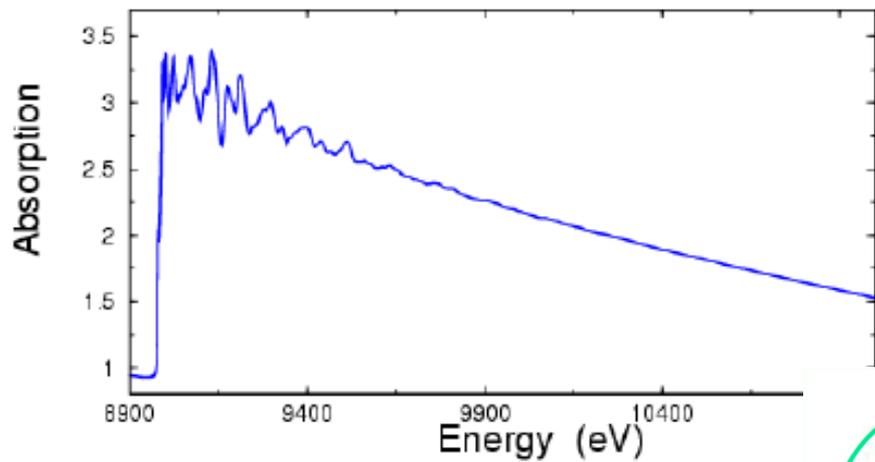
Damping



Disorder

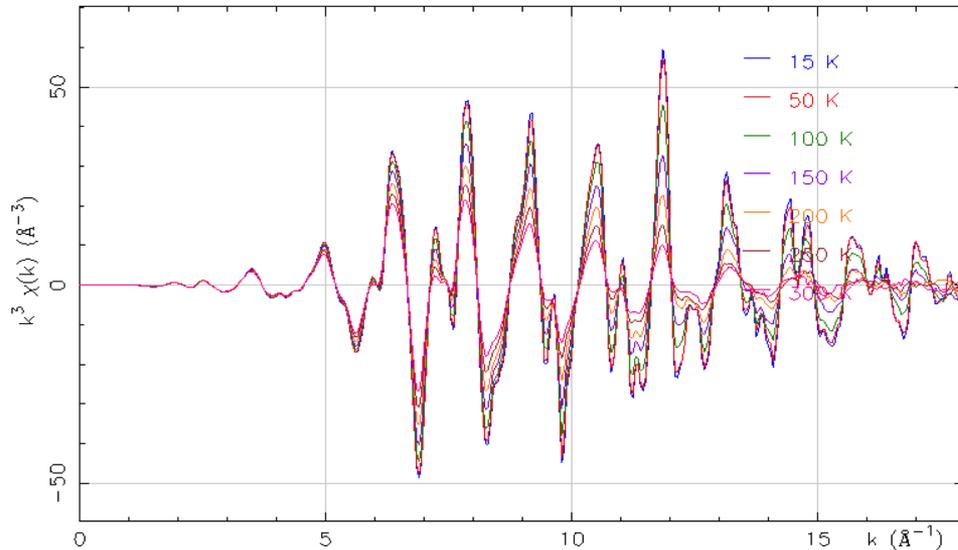
$\sigma^2$

# EXAFS data analysis



**Metallic Copper - FCC or Face Centered Cubic structure.**

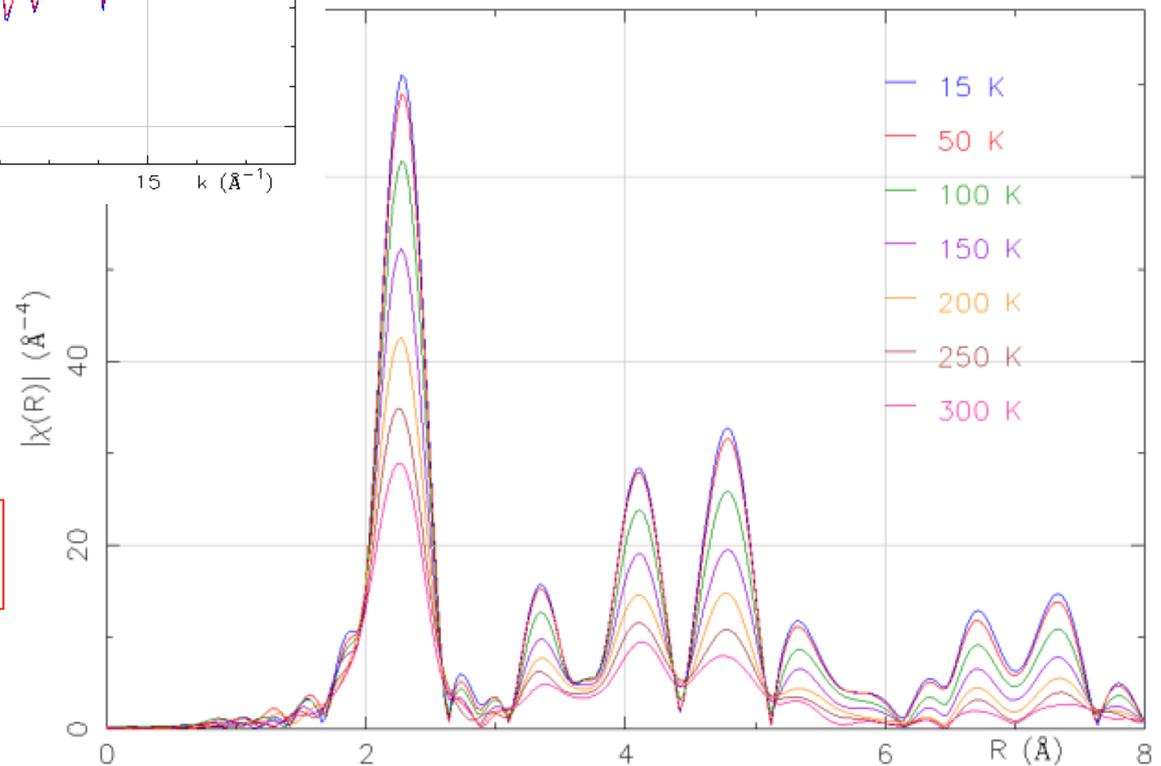
# Cu foil and temperature effects



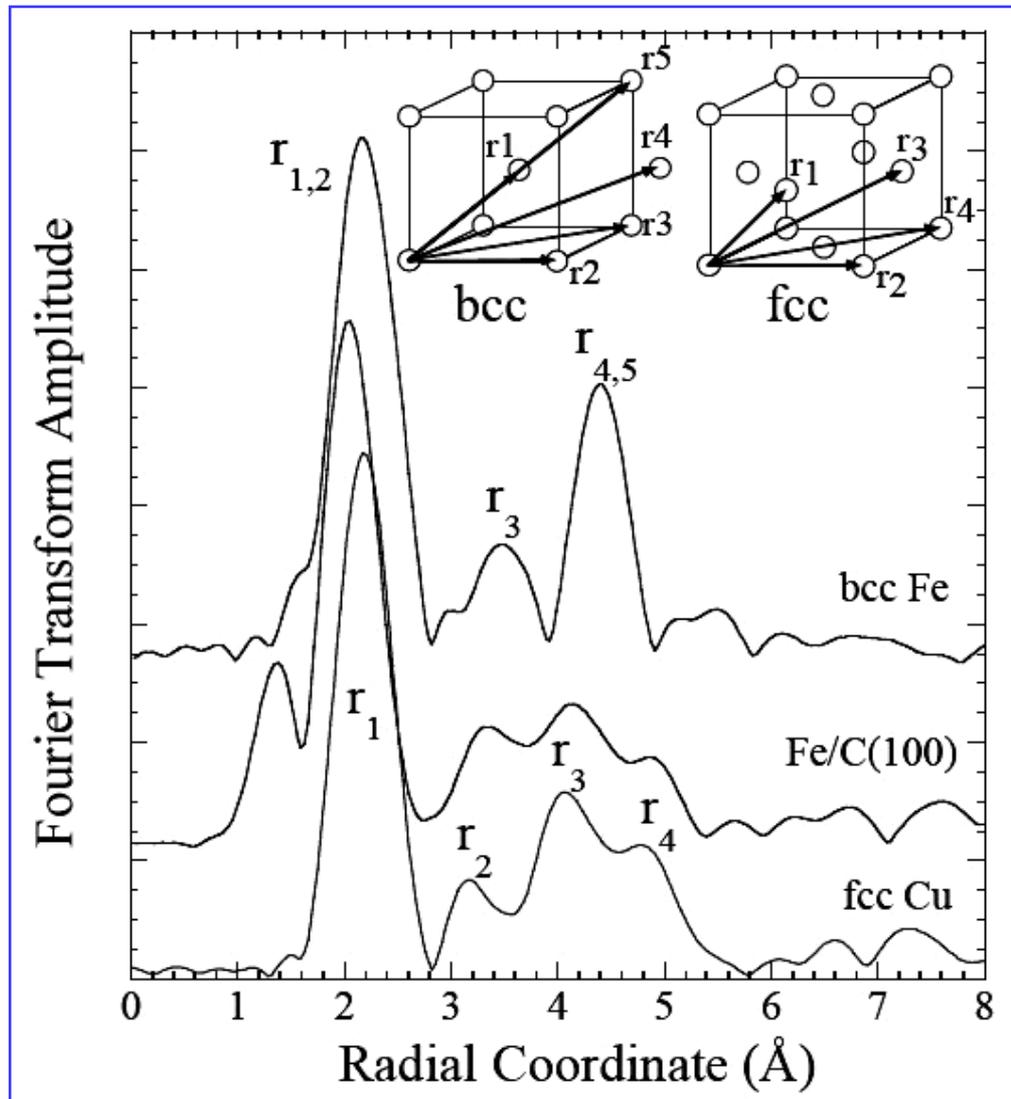
EXAFS spectra as a function of temperature.

Thermal disorder:  $e^{-k^2/\sigma^2}$

Fourier transforms of the EXAFS spectra.

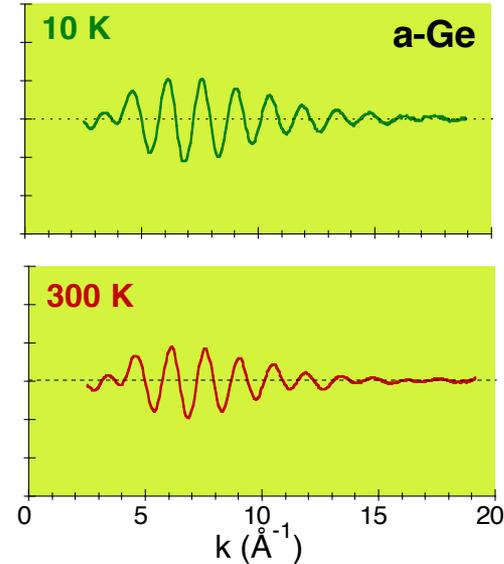
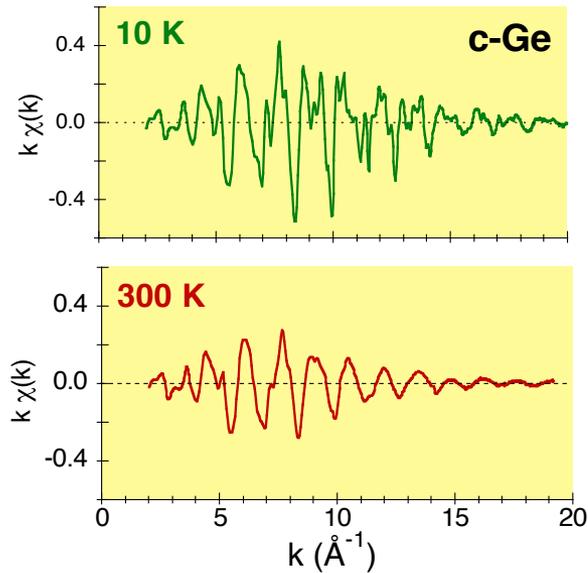


# EXAFS data analysis

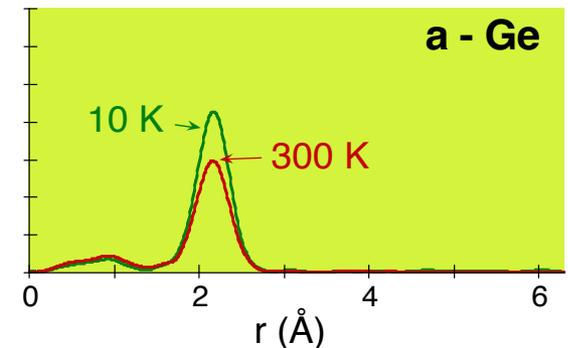
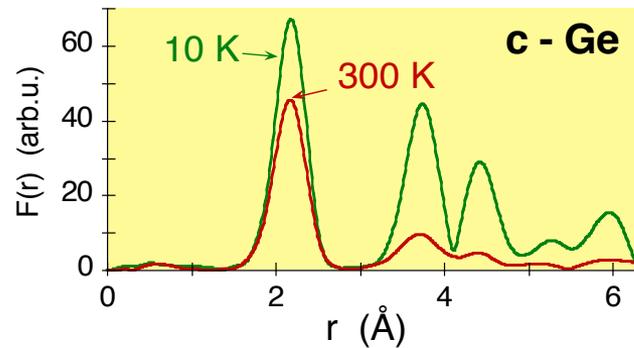


# EXAFS data analysis

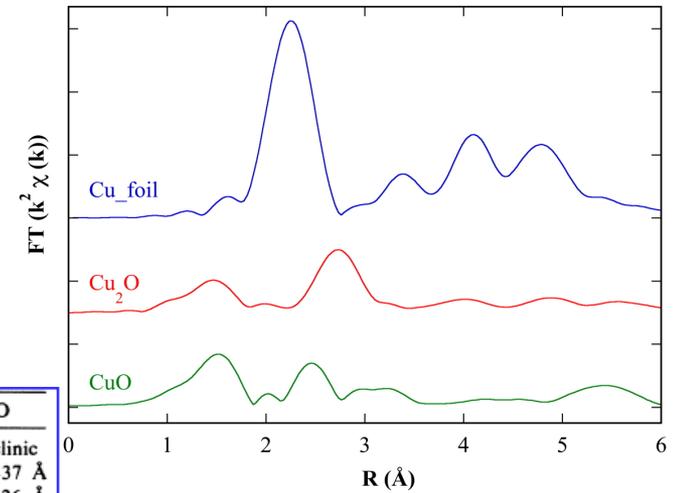
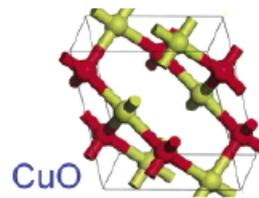
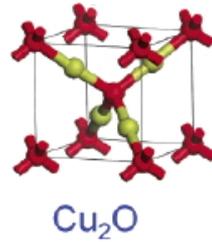
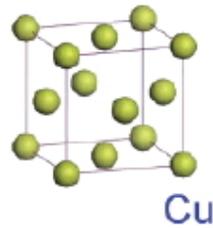
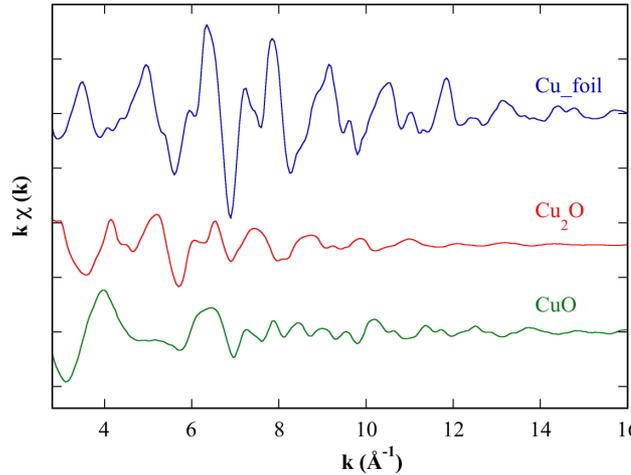
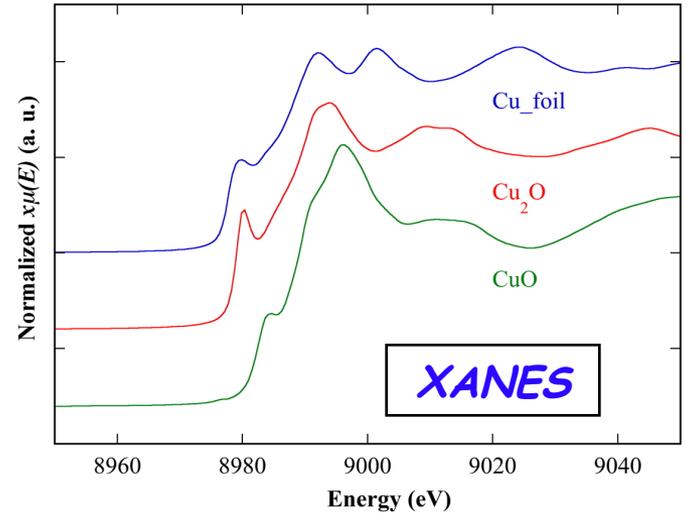
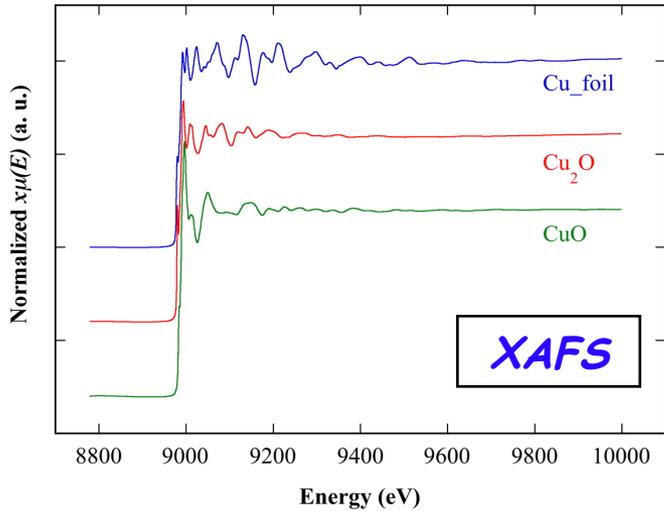
*EXAFS signals*



*Fourier transforms*



# Cu      Cu<sub>2</sub>O      CuO

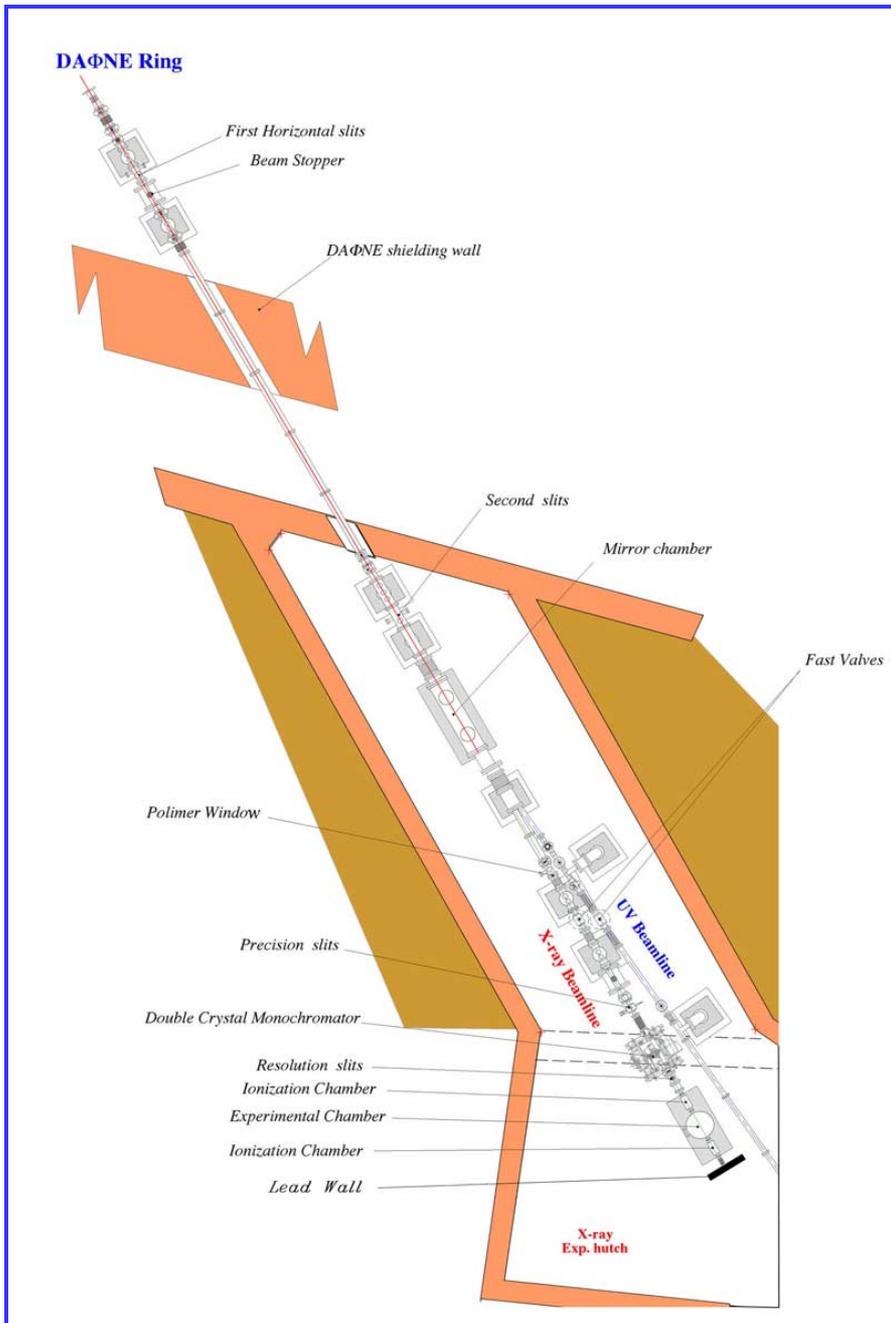


**Cu metal FCC  $a = 3.61 \text{ \AA}$**

	Cu <sub>2</sub> O	CuO
Lattice parameter	Cubic $a = 4.27 \text{ \AA}$	Monoclinic $a = 4.6837 \text{ \AA}$ $b = 3.4226 \text{ \AA}$ $c = 5.1288 \text{ \AA}$ $\beta = 99.54^\circ$
Shortest distances		
$d_{\text{Cu-O}}$	1.84 $\text{ \AA}$	1.95 $\text{ \AA}$
$d_{\text{O-O}}$	3.68 $\text{ \AA}$	2.62 $\text{ \AA}$
$d_{\text{Cu-Cu}}$	3.02 $\text{ \AA}$	2.90 $\text{ \AA}$

***DXR1 XAFS beamline***

# DAΦNE Soft X-ray DXR1 Beamline

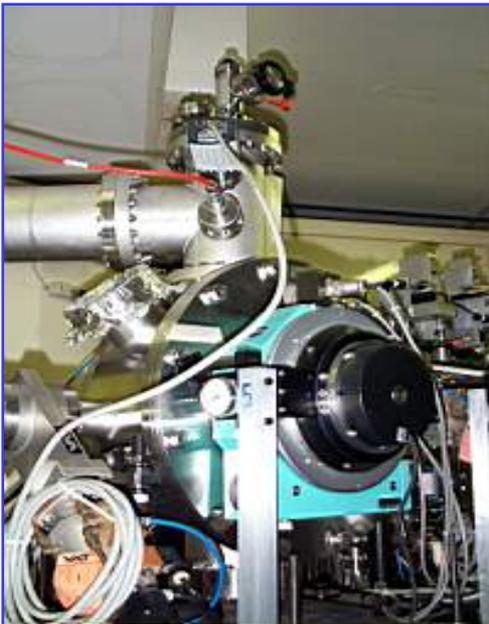


- Wiggler soft x-ray beam line
- Critical energy  $E_c = 284$  eV
- Working range 0.9 - 3.0 keV
- TOYAMA double crystal monochromator with KTP (011), Ge (111), Si (111), InSb (111) and Beryl (10-10) crystals
- Soft X-ray absorption spectroscopy and tests of Soft x-ray optics and detectors.

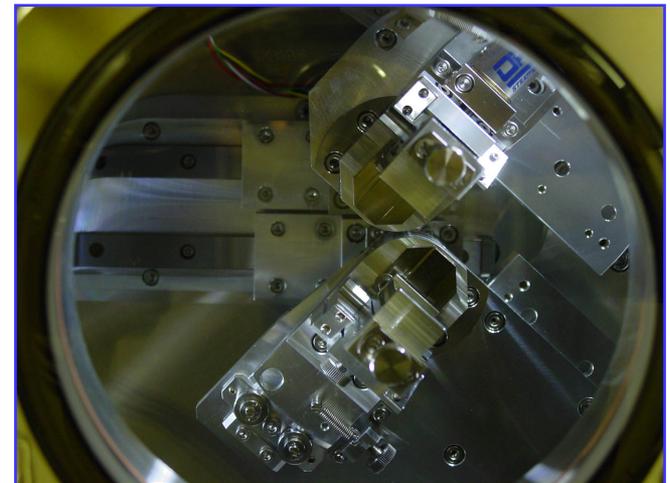
# DXR1 Beamline

*As a function of the energy range to be used each beamline must be optimized for a particular field of research.*

*The front end isolates the beamline vacuum from the storage ring vacuum; defines the angular acceptance of the synchrotron radiation via an aperture; blocks (beam shutter) when required, the x-ray and Bremsstrahlung radiation during access to the other hutches.*



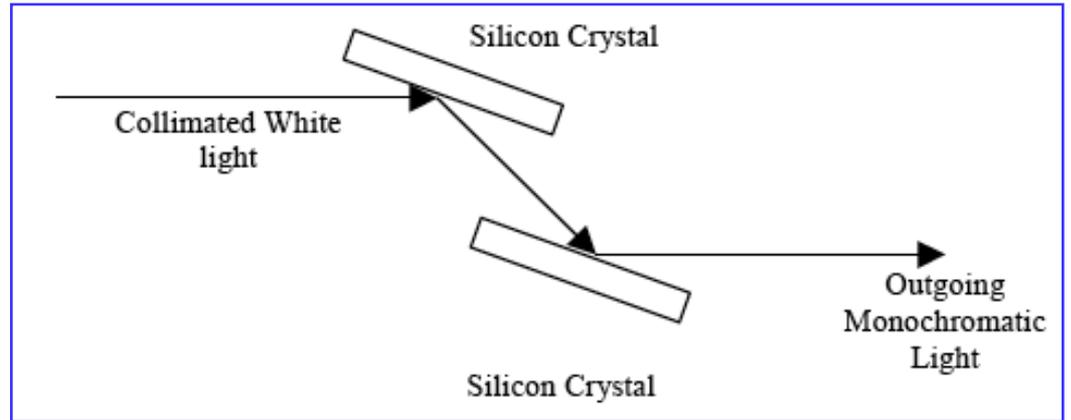
*Monochromator*



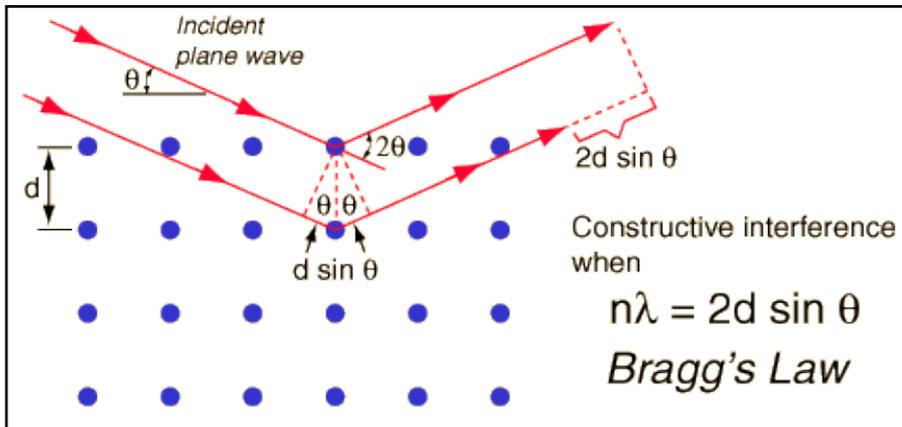
# Monochromator



*Prism and visible light*



*X-rays and crystals*



Crystal type	2d spacing (Å)	Energy range (eV)	Absorption edges
Beryl (10-10)	15.954	1000 - 1560	Na K, Mg K, Cu L
KTP (011)	10.950	1200 - 2200	Mg K, Al K
InSb (111)	7.481	1800 - 3100	Si K, P K, S K, Cl K
Ge (111)	6.532	2100 - 3100	P K, S K, Cl K

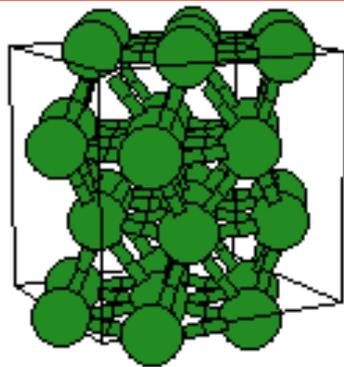
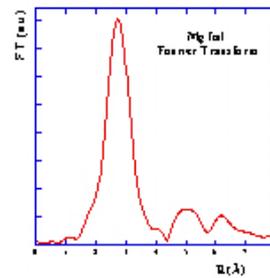
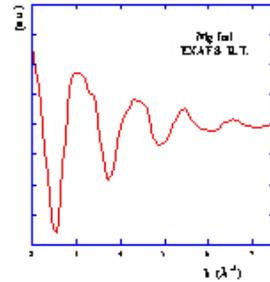
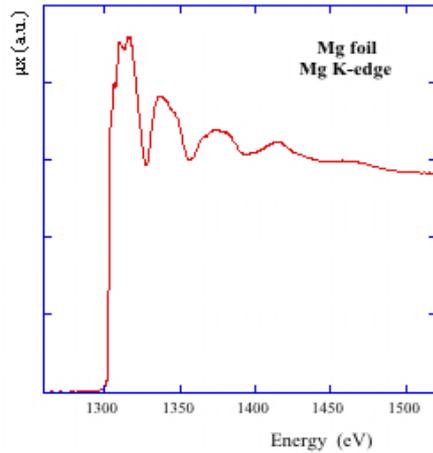
$$n\lambda = 2d \sin \theta \quad \text{Bragg's Law}$$

# Elements that can be investigated

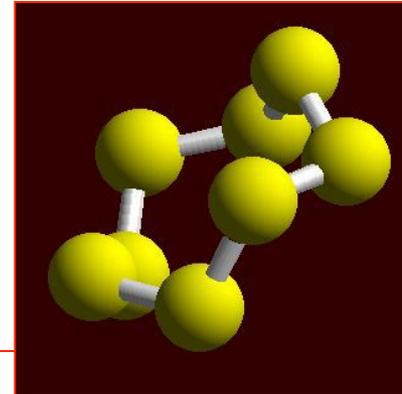
												<b>K - edges</b>										
												<b>L - edges</b>										
												<b>M - edges</b>										
1 H 1.00794													1 H 1.00794	2 He 4.002602								
3 Li 6.941	4 Be 9.012182													5 B 10.811	6 C 12.0107	7 N 14.00674	8 O 15.9994	9 F 18.9984032	10 Ne 20.1797			
11 Na 22.989770	12 Mg 24.3050													13 Al 26.981538	14 Si 28.0855	15 P 30.973761	16 S 32.066	17 Cl 35.4527	18 Ar 39.948			
19 K 39.0983	20 Ca 40.078	21 Sc 44.955910	22 Ti 47.867	23 V 50.9415	24 Cr 51.9961	25 Mn 54.938049	26 Fe 55.845	27 Co 58.933200	28 Ni 58.6934	29 Cu 63.546	30 Zn 65.39	31 Ga 69.723	32 Ge 72.61	33 As 74.92160	34 Se 78.96	35 Br 79.904	36 Kr 83.80					
37 Rb 85.4678	38 Sr 87.62	39 Y 88.90585	40 Zr 91.224	41 Nb 92.90638	42 Mo 95.94	43 Tc (98)	44 Ru 101.07	45 Rh 102.90550	46 Pd 106.42	47 Ag 107.8682	48 Cd 112.411	49 In 114.818	50 Sn 118.710	51 Sb 121.760	52 Te 127.60	53 I 126.90447	54 Xe 131.29					
55 Cs 132.90545	56 Ba 137.327	57 La 138.9055	72 Hf 178.49	73 Ta 180.9470	74 W 183.84	75 Re 186.207	76 Os 190.23	77 Ir 192.217	78 Pt 195.078	79 Au 196.96655	80 Hg 200.59	81 Tl 204.383	82 Pb 207.2	83 Bi 208.98038	84 Po (209)	85 At (210)	86 Rn (222)					
87 Fr (223)	88 Ra (226)	89 Ac (227)	104 Rf (261)	105 Db (262)	106 Sg (263)	107 Bh (262)	108 Hs (265)	109 Mt (266)	110 (269)	111 (272)	112 (277)		114 (289) (287)		116 (289)		118 (293)					

58 Ce 140.116	59 Pr 140.90765	60 Nd 144.24	61 Pm (145)	62 Sm 150.36	63 Eu 151.964	64 Gd 157.25	65 Tb 158.92534	66 Dy 162.50	67 Ho 164.93032	68 Er 167.26	69 Tm 168.93421	70 Yb 173.04	71 Lu 174.967
90 Th 232.0381	91 Pa 231.03588	92 U 238.0289	93 Np (237)	94 Pu (244)	95 Am (243)	96 Cm (247)	97 Bk (247)	98 Cf (251)	99 Es (252)	100 Fm (257)	101 Md (258)	102 No (259)	103 Lr (262)

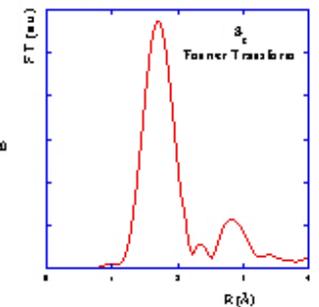
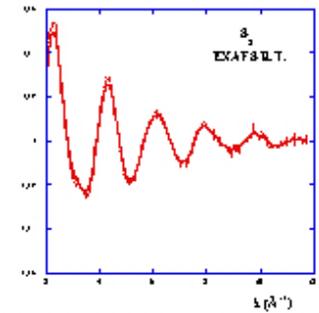
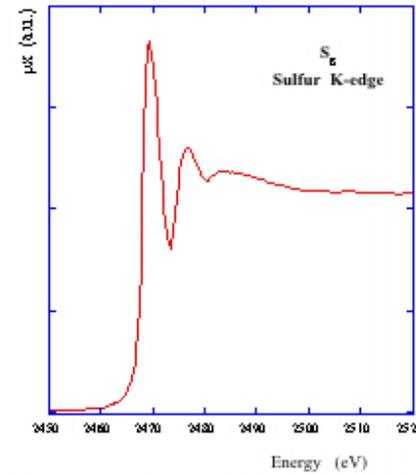
# ***DXR1 EXAFS examples***



***Mg hcp crystal structure***



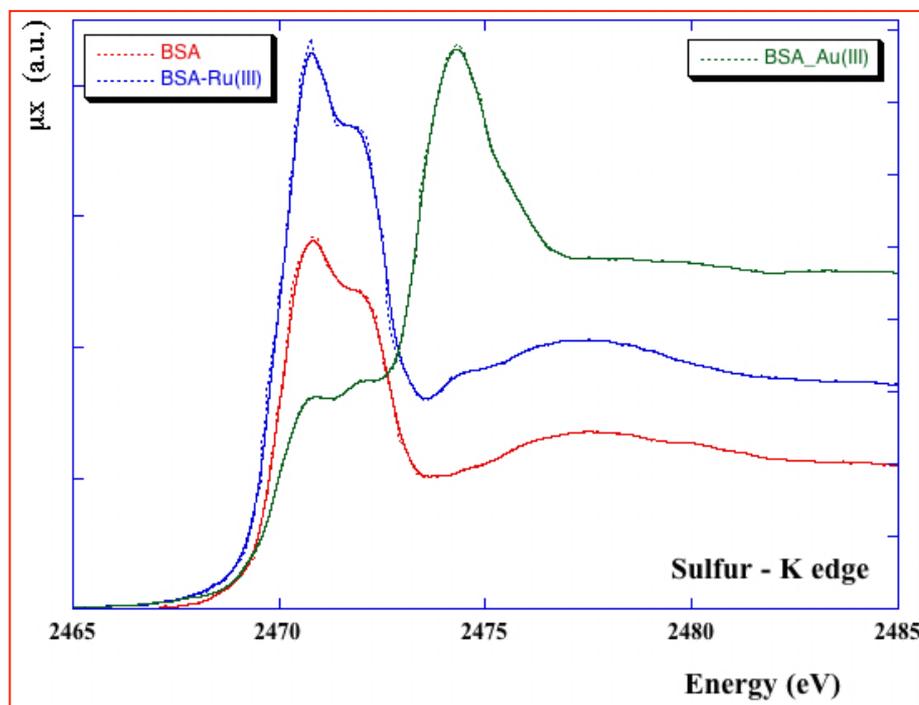
***S<sub>8</sub>***



# X-ray absorption studies of adducts of gold and ruthenium anticancer metallo-drugs with a serum protein

Due to the *clinical success of platinum-based anticancer drugs*, much attention has been focused on similar metal complexes of potential use in cancer treatment.

Specifically, a *great attention has been given to ruthenium and gold complexes that seem to be very promising*. The mechanisms through which the metal complexes produce their biological and pharmacological effects are still largely unexplored and it seems that *gold and ruthenium complexes act on different targets, most likely on protein targets*.



Measurements have been performed at the Sulfur K- edge on **Bovine Serum Albumin (BSA)** proteins which have interacted with ruthenium(III) and gold(III) metallo-drugs.

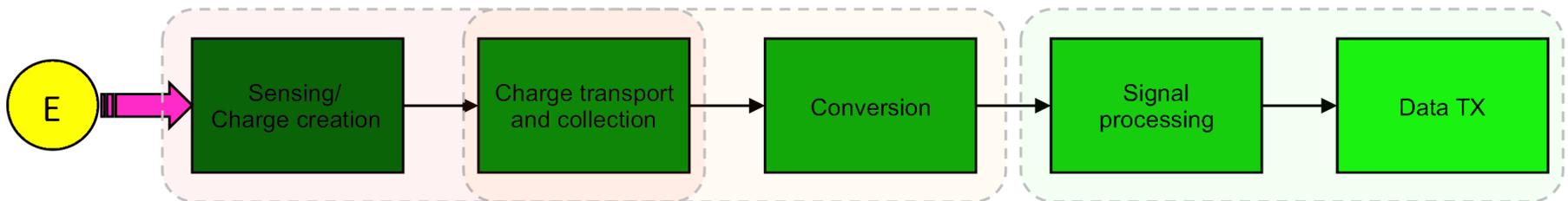
# *X-ray detectors*

## *Ionization chambers and SDD*

# *X-ray detectors and basic principles*

*An X-ray detector is used to convert the energy released by an X-ray photon in the detector material into an electric signal.*

*The readout and processing of this electric signal by means of a suitable electronics chain can be used to achieve different information including for specific detectors the energy released by the photon and the arrival time of the event.*



# *Signal generation and transfer of energy*

- *Detection principles mostly used in SR detectors can be direct or not. Direct detection mode using gas or semiconductors*
- *Using gases: electron ion pairs are produced*
- *Using semiconductors: electron hole pairs are produced*
- *Pair creation energy in semiconductors is much lower than ionization energy in gases (Si 3.6 eV; Argon gas 26 eV)*
- *High density of solids implies high interaction probability*
- *The detector to choose depends on the information needed and provided by the detection system*

# *X ray detectors taken into account*

## ***Ionization chambers***

Current (= flux)  
operation mode

Sum the charge generated from stopped X-rays and subsequently digitize it.

## ***SDD***

Energy dispersive  
operation mode

Charge pulses production whose height is directly proportional to the energy of the incident X-ray

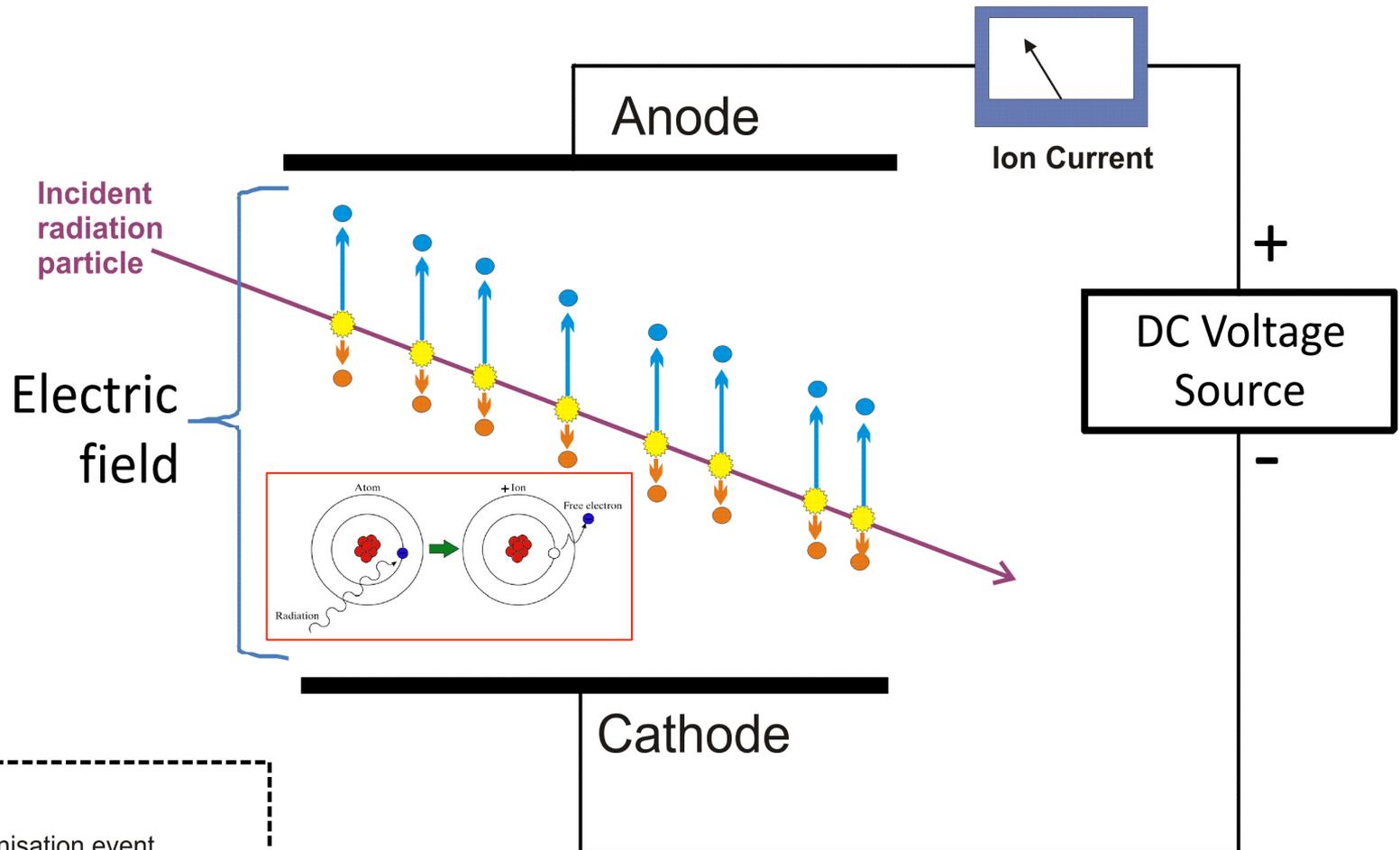
***Detector chosen as a function of the required information.***

### ***General properties:***

- ***Quantum detection efficiency:*** fraction of photons emitted by the source that interact with the detector and are completely absorbed.
- ***Count rate***
- ***Noise***
- ***Energy resolution***

# *Gas ionization chambers*

# Visualisation of ion chamber operation



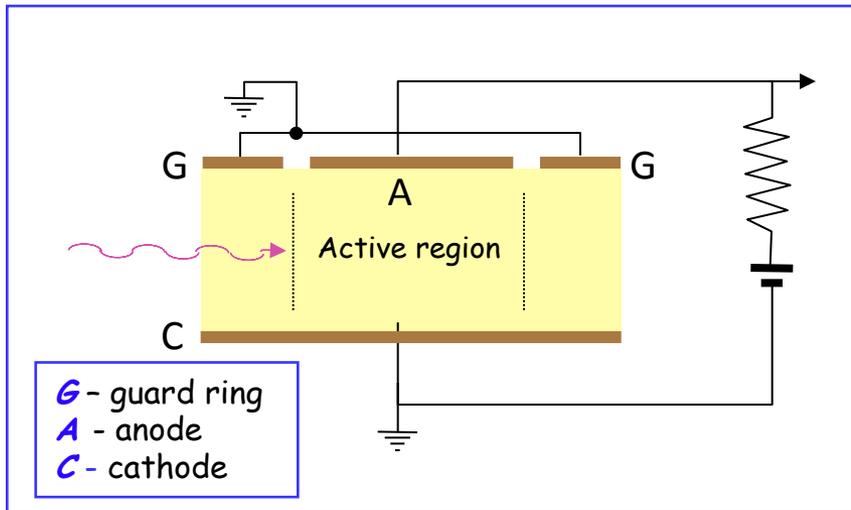
## Key

- Ionisation event
- Electron
- +Ve ion

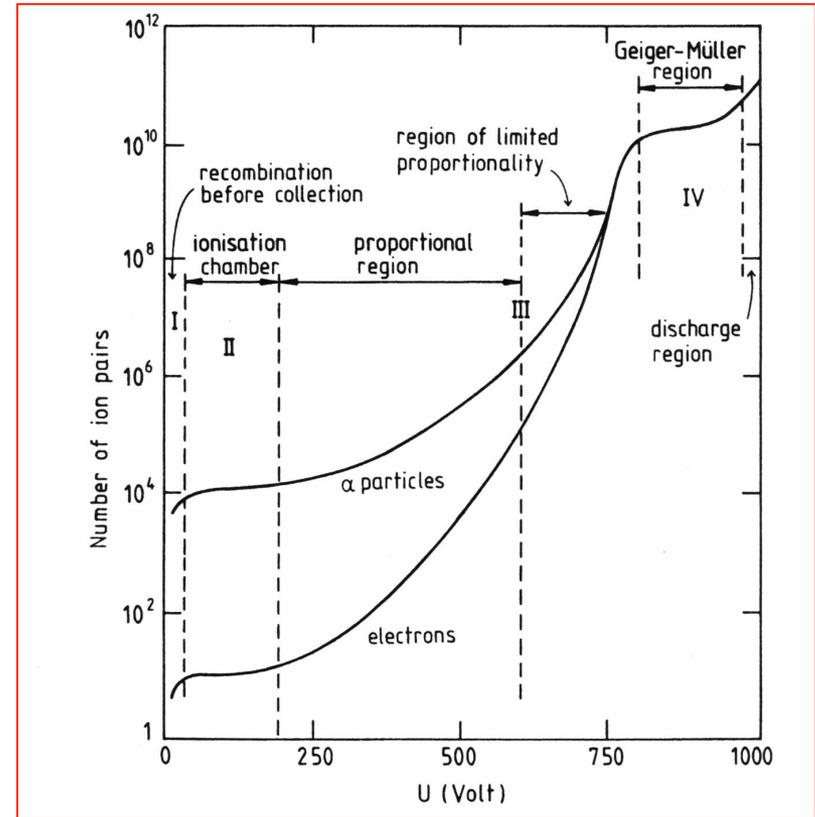
*Schematic diagram of parallel plate ion chamber, showing drift of ions. Electrons typically drift 1000 times faster than positive ions due to their much smaller mass.*

*Credit: Wikipedia - Dougsim*

# X-ray Ion Chamber

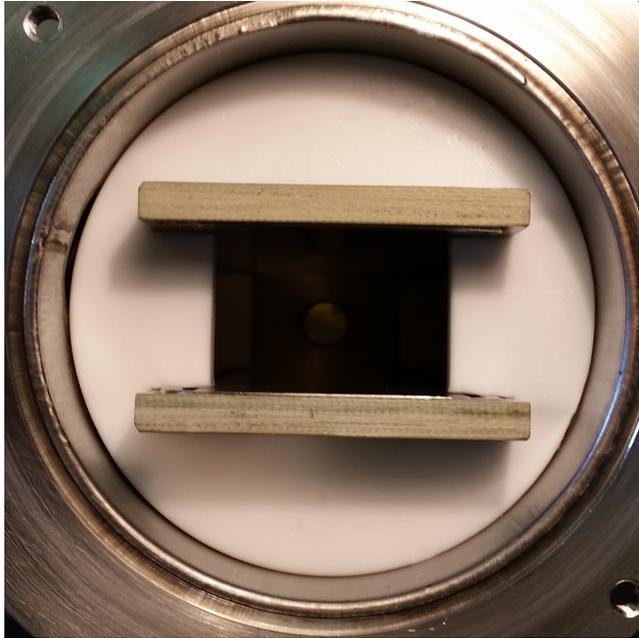


Gas ionization detectors are commonly used as integrating detectors to measure beam flux rather than individual photons. A typical detector consists of a rectangular gas cell with thin entrance and exit windows.

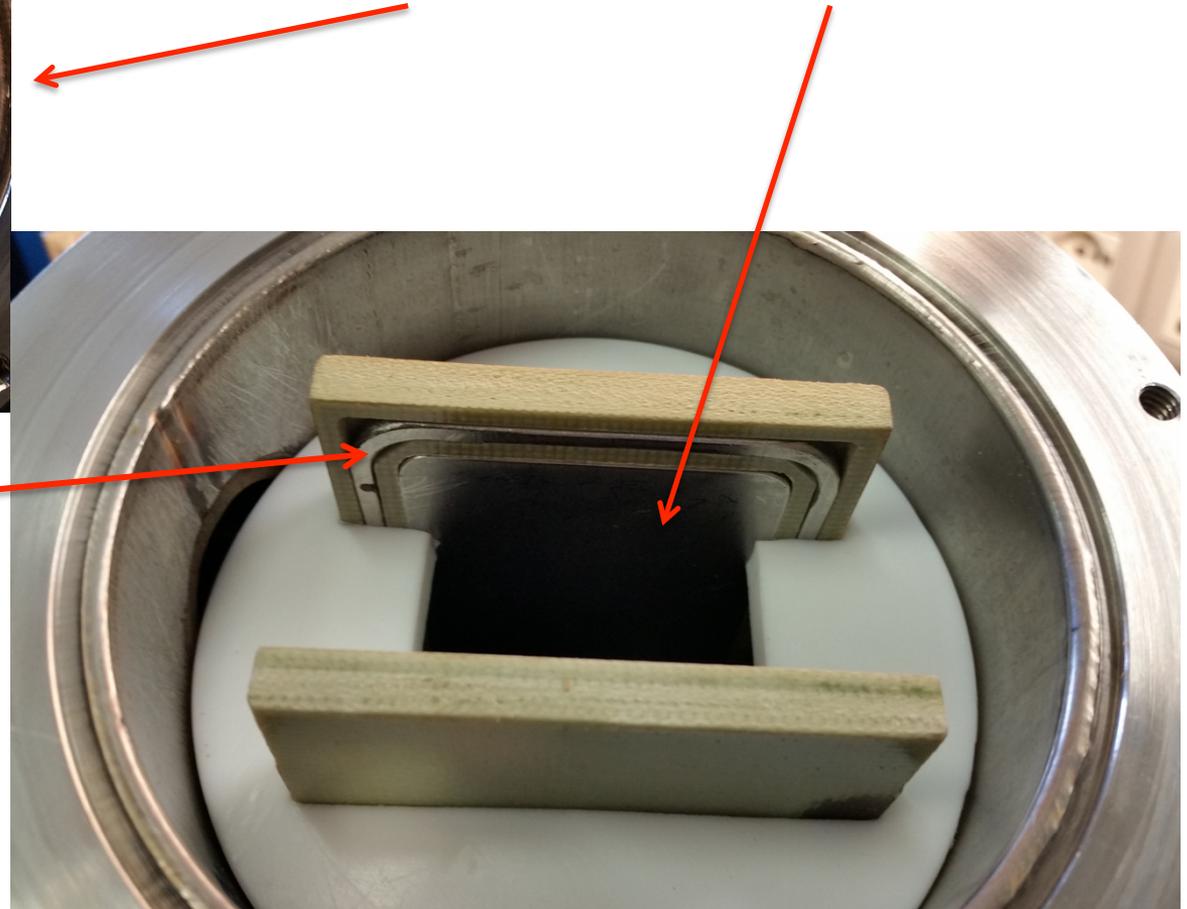


Inside the detector, an electric field is applied across two parallel plates. Some of the x-rays in the beam interact with the chamber gas to produce fast photoelectrons, Auger electrons, and/or fluorescence photons. The energetic electrons produce additional electron-ion pairs by inelastic collisions, and the photons either escape or are photo-electrically absorbed. The electrons and ions are collected at the plates, and the current is measured with a low-noise current amplifier. The efficiency of the detector can be calculated from the active length of the chamber, the properties of the gas, and the x-ray absorption cross section at the appropriate photon energy.

# X-ray Ion chamber



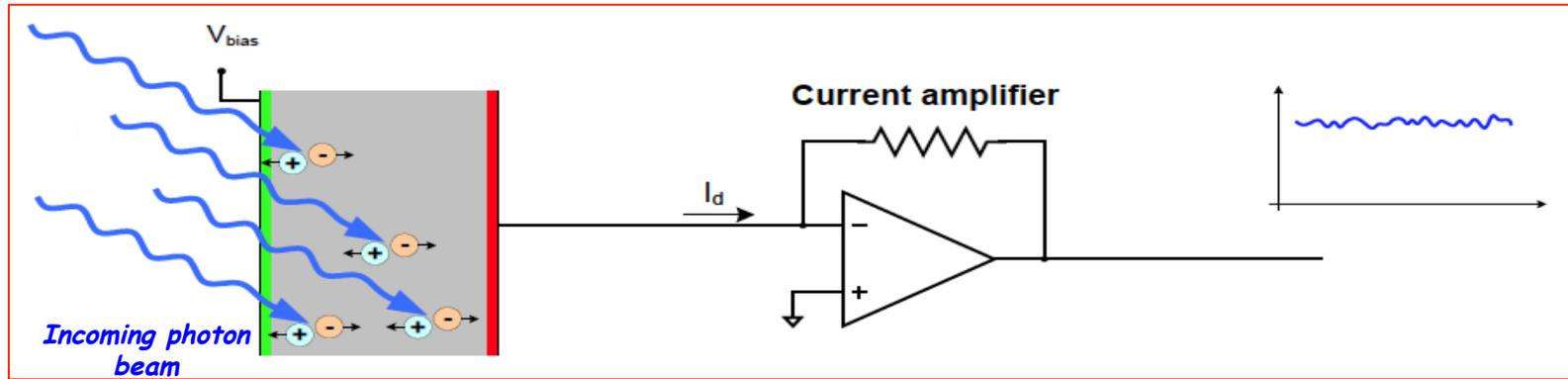
*Ion chamber with parallel plates.*



*Guard ring*

*In the parallel plate chamber the charge-collecting electrode is surrounded by an annular ring. The annular ring represents the guard ring (or guard electrode) and is separated from the collecting electrode by a narrow insulating gap, and the applied voltage to the guard ring is the same as that to the collecting electrode.*

# Direct detection: charge conversion scheme and intensity measurement



The measured intensity is usually integrated during a well defined time interval and is proportional to the number of incident X-ray photons ( $N_{ph}$ ).

Intrinsic statistical noise (Poisson statistics):

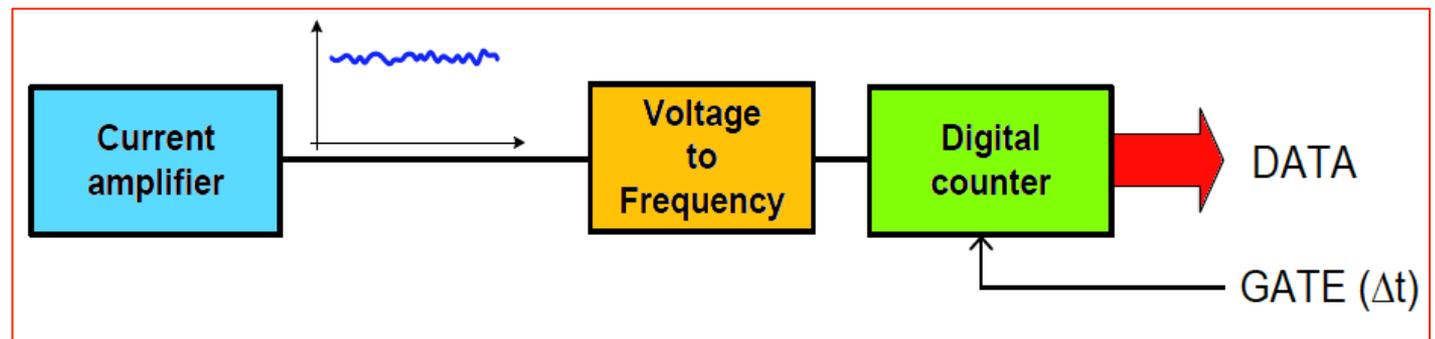
$$\sigma_{N_{ph}} = \sqrt{N_{ph}}$$

Effective:

$$\sigma_{N_{ph}} = \sqrt{FN_{ph}}$$

Fano factor  $F$  accounts empirically for deviation from Poisson statistics  $F \approx 0.2$  for gasses,  $\approx 0.1$  for semiconductors

The measured intensity is integrated during the exposure time  $\Delta t$ .

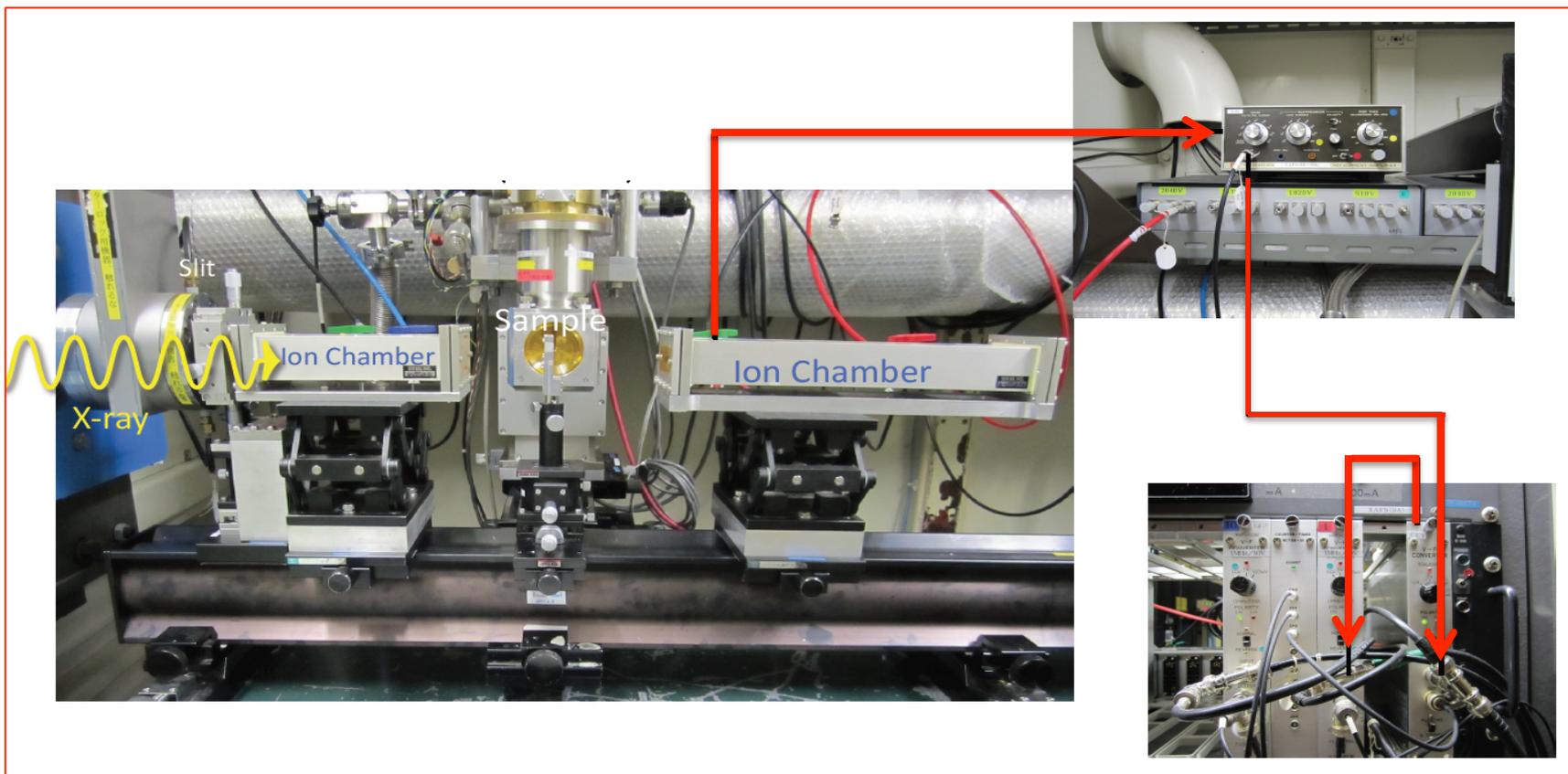


# Setup: XAFS in transmission mode

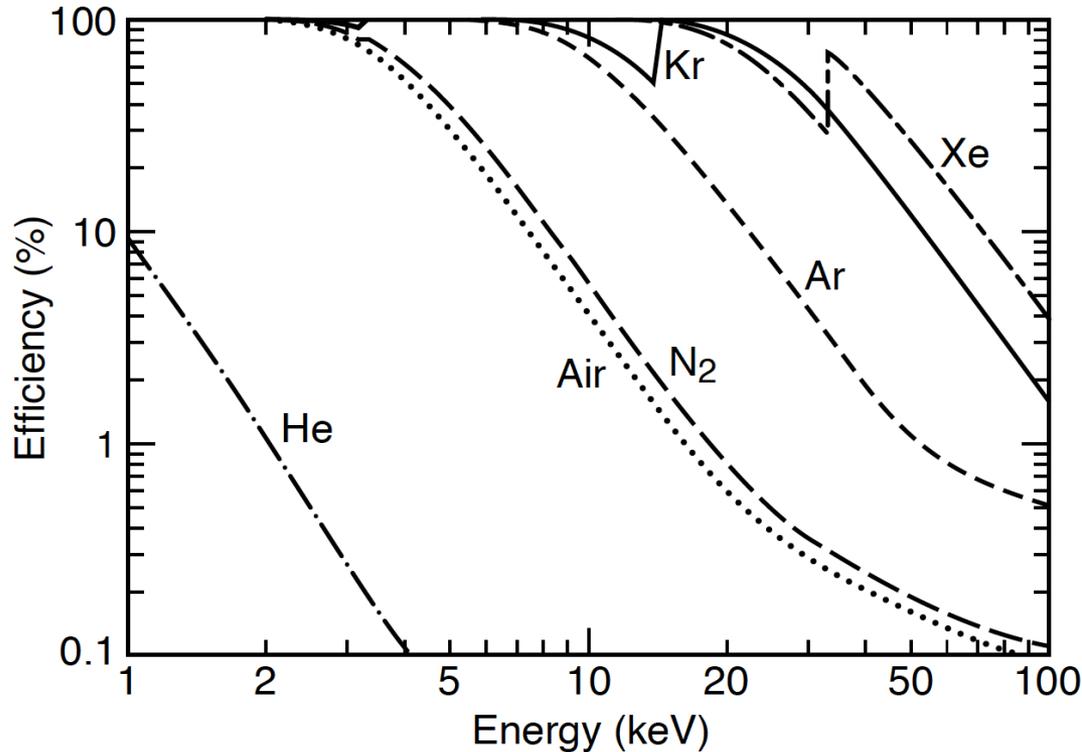
$$\mu(E)x = \ln\left(\frac{I_0}{I_1}\right)$$

Current proportional to the x-ray intensity

Current amplifier and converter of I to V



# ***Ion chamber characteristics***



*Efficiency of a 10-cm-long gas ionization chamber as a function of energy, for different gases at normal pressure.*

*The efficiency of the detector can be calculated from the active length of the chamber, the properties of the chamber gas, and the x-ray absorption cross section at the appropriate photon energy*

*Once the efficiency is known, the photon flux can be estimated from chamber current and the average energy required to produce an electron-ion pair*

<b>Element</b>	<b>Energy (eV)</b>
Helium	41
Nitrogen	36
Air	34.4
Neon	36.3
Argon	26
Krypton	24
Xenon	22

# Photon flux evaluation

$$I = Ne = I_0 T \gamma e$$

$$N \cong \frac{E}{\langle V_i \rangle}$$

$N$  = Number of electron-ion pairs produced

$E$  = X ray energy

$\langle V_i \rangle$  = Average energy required to produce an electron-ion pair

$I_0$  = Incoming photon flux (ph/s)

$T$  = Ion chamber window transmission

$\gamma$  = gas efficiency (electrons/ph)

$L$  = length of the ion chamber plate

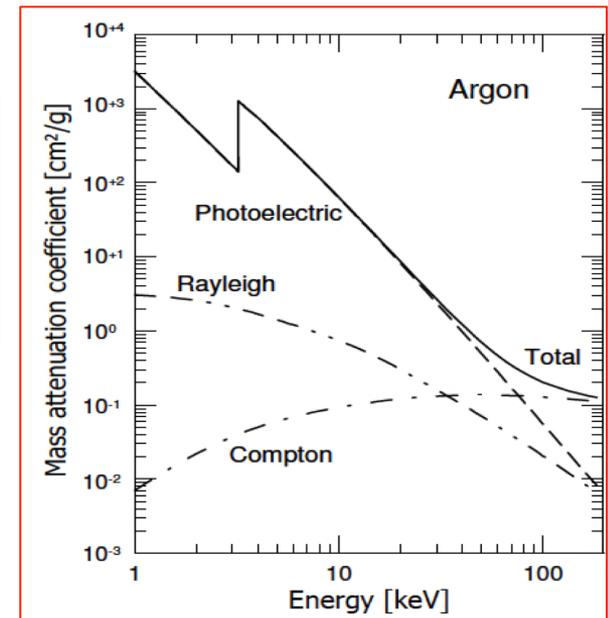
$$I_0 (\text{ph} / \text{s}) = \frac{I(A)}{\gamma e(C)} \frac{\langle V_i \rangle (eV)}{E(eV)} \frac{1}{1 - e^{-\mu L(\text{cm})}}$$

$$\mu(\text{cm}^{-1}) = \left[ \frac{\mu}{\rho}(E) \right] \rho$$

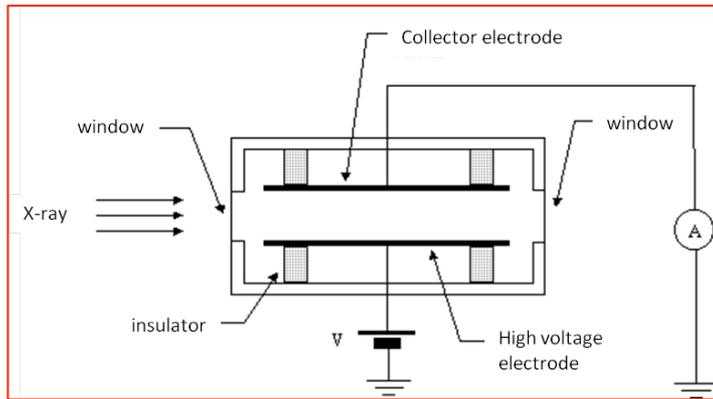
$\left[ \frac{\mu}{\rho} \right]$  = gas mass attenuation coefficient

$\rho$  = gas density function of pressure ( $\gamma$ )

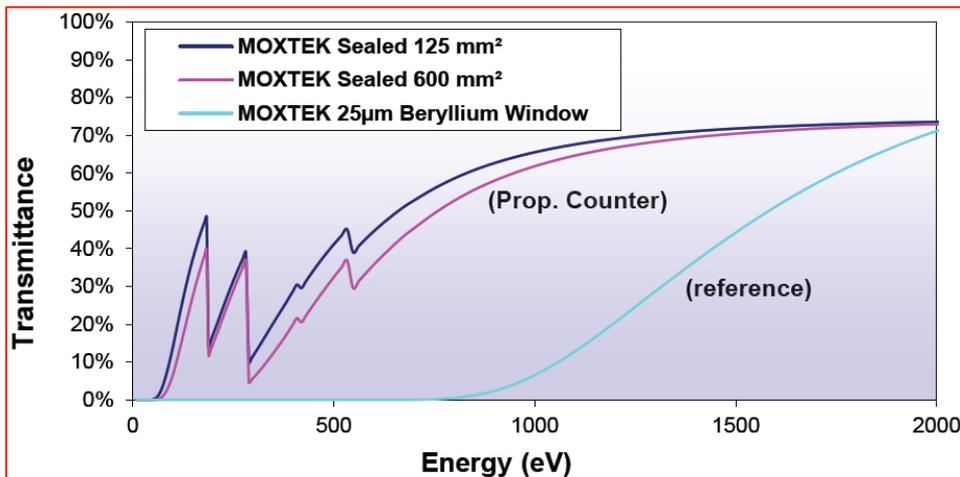
$\gamma = I_0$  10%;  $I_1$  90%



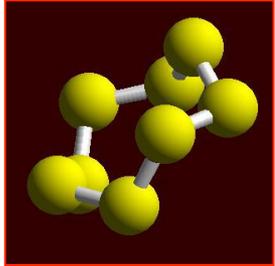
# X-ray ion chambers and windows



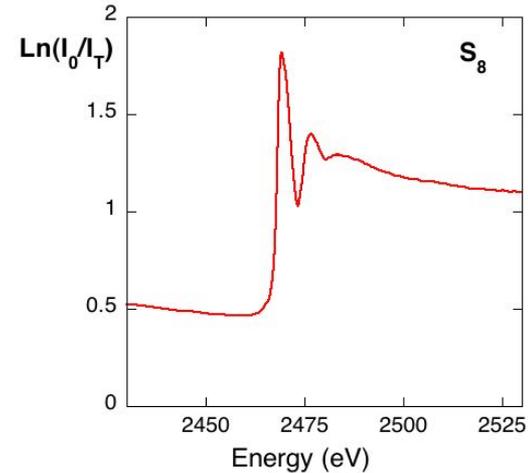
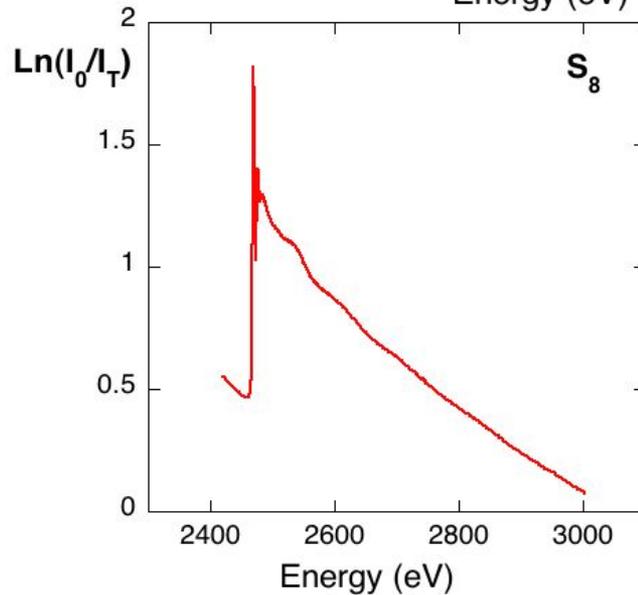
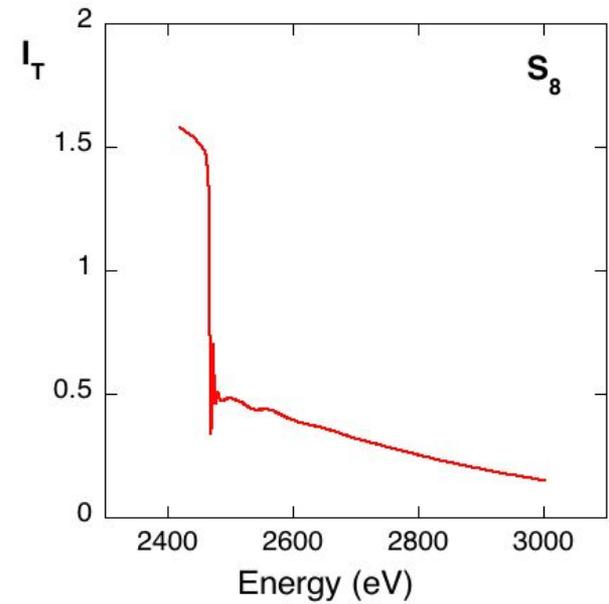
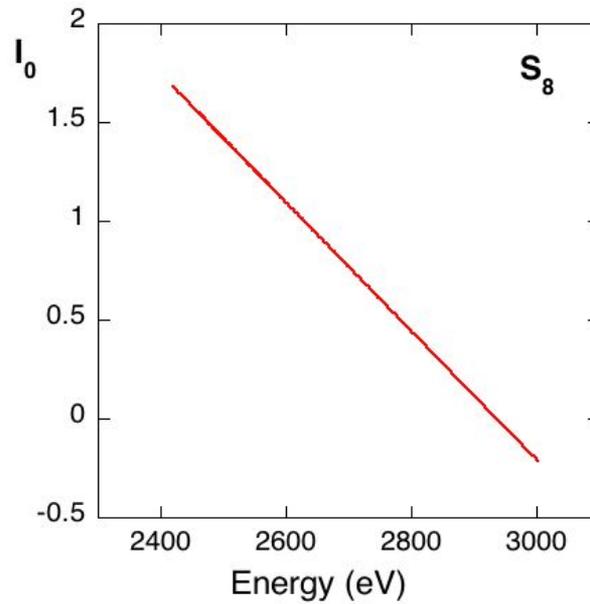
Unmounted and mounted MOXTEK ultrathin windows



# XAFS $S_8$



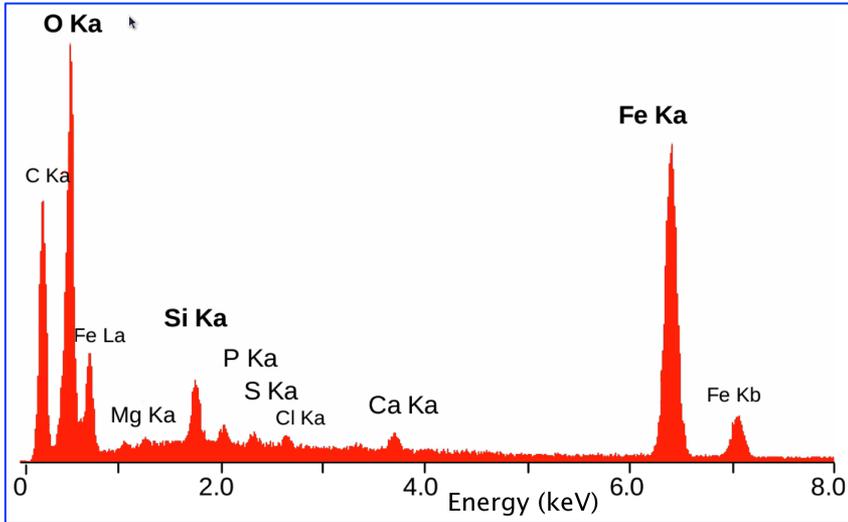
$S_8$



***SDD***

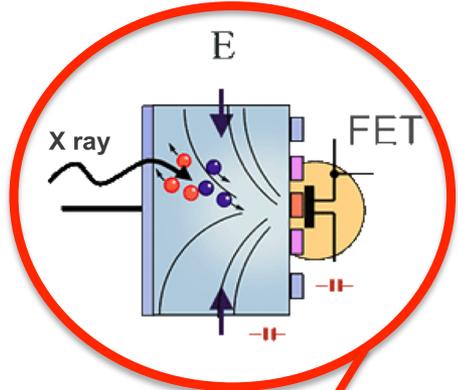
***Silicon Drift Detectors  
or Energy dispersive detectors***

# XRF and energy dispersive SDD



A typical XRF spectrum obtained on mineral particles used to characterize the elemental composition of the sample and to perform this kind of measurements an energy dispersive detector is needed.

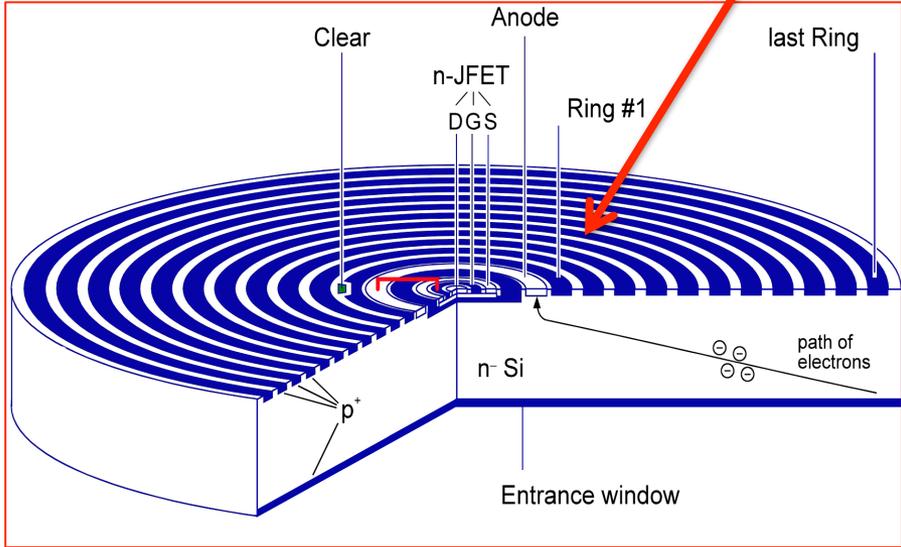
$$\mu(E)x = \left( \frac{I_F}{I_0} \right)$$



Schematic view of a SDD detector.

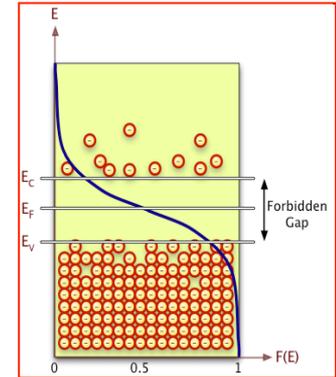
The latest generation of SDD detectors offers: all the advantages of being liquid nitrogen-free, an excellent energy resolution at high count rates and also large active areas.

E. Gatti and P. Rehak, Semiconductor drift chamber-an application of a novel charge transport scheme, Nucl. Instr. and Meth. A225 (1984) 608



# Energy Dispersive detectors

*Silicon and germanium detectors can make excellent energy-resolving detectors. When a photon interacts in the intrinsic region, tracks of electron-hole pairs are produced (analogous to electron- positive ion pairs in a counting gas). In the presence of the electric field, these pairs separate and rapidly drift to the detector contacts. The average energy required to generate an electron-hole pair is **3.6 eV for silicon** and **2.98 eV for germanium**.*



*Electrons move to the conduction band of the silicon semiconductor and leave behind holes that behave like free positive charges within the sensor.*

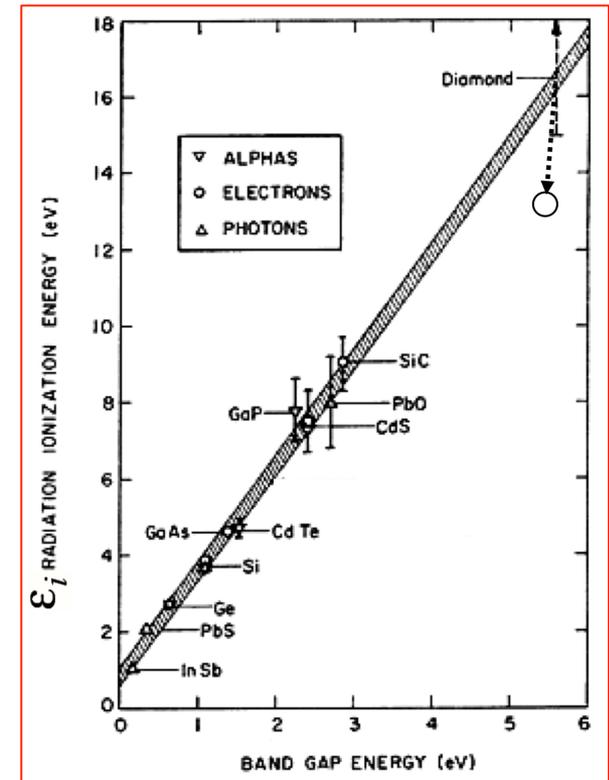
*Lower band gap materials can offer better resolution due to better ( $\Delta E \sim \epsilon_j$ ) but must be cooled to limit noise from thermal generation of carriers.*

*Absorbed radiation energy E is shared between crystal lattice excitations ( $\sim 2/3$ ) and generation of charge carriers ( $\sim 1/3$ ) this ratio is  $\sim$  same for many semiconductor materials*

*The ED detector converts the energy of each individual X-ray into a voltage signal of proportional size. This is achieved through a three stage process:*

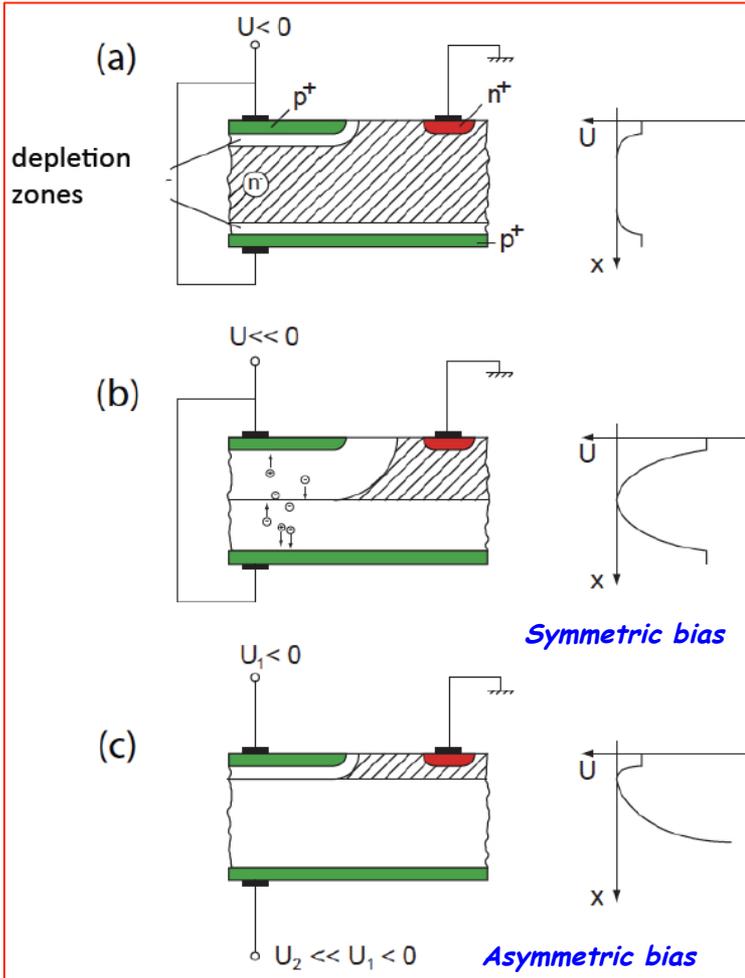
- **First** - the X-ray is converted into a charge by the ionization of atoms in the semiconductor crystal.
- **Second** - this charge is converted into the voltage signal by the FET preamplifier.
- **Finally** - the voltage signal enters the pulse processor for measurement.

*The output from the preamplifier is a voltage 'ramp' where each X-ray appears as a voltage step on the ramp. At the same time electronic noise must be minimized to allow detection of the lowest X-ray energies.*



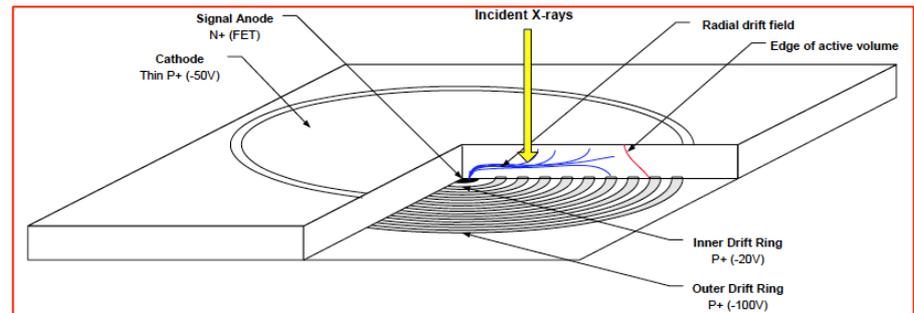
# SDD working principle

## Sideward depletion



With respect to a conventional p-n diode detector, where the ohmic n+ contact extends over the full area on one wafer side, the **depletion of the bulk can be also achieved by positively biasing a small n+ electrode with respect to p+ electrodes covering both sides of the wafer.** When the n+ voltage is high enough, the two space charge regions separated by the undepleted bulk touch each other, leading to a small undepleted bulk region only close to the n+ electrode.

In the **Silicon Drift Detector**, based on the principle of the **sideward depletion**, an **additional electric field parallel to the surface of the wafer is added** in order to **force the electrons in the energy potential minimum to drift towards to the n+ anode.**



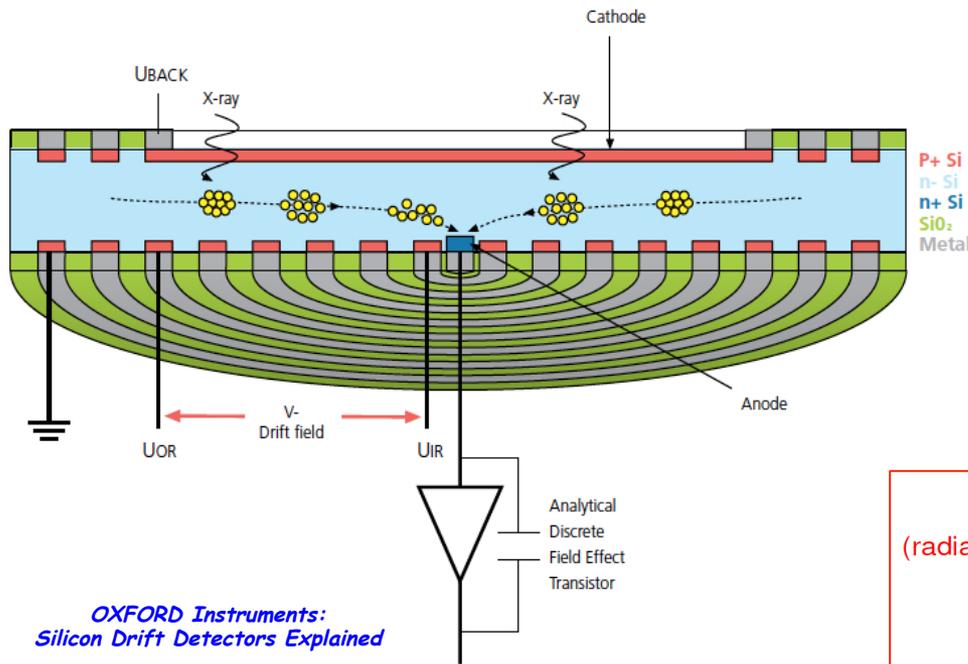
# SDD

The silicon drift detector (SDD) sensor is produced using high purity silicon with a large contact area on the side facing the incoming X-rays.

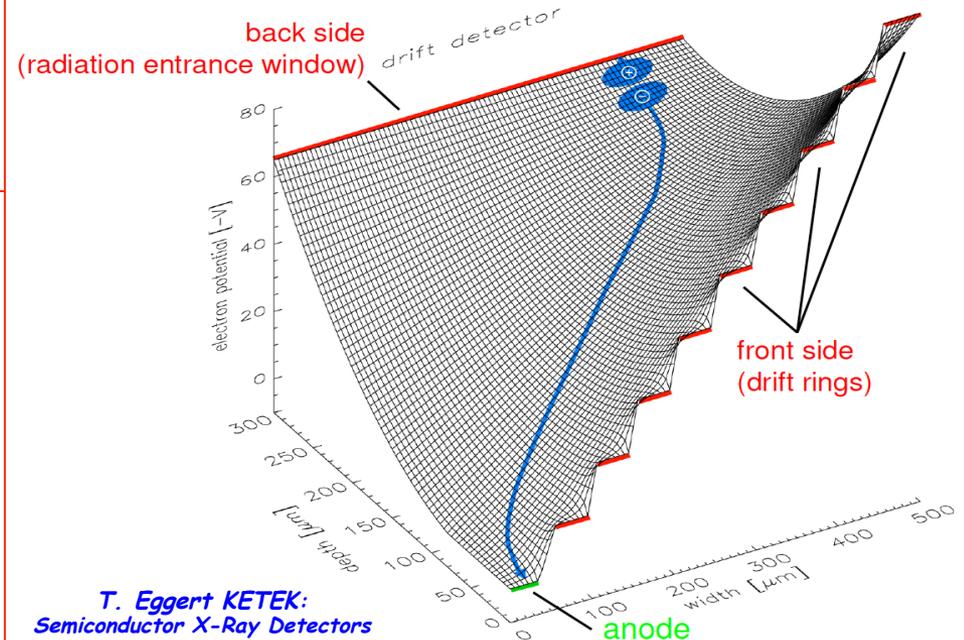
On the opposite side there is a central, small anode contact, which is surrounded by a number of concentric drift electrodes.

The major distinguishing feature of an SDD is the transversal field generated by a series of ring electrodes that causes charge carriers to 'drift' to a small collection electrode. (Anode)

The 'drift' concept of the SDD allows for significantly higher count rates.



OXFORD Instruments:  
Silicon Drift Detectors Explained



T. Eggert KETEK:  
Semiconductor X-Ray Detectors

# SDD

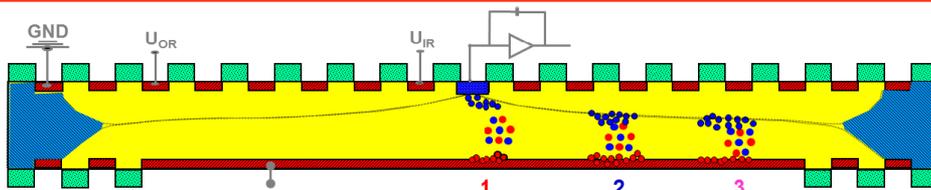
The electrons are 'drifted' down a field gradient applied between the drift rings to be collected at the anode.

The charge that accumulates at the anode is converted to a voltage signal by the FET preamplifier.

During operation, charge is built up on the feedback capacitor. There are two sources of this charge, current leakage from the sensor material and the X-ray induced charge from the photons that are absorbed in the detector.

The output from the preamplifier caused by this charge build-up is a steadily increasing voltage 'ramp' due to leakage current, onto which are superimposed sharp steps due to the charge created by each X-ray event. The accumulating charge has to be periodically restored to prevent saturation of the preamplifier. Therefore at a pre-determined charge level the capacitor is discharged, a process called restoration, or 'reset'.

The fundamental job of the pulse processor is to accurately measure the energy of the incoming X-ray, and give it a digital count in the corresponding channel in the computer. It must optimize the removal of noise present on the original X-ray signal and it needs to recognize quickly and accurately a wide range of energies of X-ray events from below 100 eV up to 40 keV. It also needs to differentiate between events arriving in the detector very close together in time to prevent pulse pile-up effects.

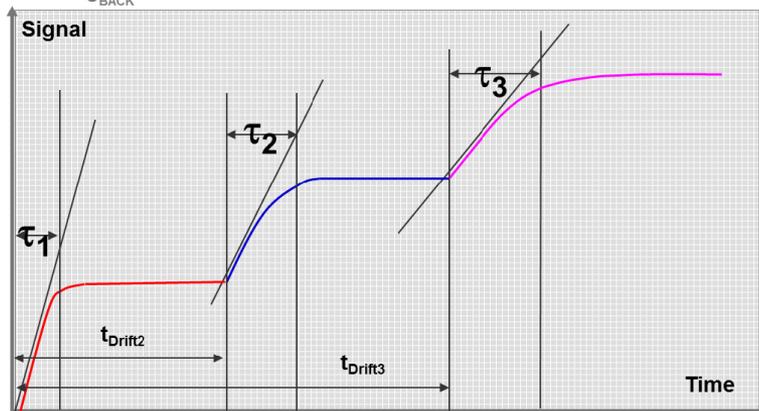


Charge collection:

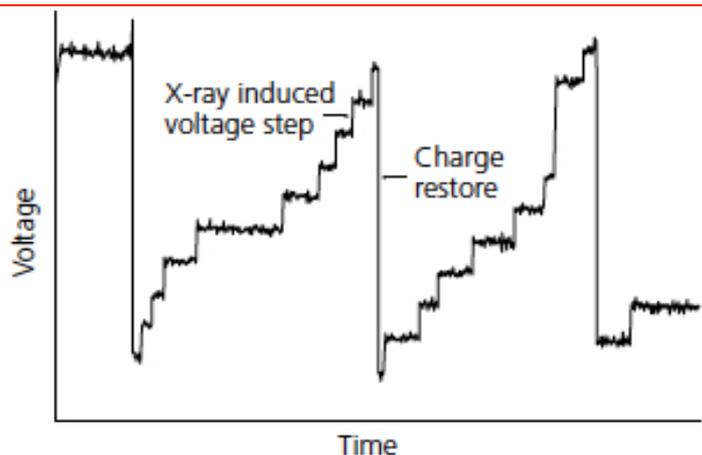
Event 1 signal 1

Event 2 signal 2

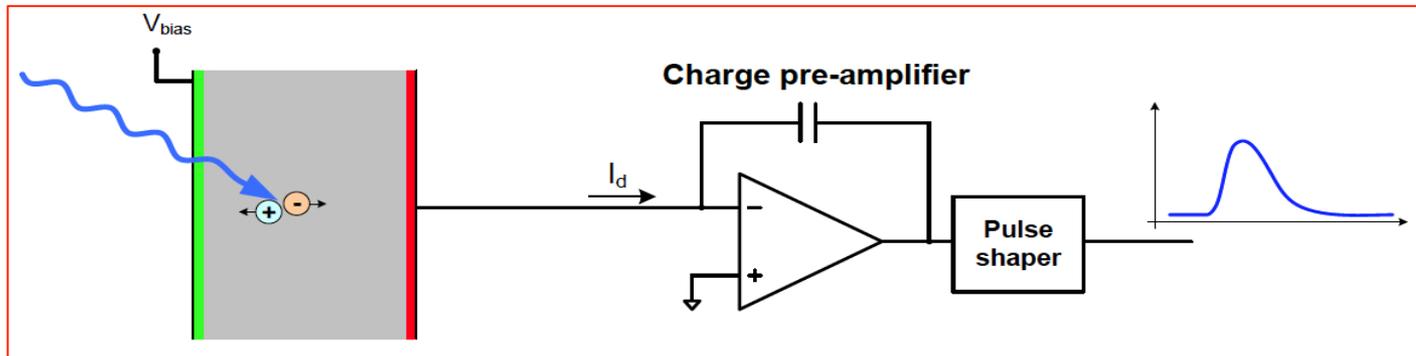
Event 3 signal 3



KETEK - High Throughput Large Area Silicon Drift Detectors

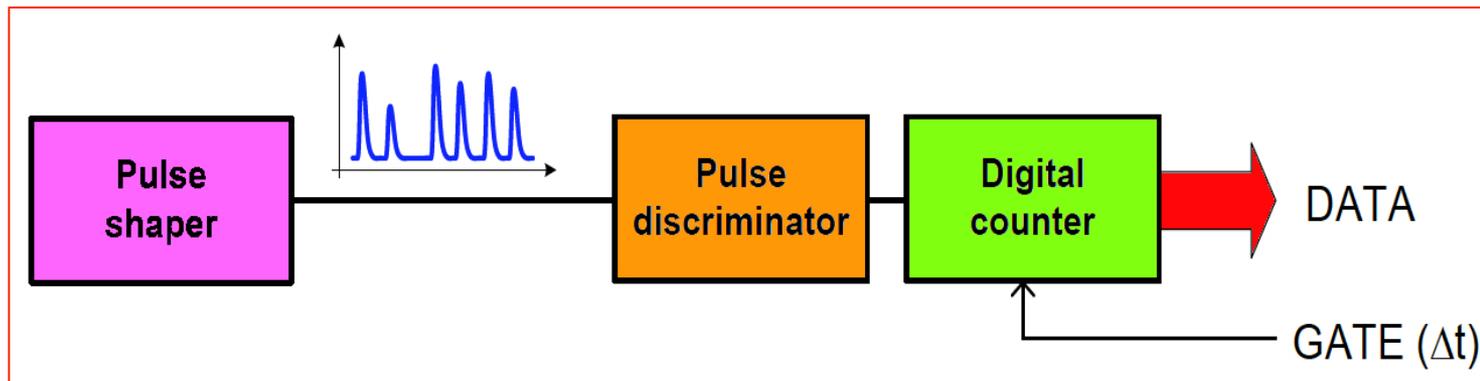


# Direct detection: charge conversion scheme and measurement



*Photon by photon processing and evaluation of the photon energy by measuring the charge generated in the sensor*

*Pulse discriminator: from simple level discrimination to complex pulse-height analysis (pileup rejection)*



# SDD energy resolution

The number of generated charge carriers by a single X ray photon,  $N_Q$ , can be estimated as:

where the ionization energy,  $\varepsilon_i$ , is the average energy required to produce an electron/hole pair. In silicon:  $\varepsilon_i = 3.6$  eV a 10 keV photon produces 2800 e/h pairs.

$$N_Q = \frac{E}{\varepsilon_i}$$

$$\sigma_{N_Q} = \sqrt{FN_Q}$$

Standard deviation that takes into account *deviations from Poisson statistics*.  $F = 0.11$  for Si and  $0.08$  for Ge.

The RMS fluctuation,  $\sigma_E$ , associated to X ray  $\rightarrow$  charge conversion can be estimated by :

$$\sigma_E = \varepsilon_i \sigma_{N_Q} = \sqrt{FE\varepsilon_i}$$

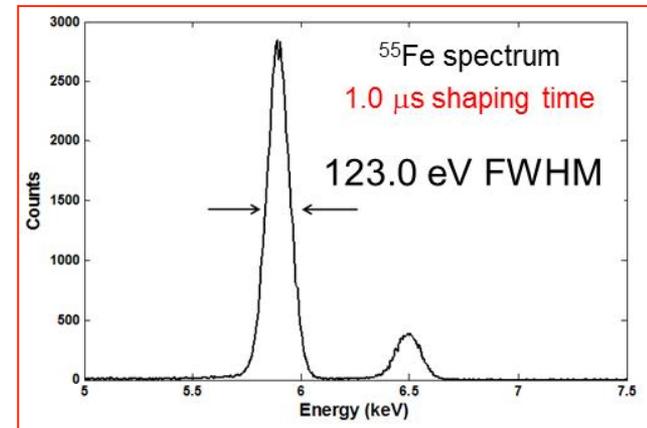
Usually known as *Fano noise*

The *energy resolution* of the detector at a certain energy is usually defined as the *full width at half-maximum (FWHM)* of recorded spectra.

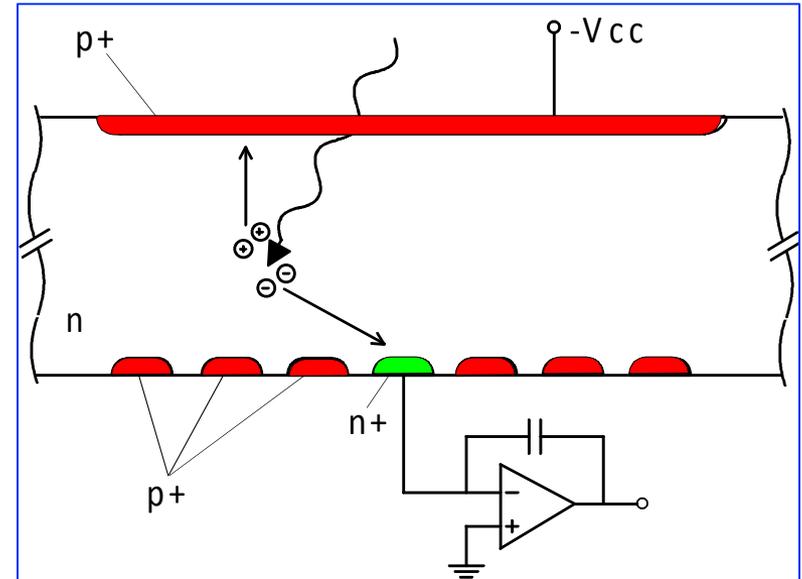
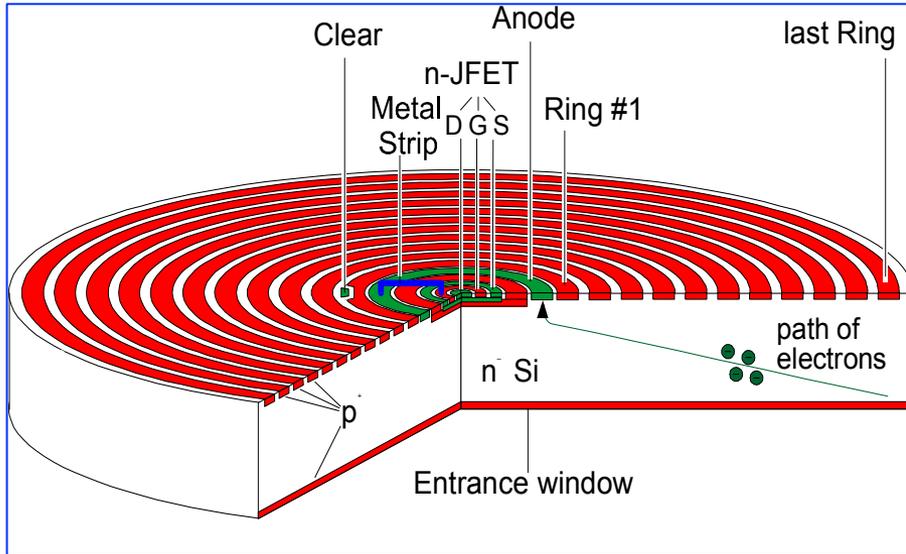
$$FWHM = 2.35\sigma_E$$

The measured spectral resolution is the quadratic-sum of various noise sources present in the detector:

$$Resolution = \sqrt{(Fano)^2 + (sensor - noise)^2 + (readout - noise)^2}$$



# Front-end for SDD



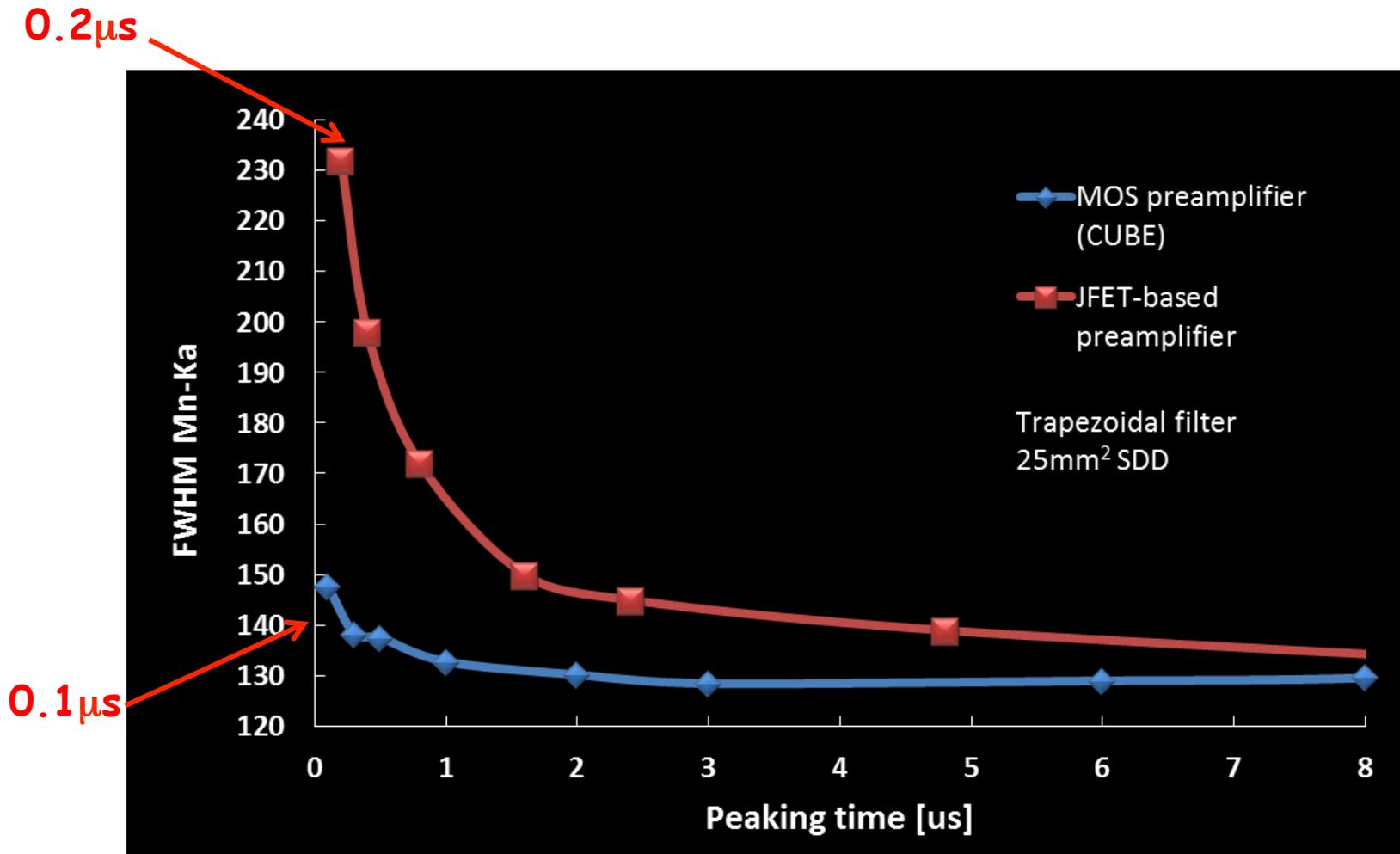
## • JFET integrated on the SDD

- lowest total anode capacitance
- easier interconnection in SDD arrays
- limited JFET performances ( $g_m$ ,  $1/f$ )
- sophisticated SDD+JFET technology

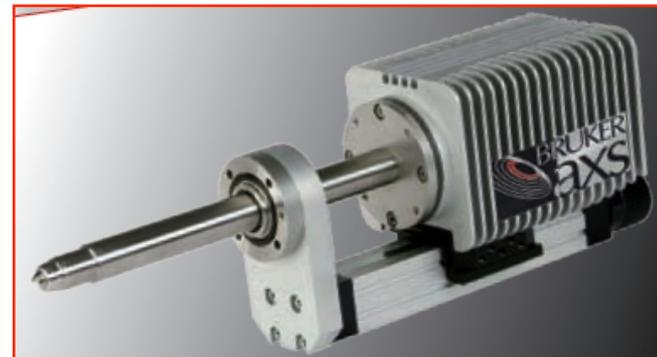
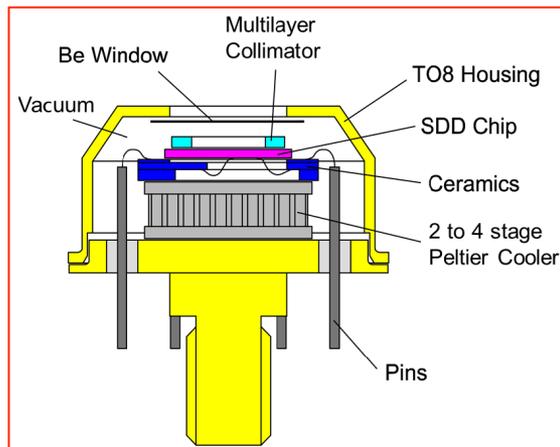
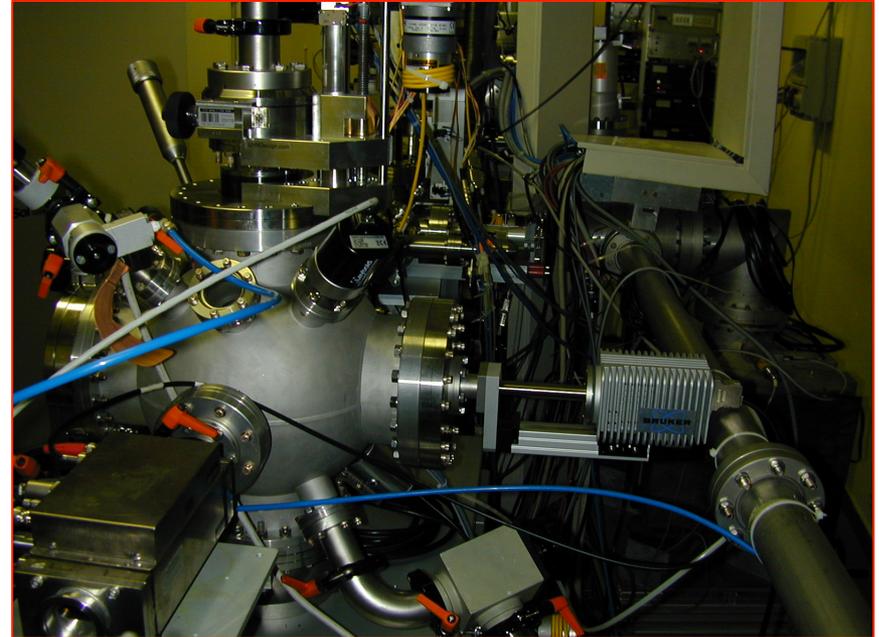
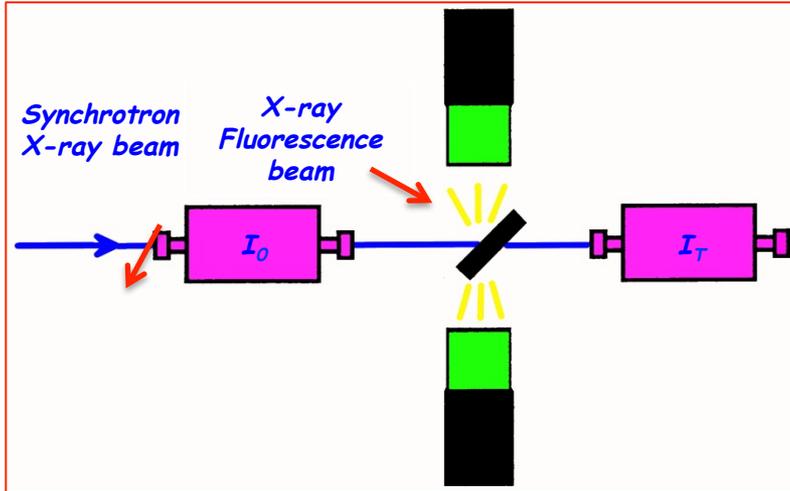
## • external FET (JFET, MOSFET)

- better FET performances
- standard SDD technology
- larger total anode capacitance
- interconnection issues in SDD arrays

# Achievable energy resolution

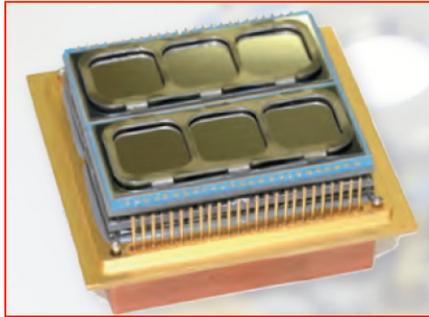


# Setup: XAFS in fluorescence mode



*J. Knobloch et al. - KETEK:  
High Throughput Large Area Silicon Drift Detectors*

# Examples of some available multi-element SDD systems



*PN-DETECTORS SDD-600 Field*  
Active area  $6 \times 100 \text{ mm}^2$   
typ.  $138 \text{ eV @ Mn K}$ ,  $-20 \text{ }^\circ\text{C}$   
P/B up to 15,000  
Input count rate up to 6 Mcps



*SGX - SENSORTECH - Active area  $6 \times 100 \text{ mm}^2$*



*Hitachi Vortex- ME 4*  
SDD/ASIC e Xpress 3 processor

*Thank you for your attention*

